

Development of Ultrafast and Ultraintense Laser Technology for Attosecond Dynamics and High Field Physics

Zhiyi Wei(魏志义)

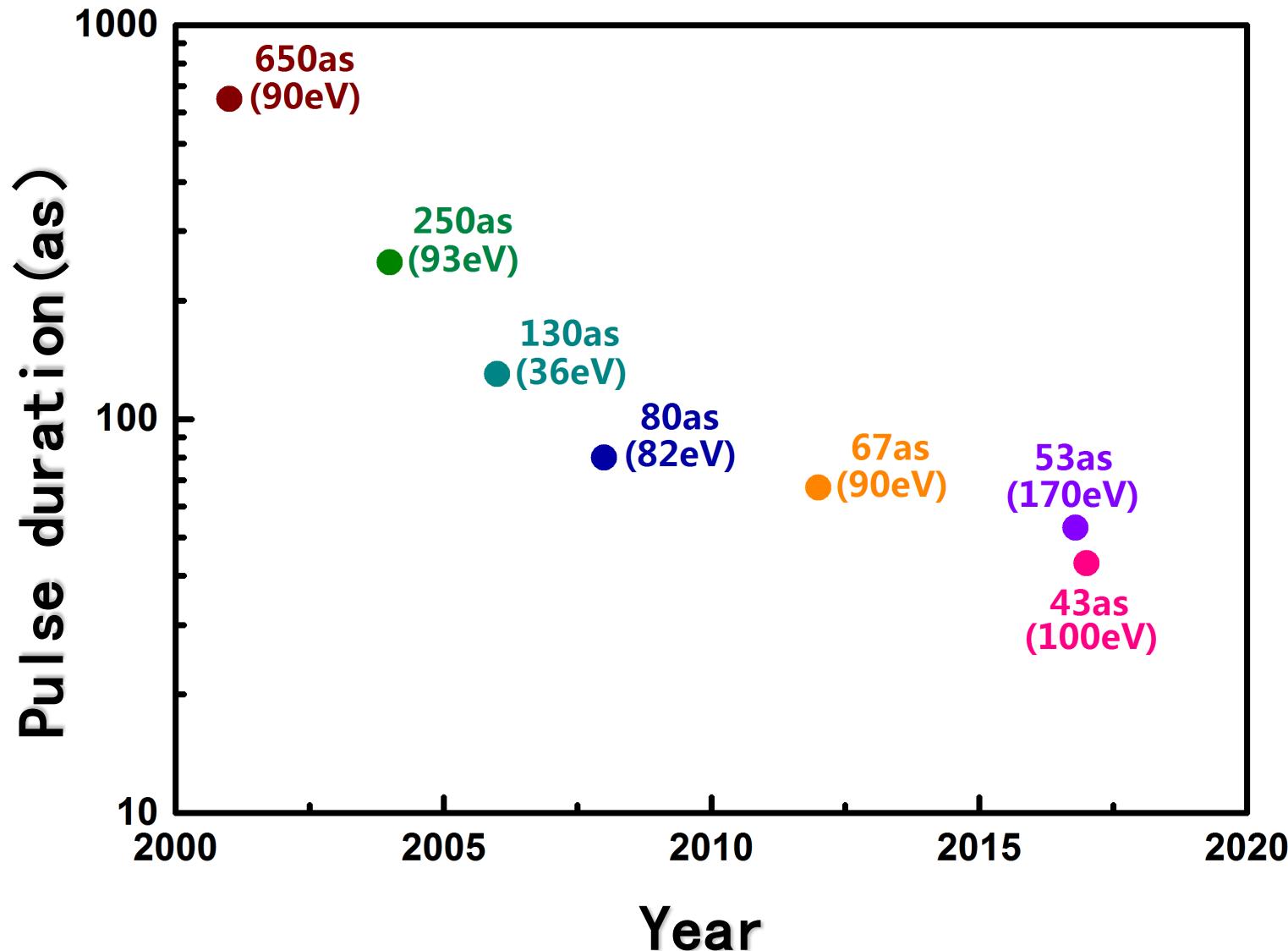
Institute of Physics, CAS

Feb 9, 2018. ICTP

Outline

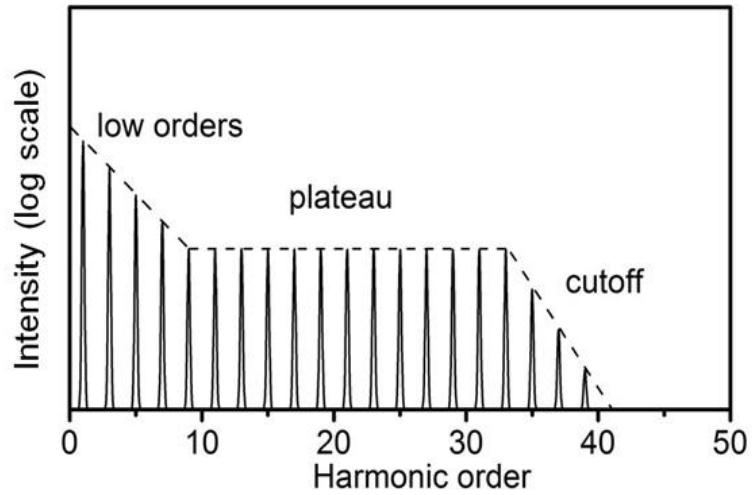
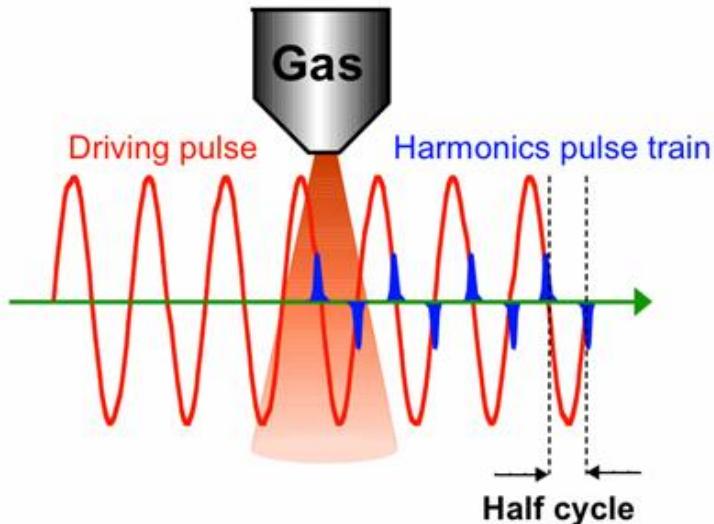
- General Introduction
- Ultrahigh Intensity Laser-Toward multi-PW power
 - ◆ Oscillator-Generation of femtosecond laser
 - ◆ Stretcher-Management of dispersion
 - ◆ Amplifier-Boost laser energy
 - ◆ Compressor-compensate dispersion for high peak power
 - ◆ Enhancement on contrast ratio
 - ◆ Typical PW laser facilities in the world
- Ultrafast Laser-Toward Few Cycles and Attosecond Pulse
- Optical Parametric Amplifier-Toward mid-infrared range
- High average power-Toward All-Solid State Amplifier
- Acknowledgement

Development of attosecond laser



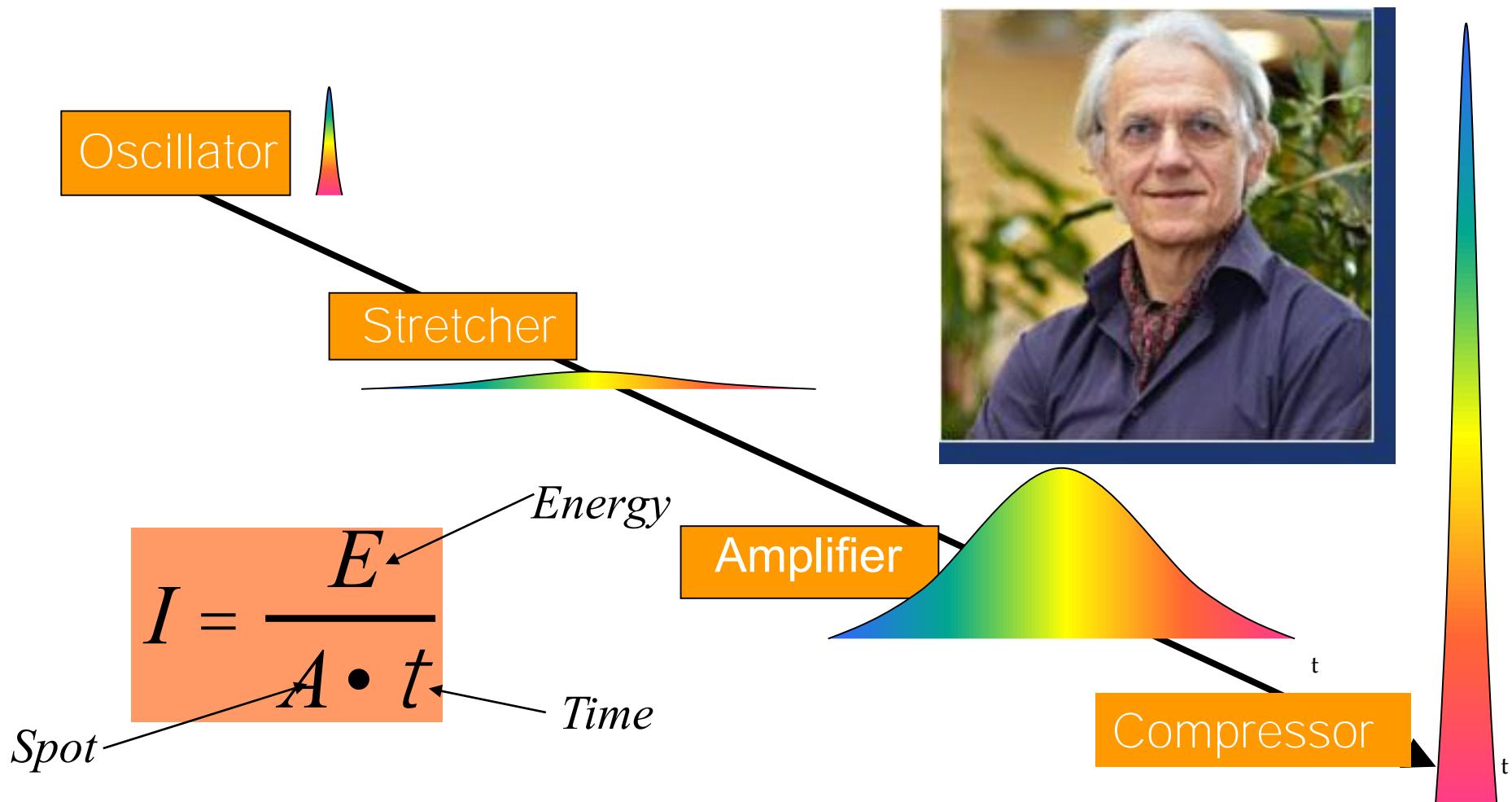
High-order Harmonic Generation at XUV

Driving
Laser



A high intensity femtosecond laser pulse is necessary for HHG and attosecond pulse

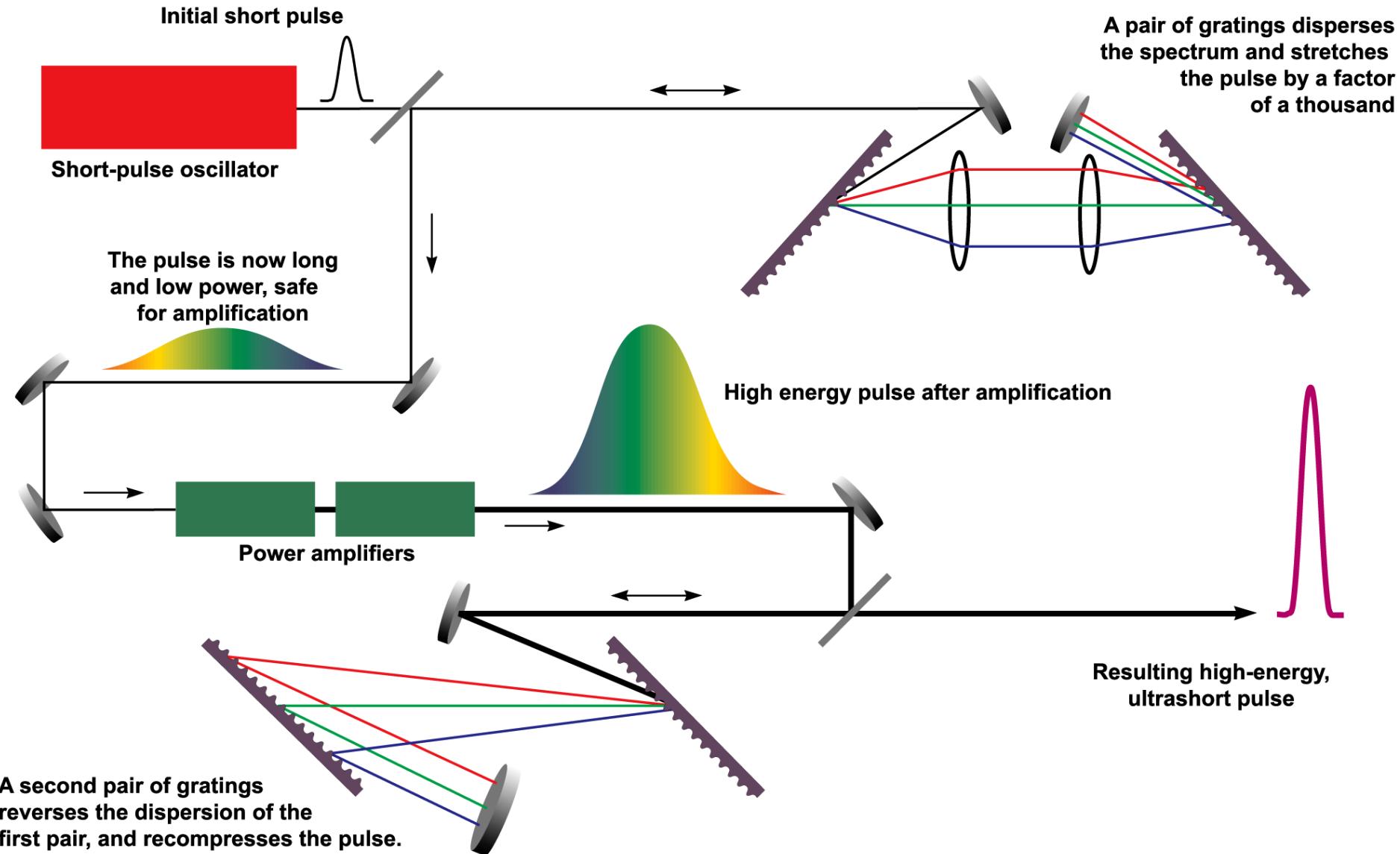
Principle of Chirp Pulse Amplification



Chirped Pulse Amplification (CPA)

D. Strickland and G. Mourou, *Optics Commun.* **56**, 219 (1985)

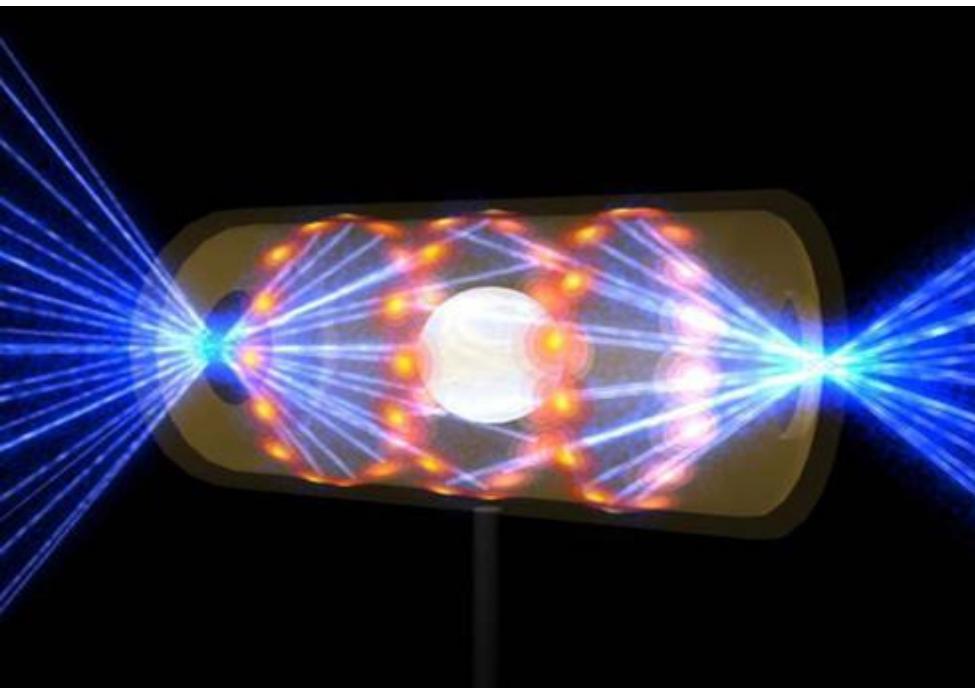
Configuration of CPA



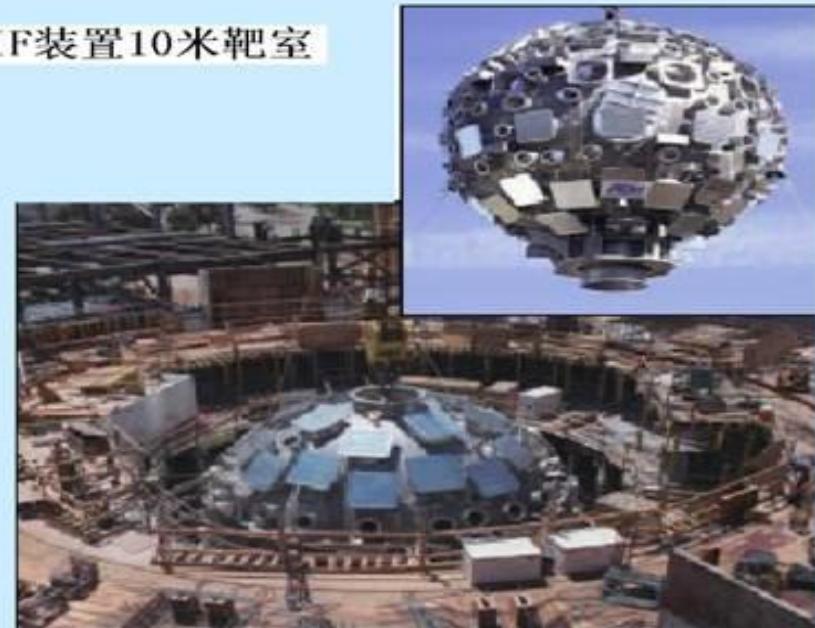
The largest laser facility in the world -National Ignition Facility(NIF)



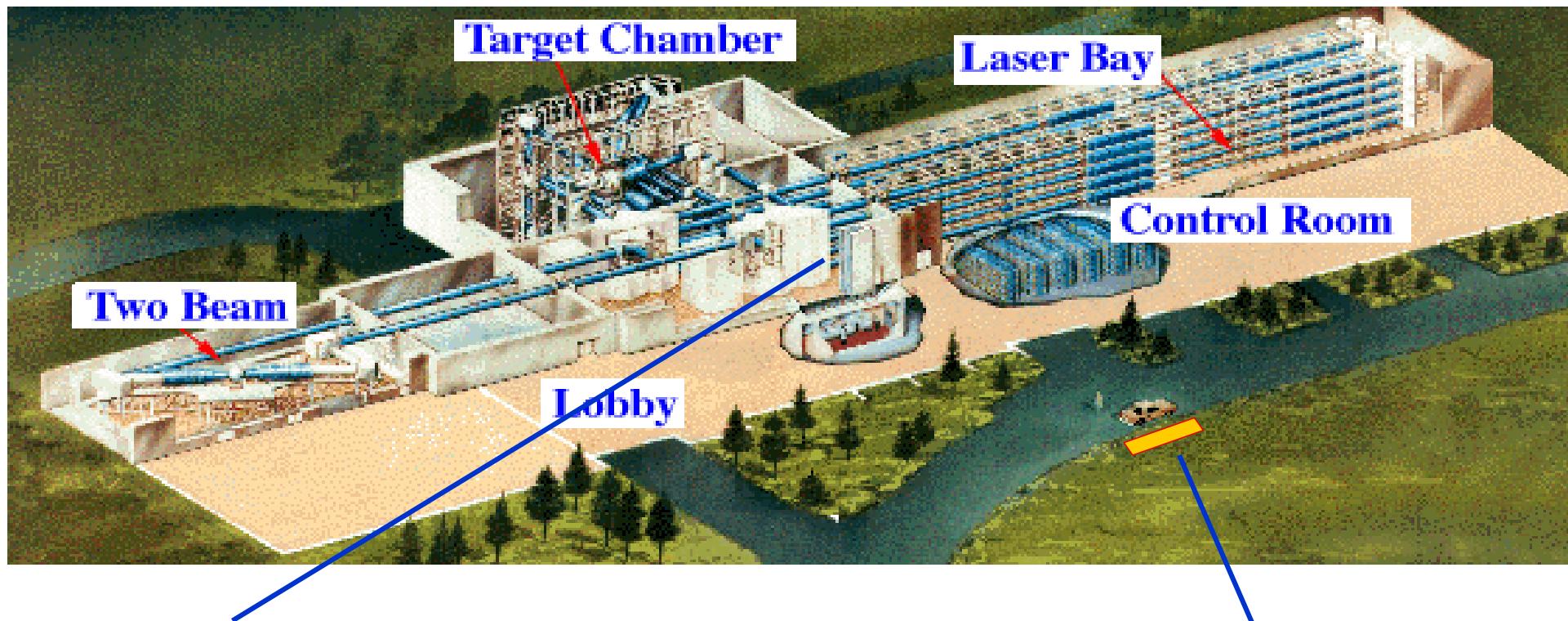
Energy: 1.8MJ
Pulse: (5-10ns),
Beams: 192,
Peak power: **500TW**



NIF装置10米靶室



Comparison of Huge Laser Facility and Table-Top Ti:Sapphire CPA laser



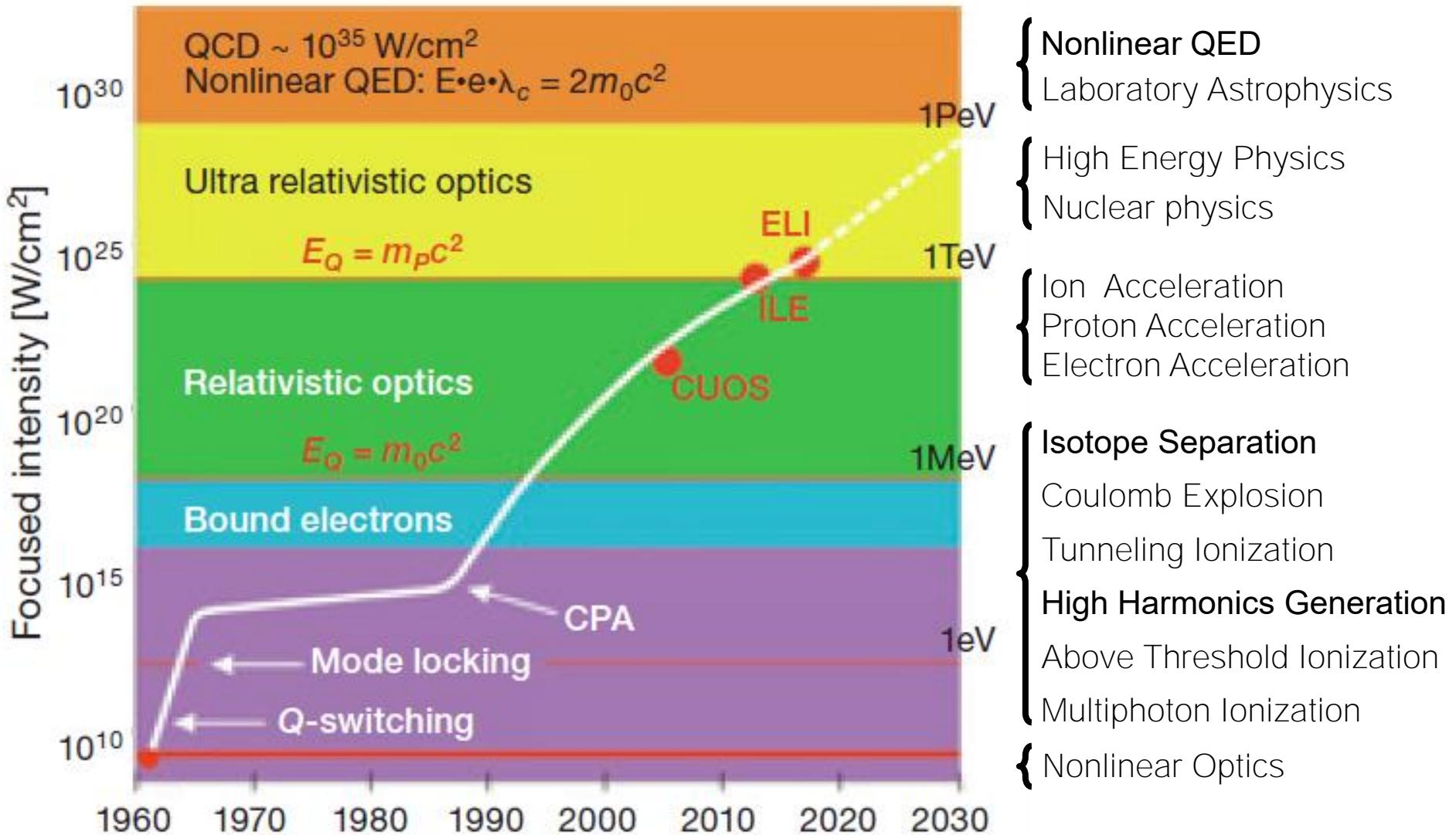
Nova

Pulse duration 1 ns
10 kJ/beam
10 beams @ 10 TW/beam = 100 TW
1 shot/hour

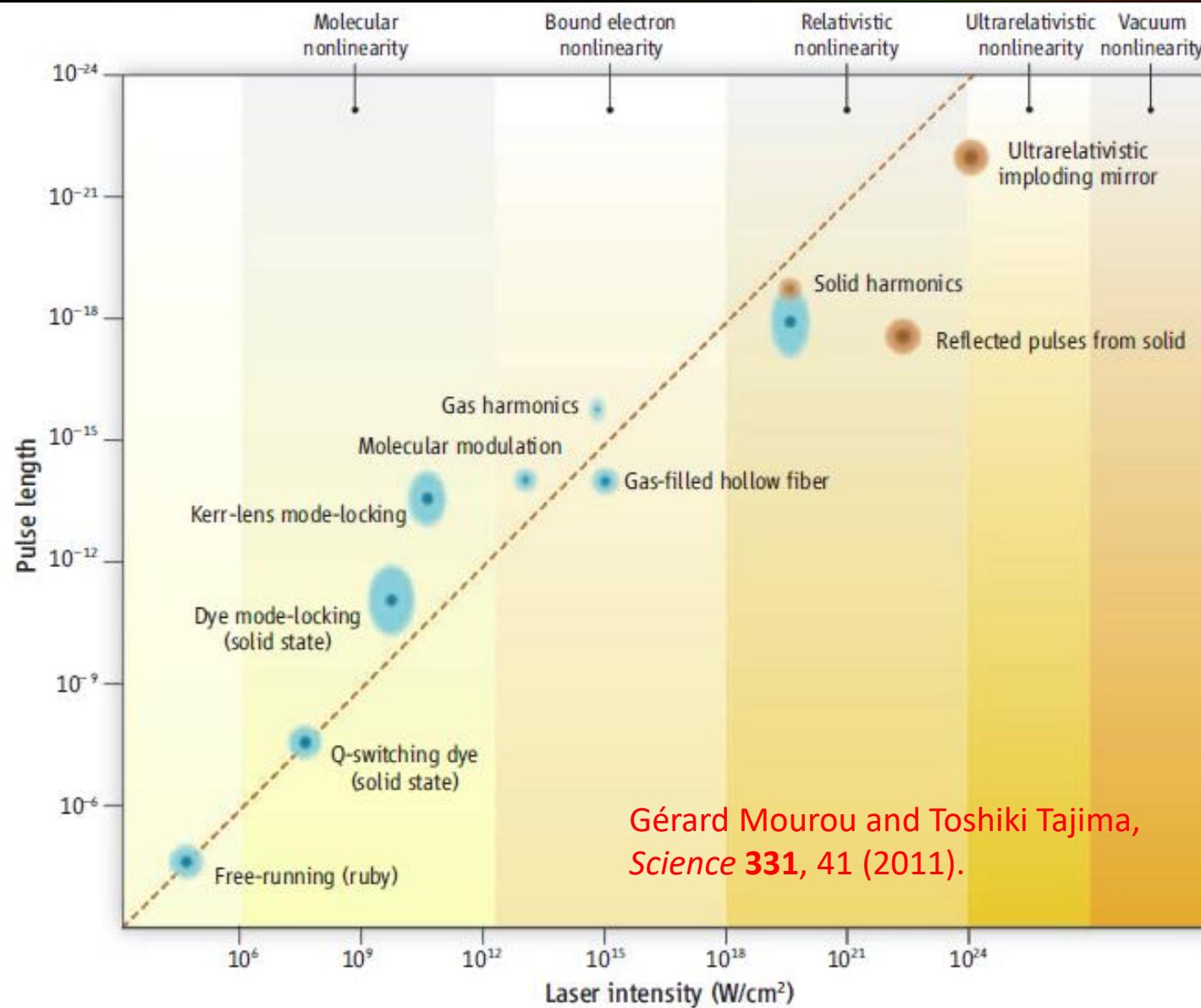
Ultrafast Ti:sapphire Amplifier

Pulse duration 15 fs
1.5 J/beam
100 TW/pulse
36,000 shots/hour

Laser Intensity vs. Years



Trend-Toward shorter, more intense

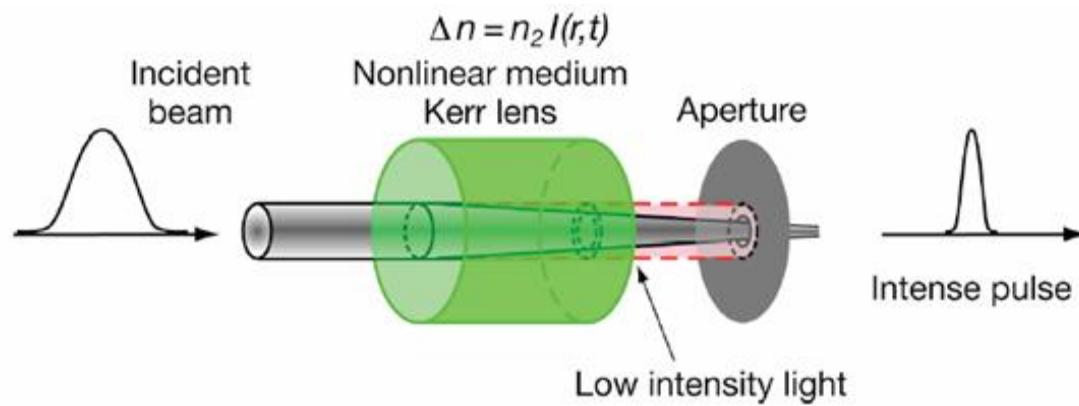
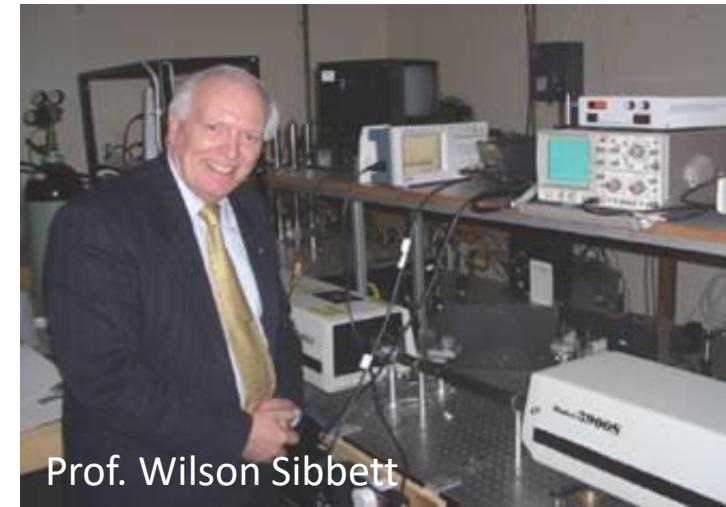
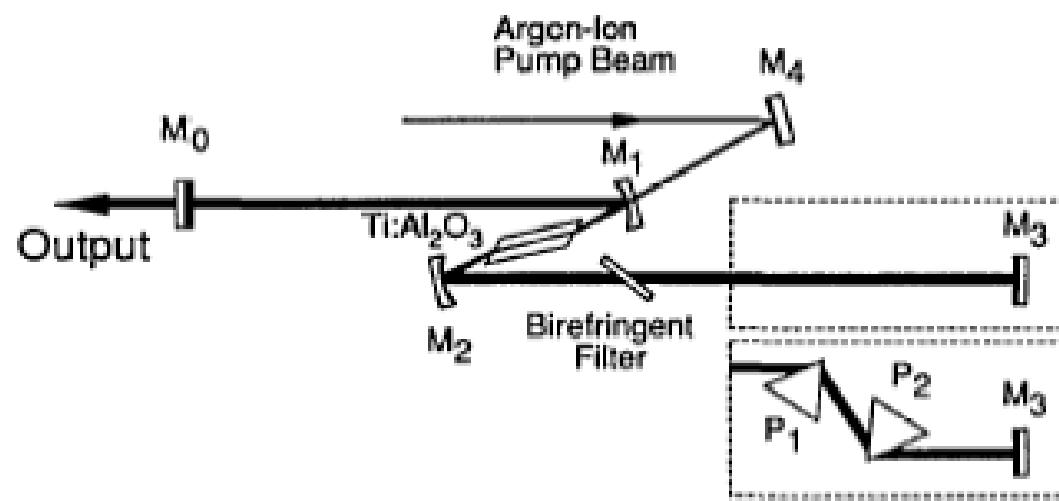


Outline

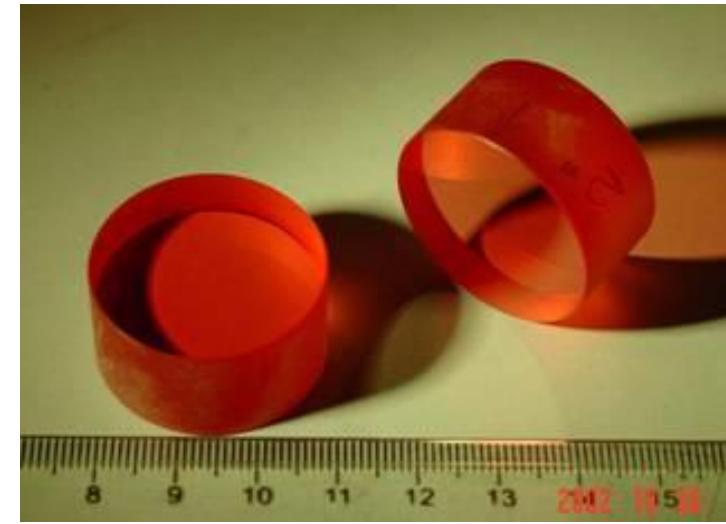
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Oscillator-Generation of femtosecond laser

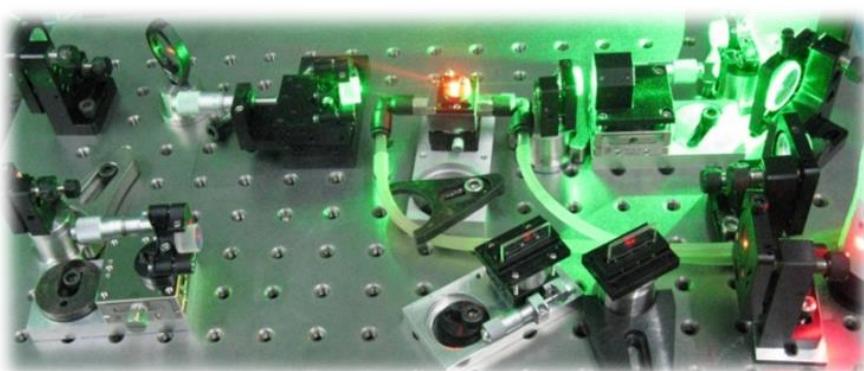
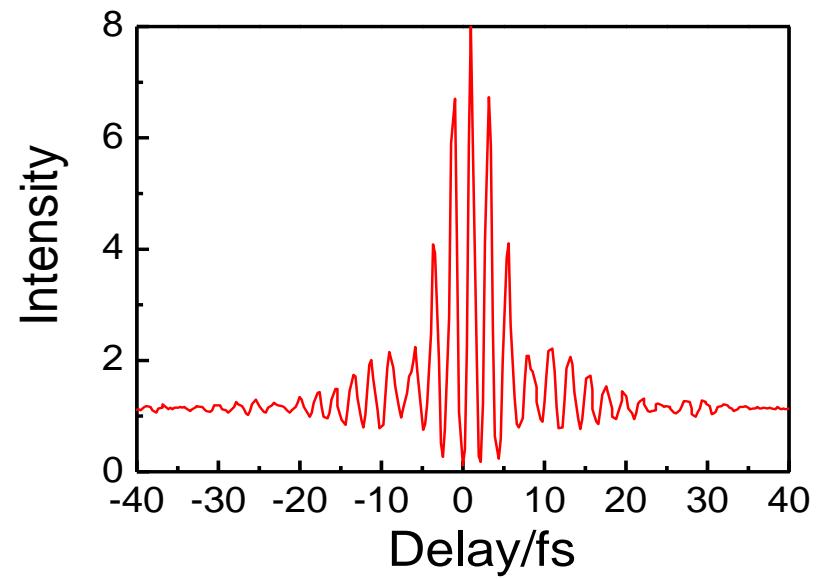
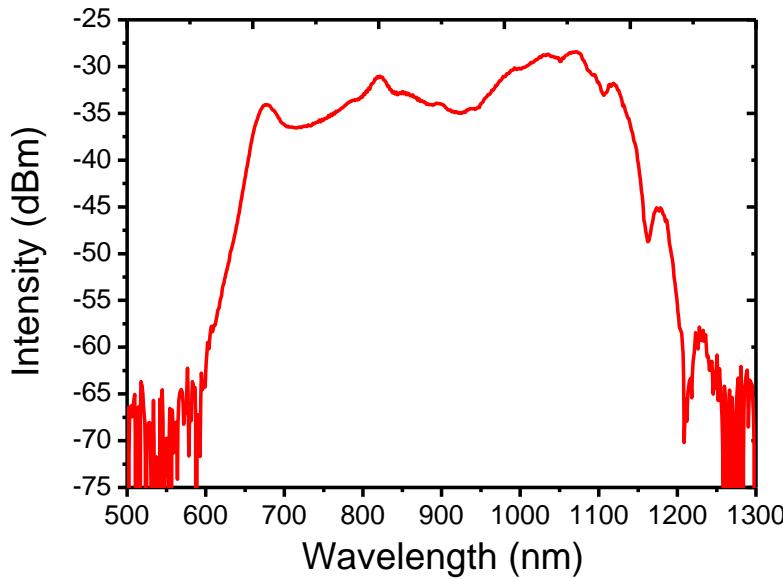
The discovery of KLM Ti:Sapphire laser



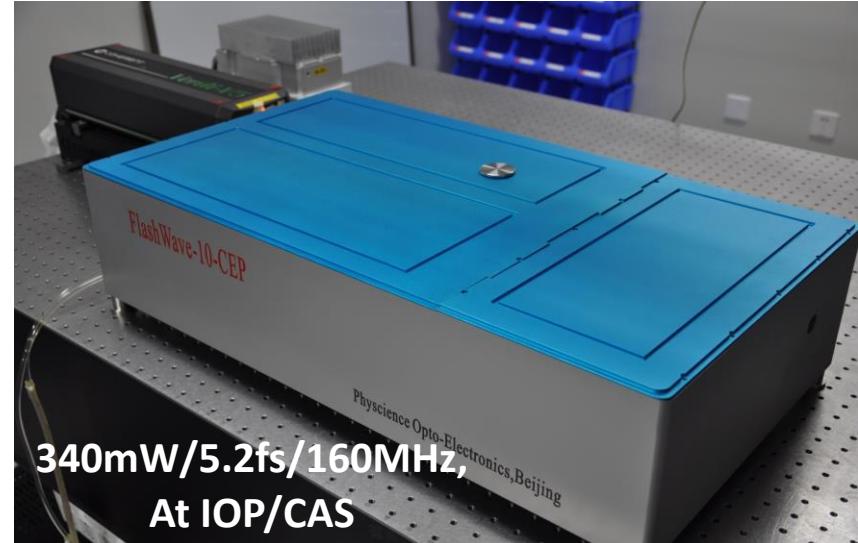
D. E. Spence et al, Opt. Lett. 16, 42, 1991



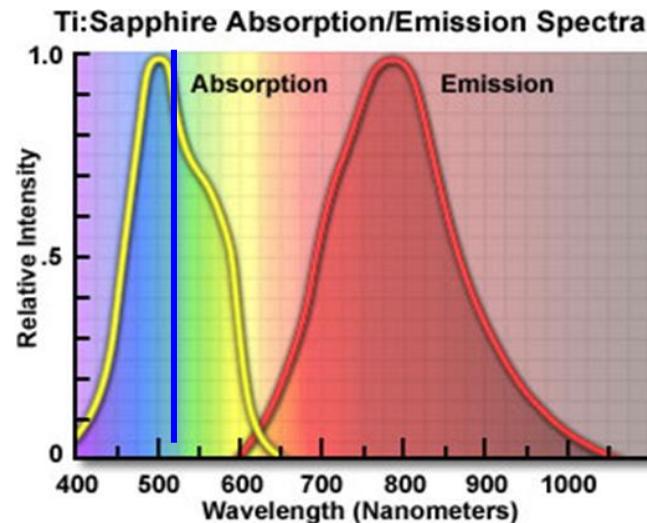
A typical sub-10fs KLM Ti:Sapphire laser



Ti:S laser is capable of the shortest pulse duration and the most broad spectrum, but lower power and high cost.



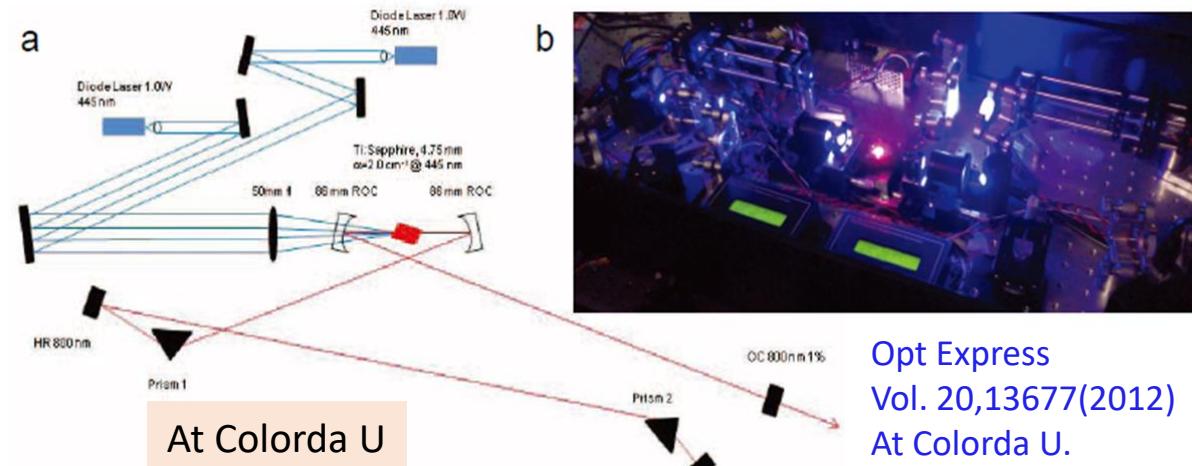
fs Ti:Sapphire lasers pumped with blue lasers



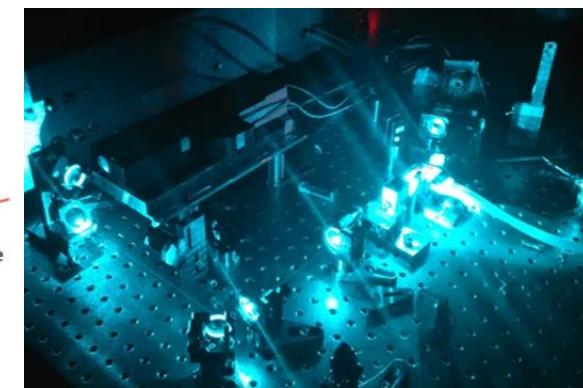
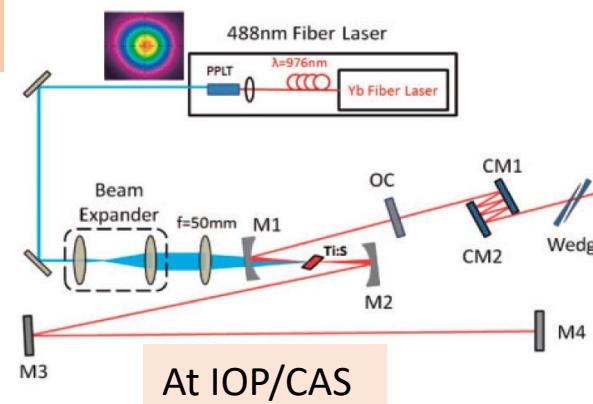
Peak absorption wavelength of Ti:sapphire crystal at 490nm.

Comparison of two pump lasers

Pump laser	Laser Diode	Fiber Laser
Pump Wavelength	445nm	488nm
Pump power	2.4W	1.5W
Absorption	60%	92%
Pulse duration	15fs	8.7fs
ML power	34mW	150mW(3%) 60mW(0.5%)



450nm blue laser diode pumped fs Ti:sapphire laser



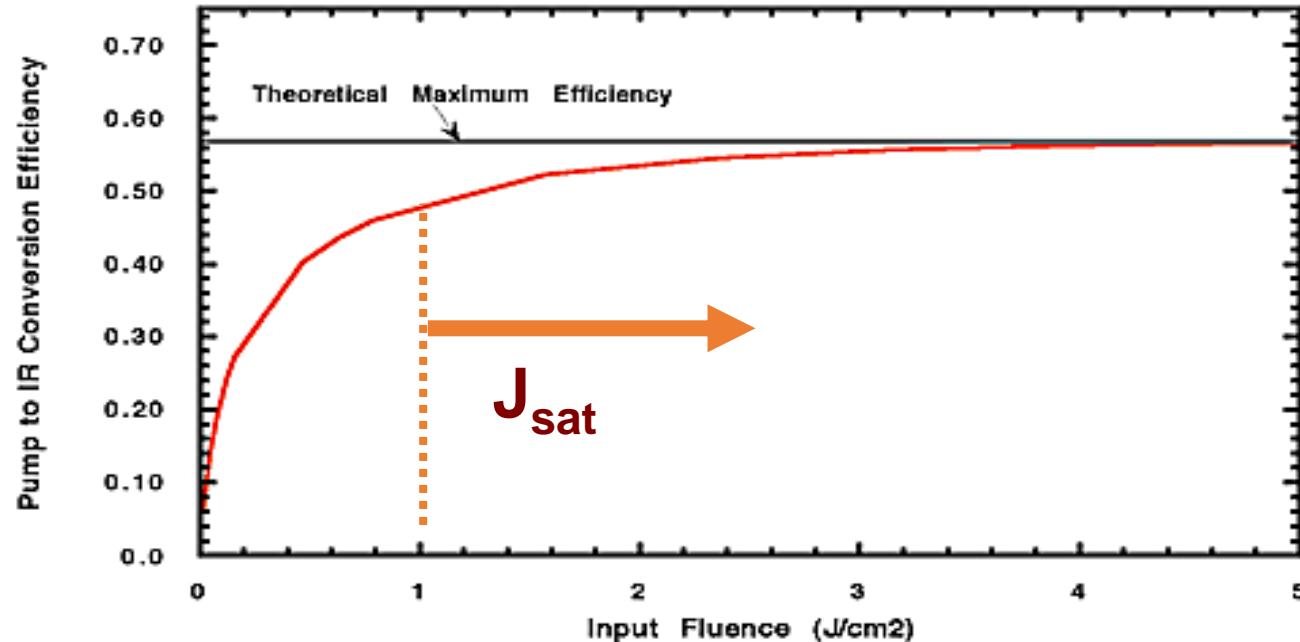
488nm blue fiber laser pumped fs Ti:Sapphire laser

Z. J. Yu et al, Low-threshold sub-10fs mode-locked Ti:Sapphire laser pumped by 488nm fiber laser, Appl Phys Express, 7, 102702(2014)

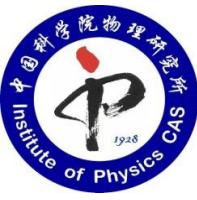
Stretcher-Management of dispersion

Saturation fluency in laser medium

- High Efficiency in Final Amplifier
 - Run above the saturation fluency



- Produce the shortest duration pulses
 - Run near the fluorescence limit
- No Damage
 - Run below the dielectric breakdown limit $< 5 \times 10^9 \text{ W/cm}^2$



Maximum Intensity at Saturation for some laser media

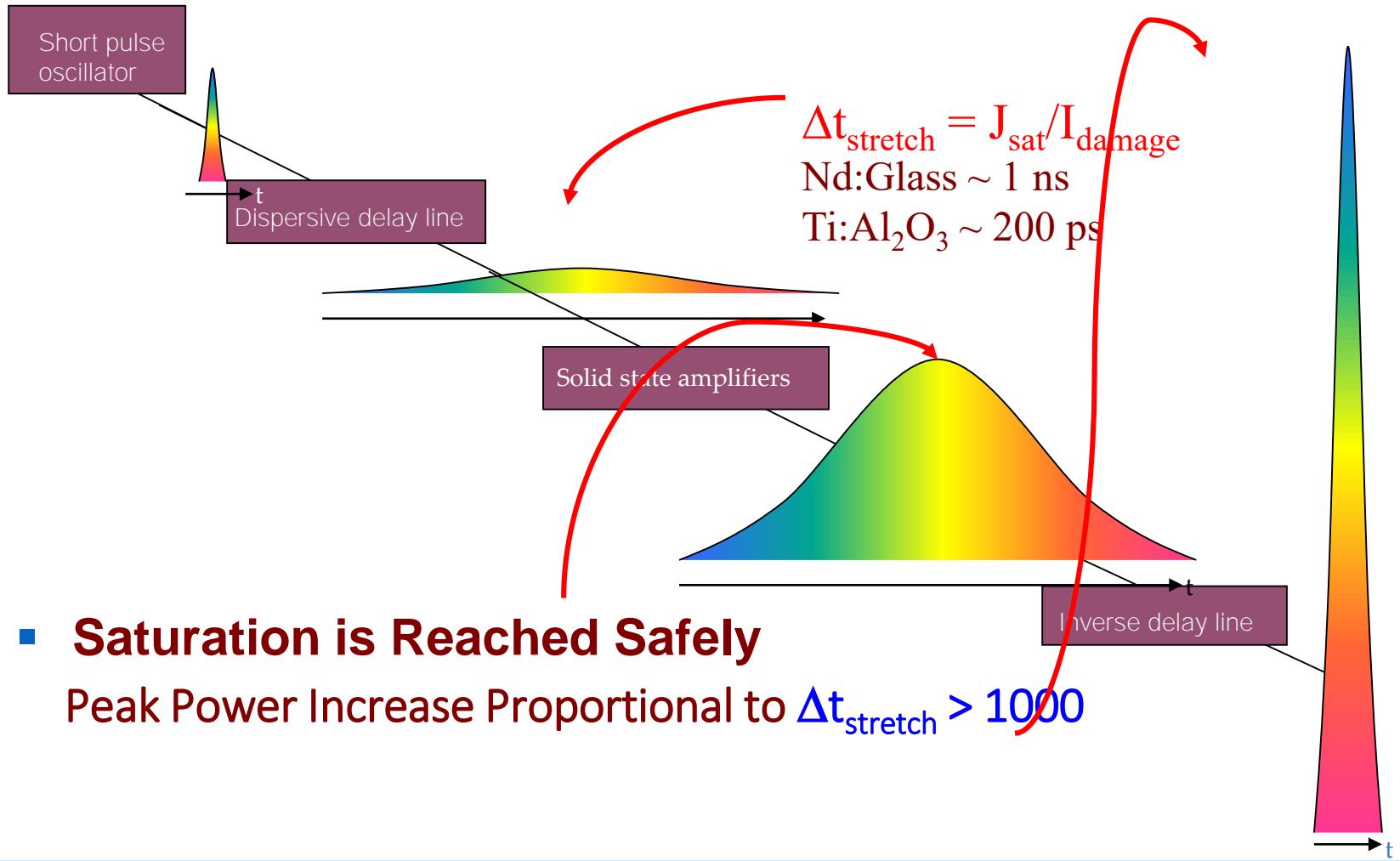
Material	J_{sat} (J/cm ²)	Δt_{min} (fs)	I_{max} (W/cm ²)
Nd:Silicate	6	60	10^{14}
Yb:Silicate	32	20	1.6×10^{15}
Ti:Sapphire	1	3	3.3×10^{14}

- Maximum output intensity = $J_{\text{sat}} / \Delta t_{\text{min}}$
- However, damage threshold < 5×10^9 W/cm²

Conclusion:

We must reduce pulse **INTENSITY** during amplification

Safe saturation in amplification



- Saturation is Reached Safely**

Peak Power Increase Proportional to $\Delta t_{\text{stretch}} > 1000$

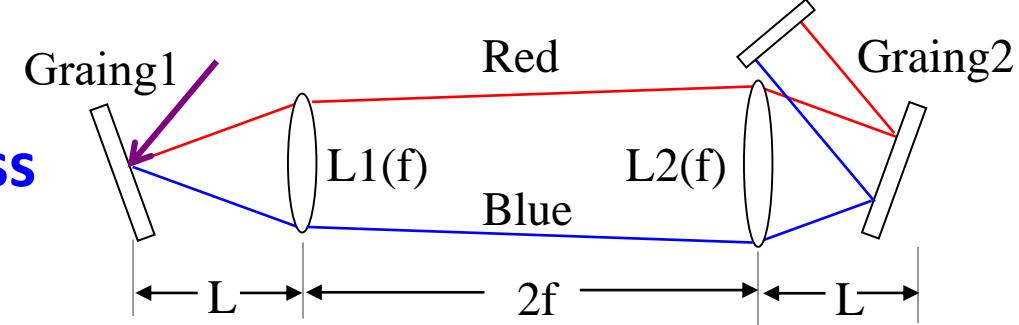
Conclusion:

Stretch laser pulse duration in necessary before amplification

A type of typical stretchers

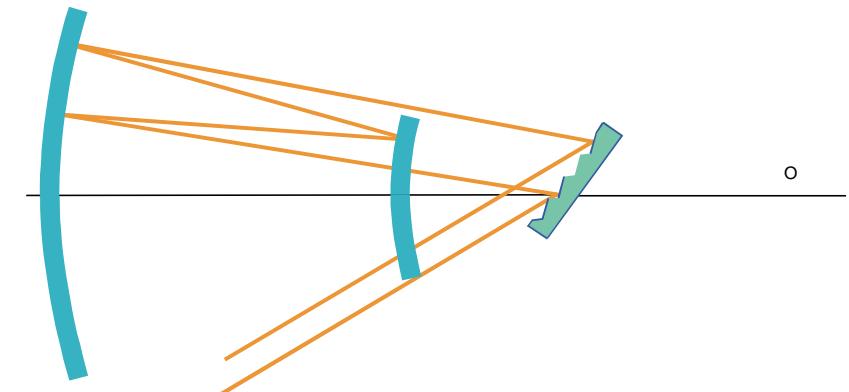
- **Martinez Stretcher**

aberration, can not compress
pulse shorter than 50fs



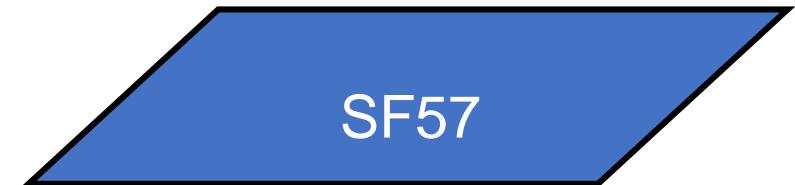
- **Öffner Stretcher**

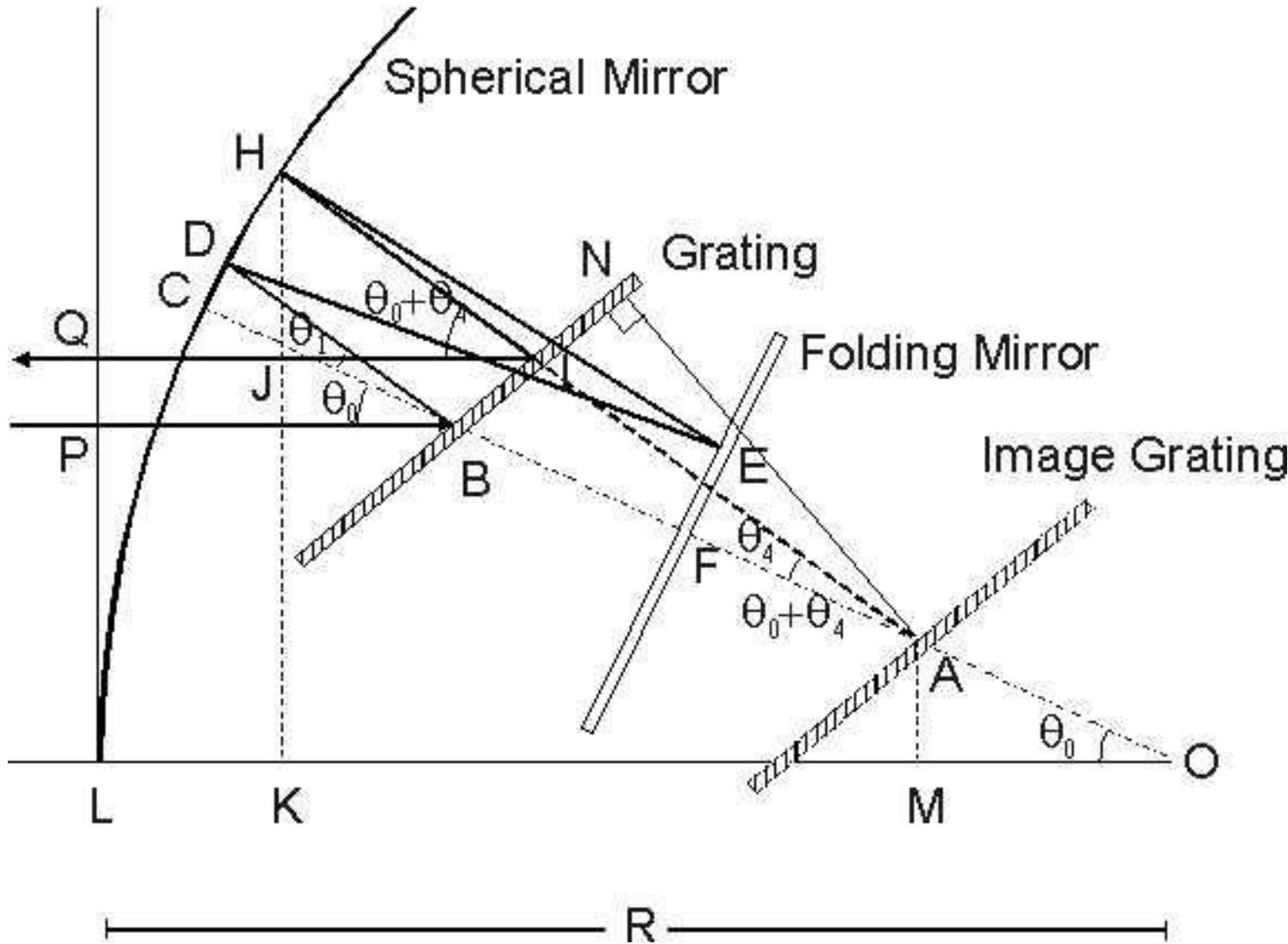
free aberration, most widely use
today



- **Material Stretcher**

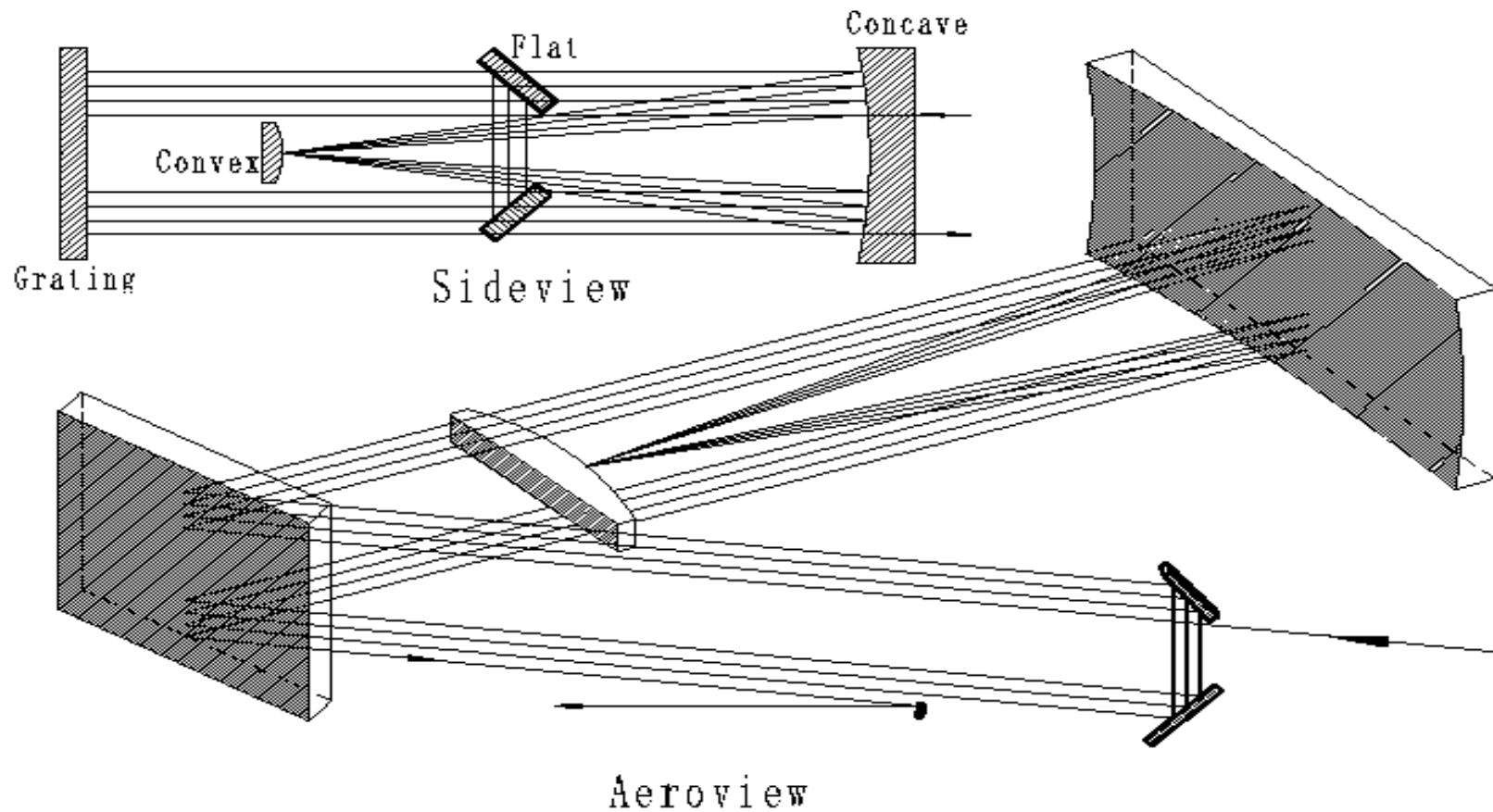
Use high dispersion material, suit
for $10\text{fs} \Rightarrow \sim 10\text{ps}$

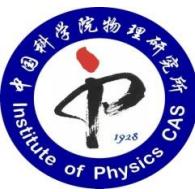




$$\varphi(\omega) = \frac{\omega}{c}(C + A) - \frac{\omega}{c}b \times [1 + \cos(\theta_0 + \theta_4)] + \frac{2\pi G}{d} \tan(\gamma - \theta_0 - \theta_4) + \frac{2\pi}{d}(G_0 - G) \tan(\gamma - \theta_0)$$

Doubled Stretcher





Dispersion in Optical Materials

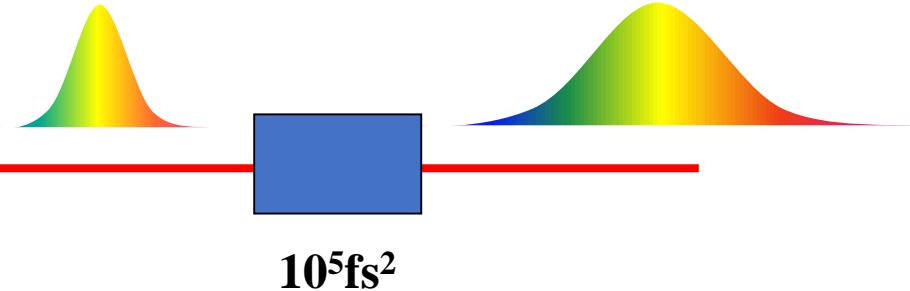
Laser will suffer dispersion when propagate in optical materials. The phase depend on the optical path with wavelength:

$$\phi_m(\omega) = L n(\omega) \omega / c$$

$$GD = \frac{d\phi_m(\omega)}{d\omega} = \frac{L_m}{c} (n(\lambda) - \lambda \frac{dn(\lambda)}{d\lambda})$$

$$GVD = \frac{d^2\phi_m(\omega)}{d\omega^2} = \frac{\lambda^3 L_m}{2\pi c^2} \frac{d^2 n(\lambda)}{d\lambda^2}$$

$$TOD = \frac{d^3\phi_m(\omega)}{d\omega^3} = -\frac{\lambda^4 L_m}{4\pi^2 c^3} (3 \frac{d^2 n(\lambda)}{d\lambda^2} + \lambda \frac{d^3 n(\lambda)}{d\lambda^3})$$

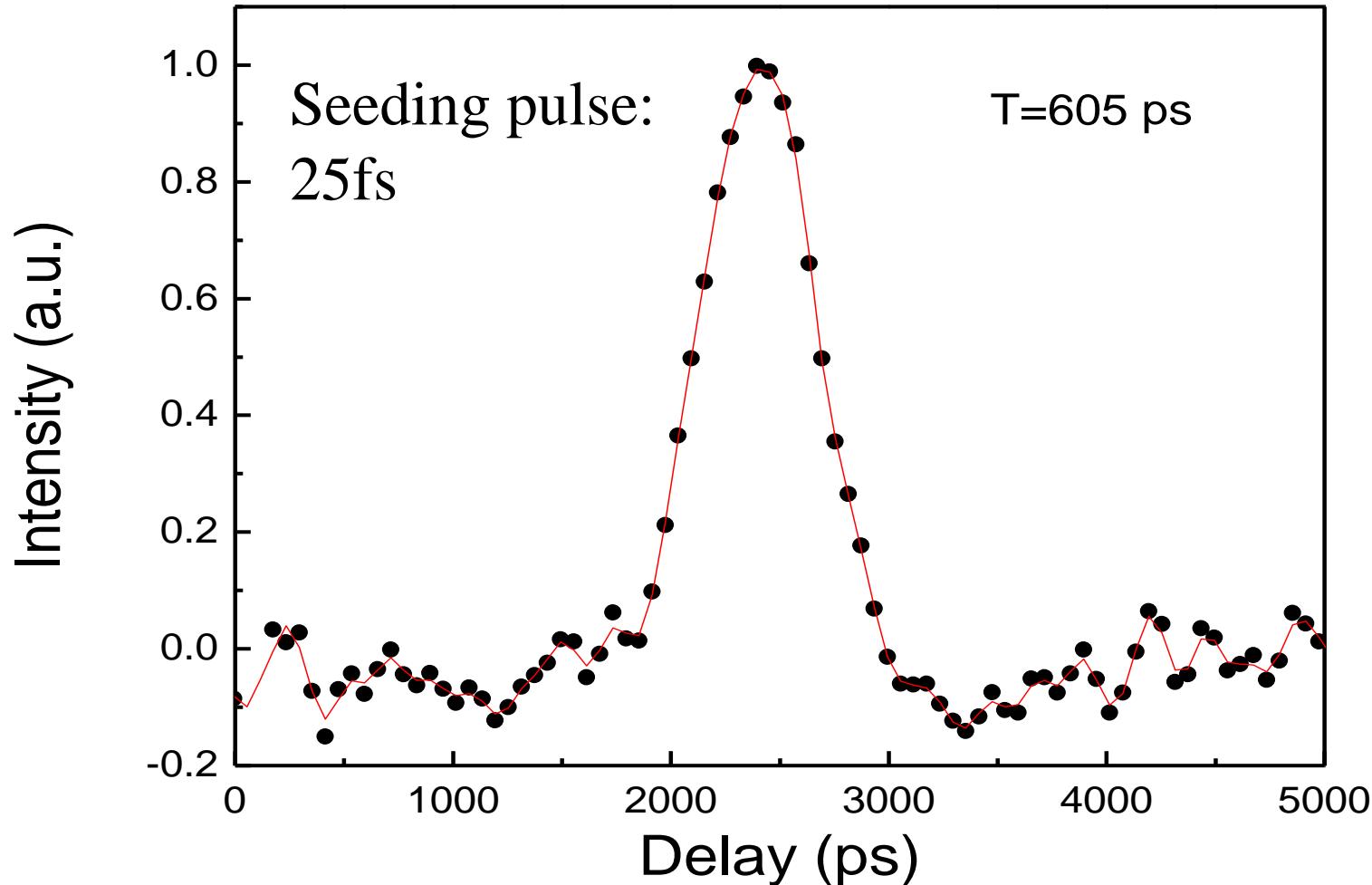


$$\frac{\tau}{\tau_0} = \sqrt{1 + \left(\frac{4 \cdot \ln 2 \cdot GVD}{\tau_0^2} \right)^2}$$

$$5\text{fs} \rightarrow \boxed{10^5 \text{fs}^2} \rightarrow 55\text{ps}$$

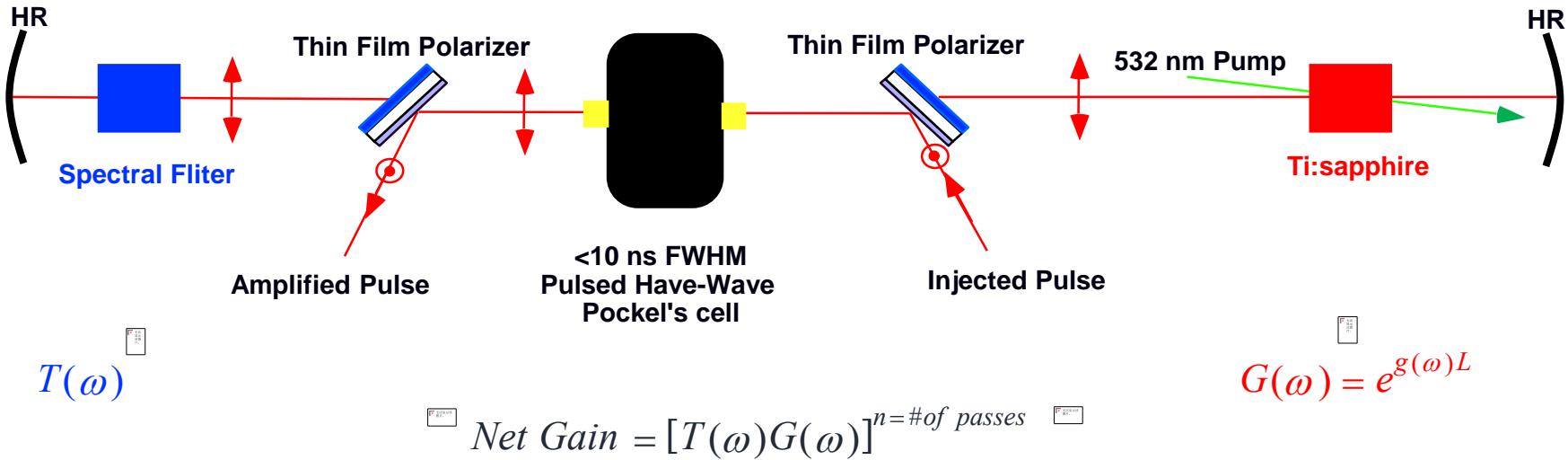
$$30\text{fs} \rightarrow \boxed{10^5 \text{fs}^2} \rightarrow 9\text{ps}$$

Pulse duration after Öffner stretcher



Amplifier-Boost laser energy

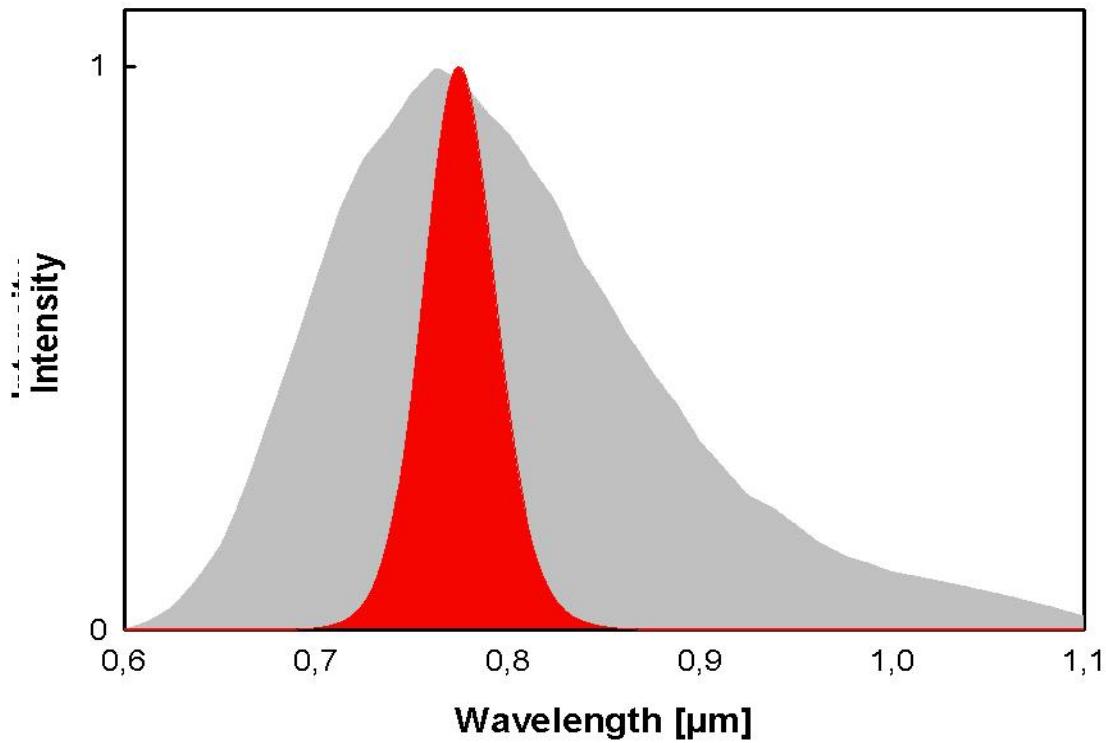
1. Regenerative amplifier and Pulse Shaping



- Most gain narrowing occurs in the regen or preamp
- Correct for gain narrowing on each round trip
- Relatively low gain per pass means we only need a linear filter

Gain narrowing effect

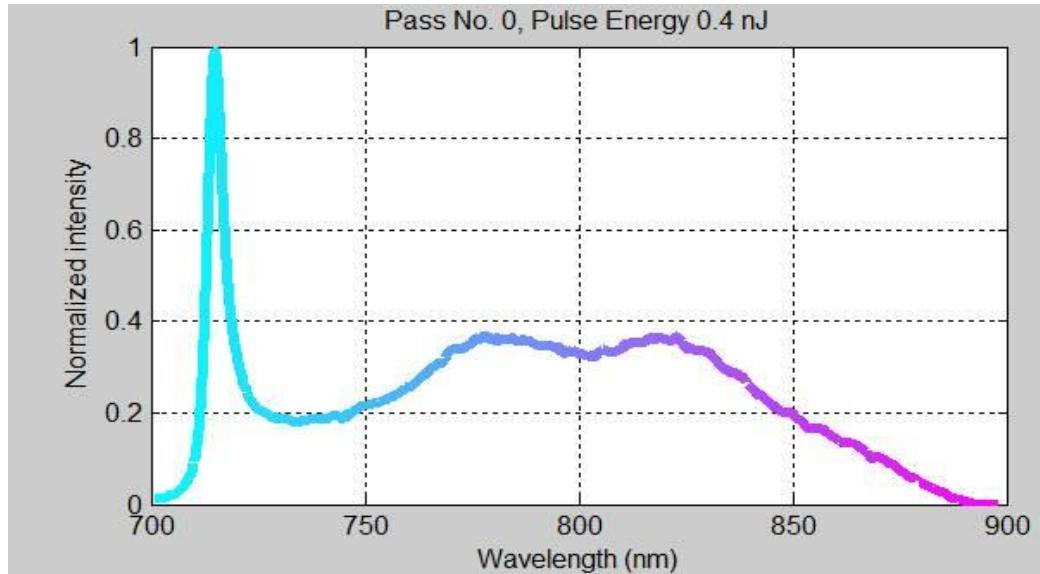
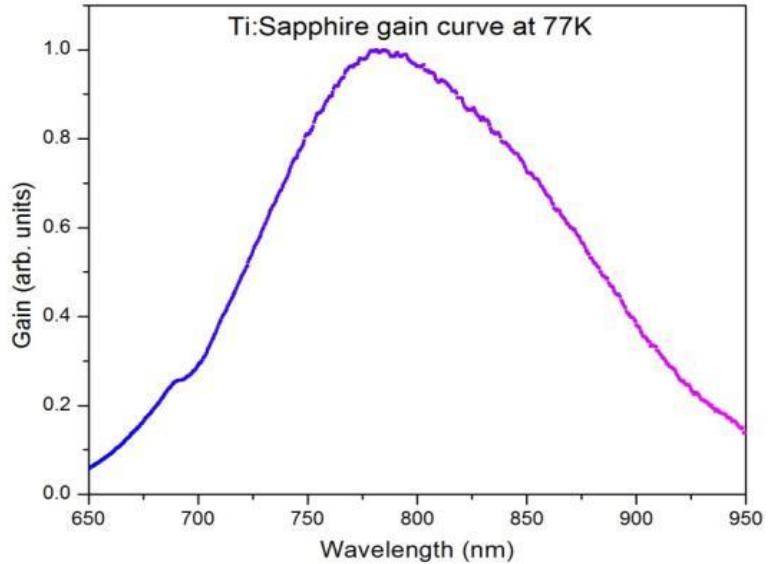
$$G(\omega) = \exp\left[\frac{\omega L}{c} \chi''(\omega)\right]$$



Approaches to Control Gain Narrowing

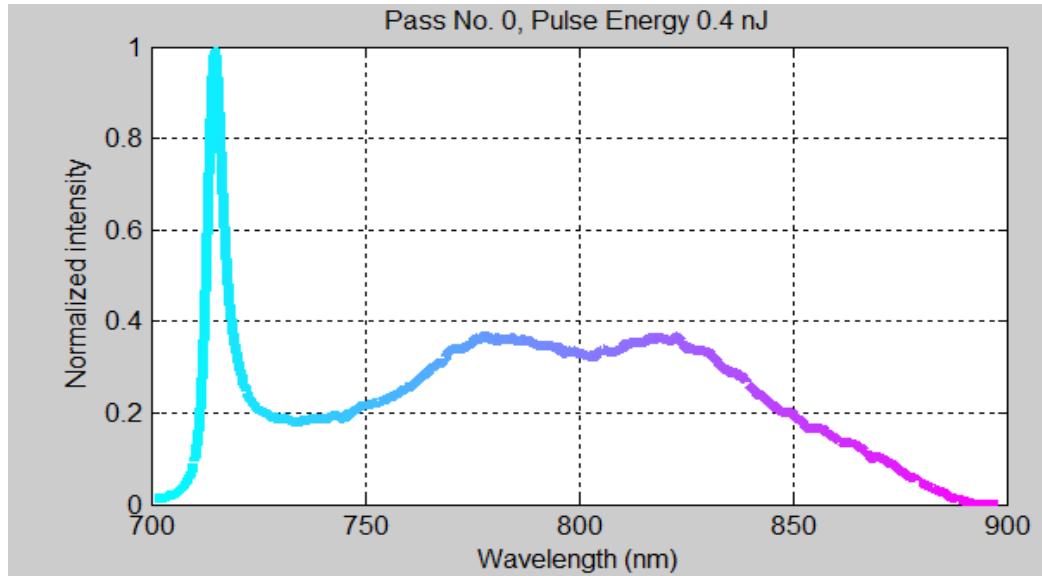
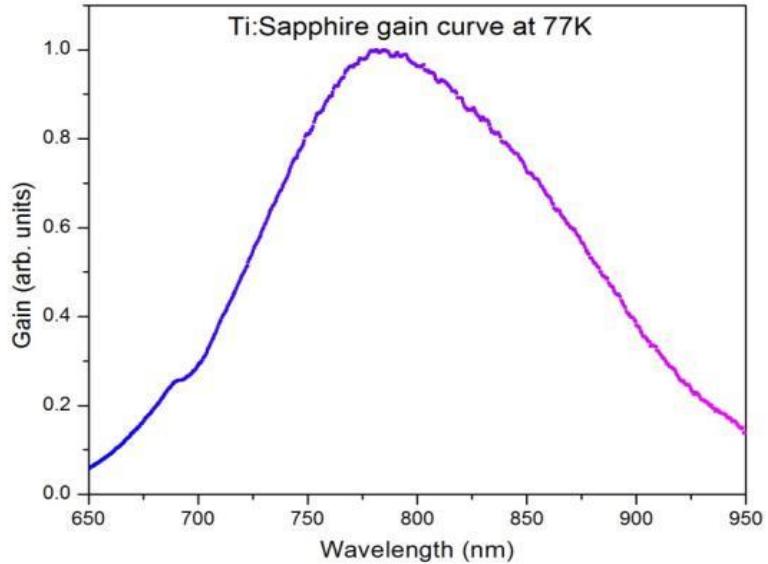
- Regenerative pulse shaping
 - Correct for the gain narrowing on each pass trip
- Minimize systems losses
 - Multi-pass amplifiers with high gain per pass
- Seed to the RED of the line center
 - Regen or multi-pass
 - Play off saturation pulling against gain shifting
- Mix amplifier materials
 - Different center frequency yields higher overall gain bandwidth
- OPCPA (Optical Parametric CPA)
 - Large gain bandwidth in parametric amplification

Gain Narrowing



nJ → J, amplification of 10^9 times

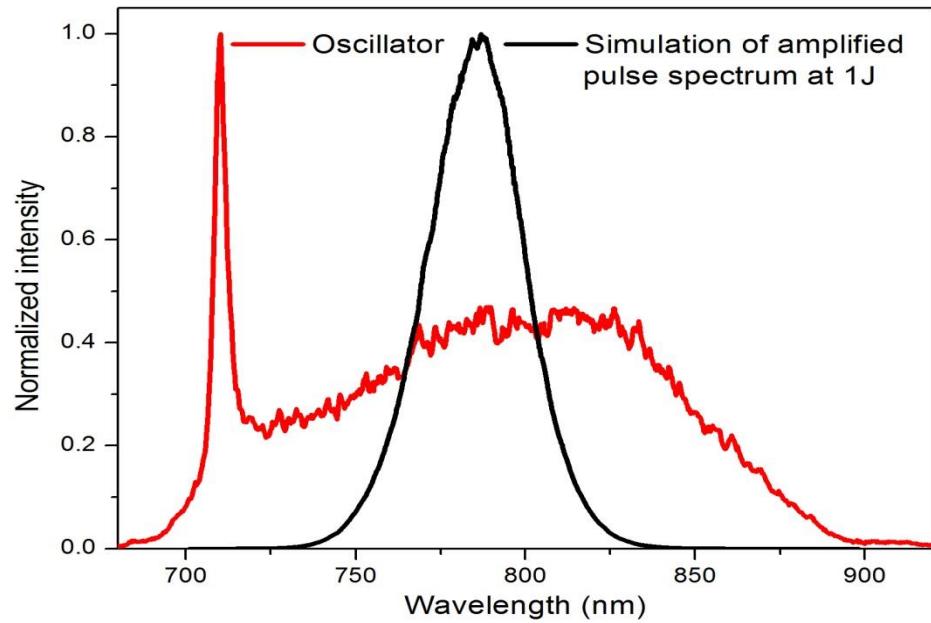
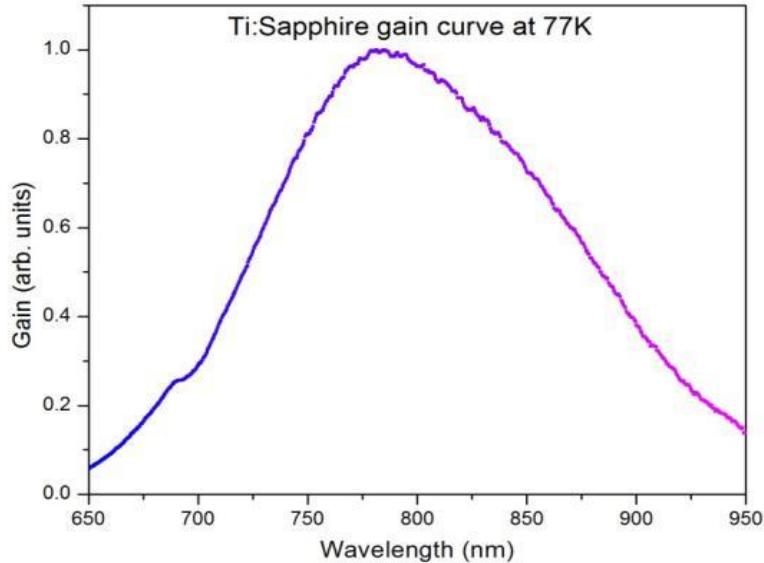
Gain Narrowing



nJ → J, amplification of 10^9 times

Gain Narrowing

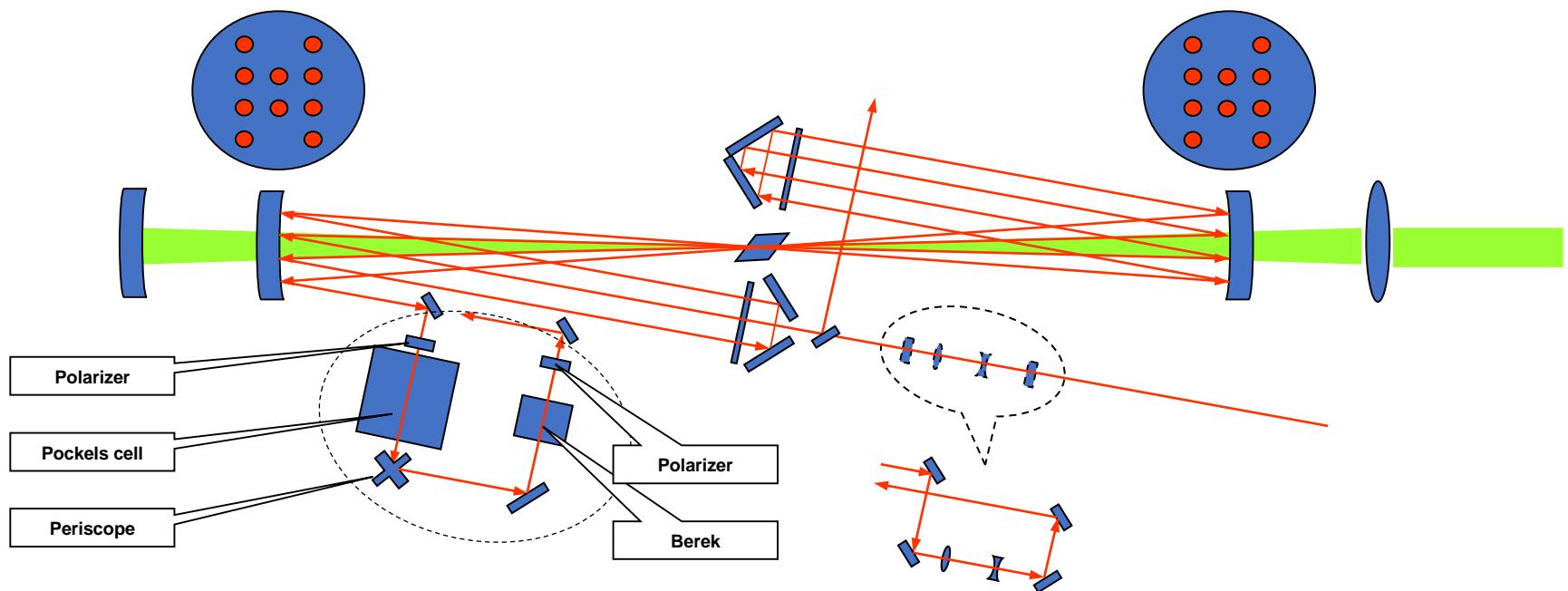
Final output pulse duration \sim 30-40 fs



nJ \rightarrow J, amplification of 10^9 times

2. Multi-pass amplifier

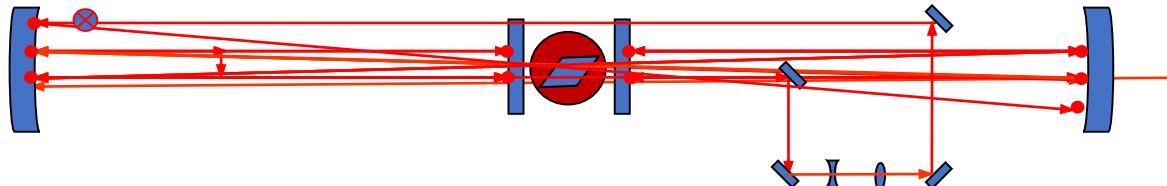
10 pass preamplifier



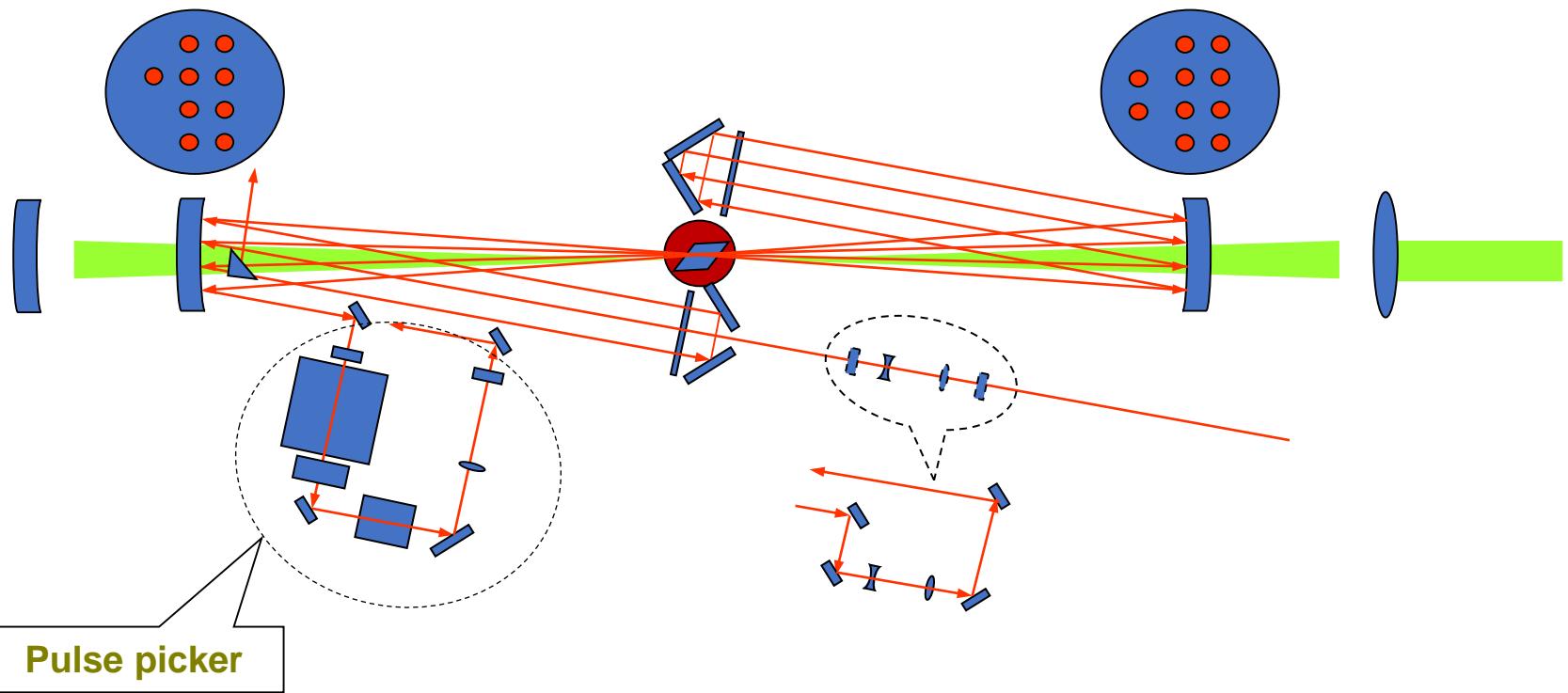
Z.Cheng, F.Krausz, Ch.Spielmann, Opt. Commun 201, 145 (2002)

10-pass Chirped pulse amplifier

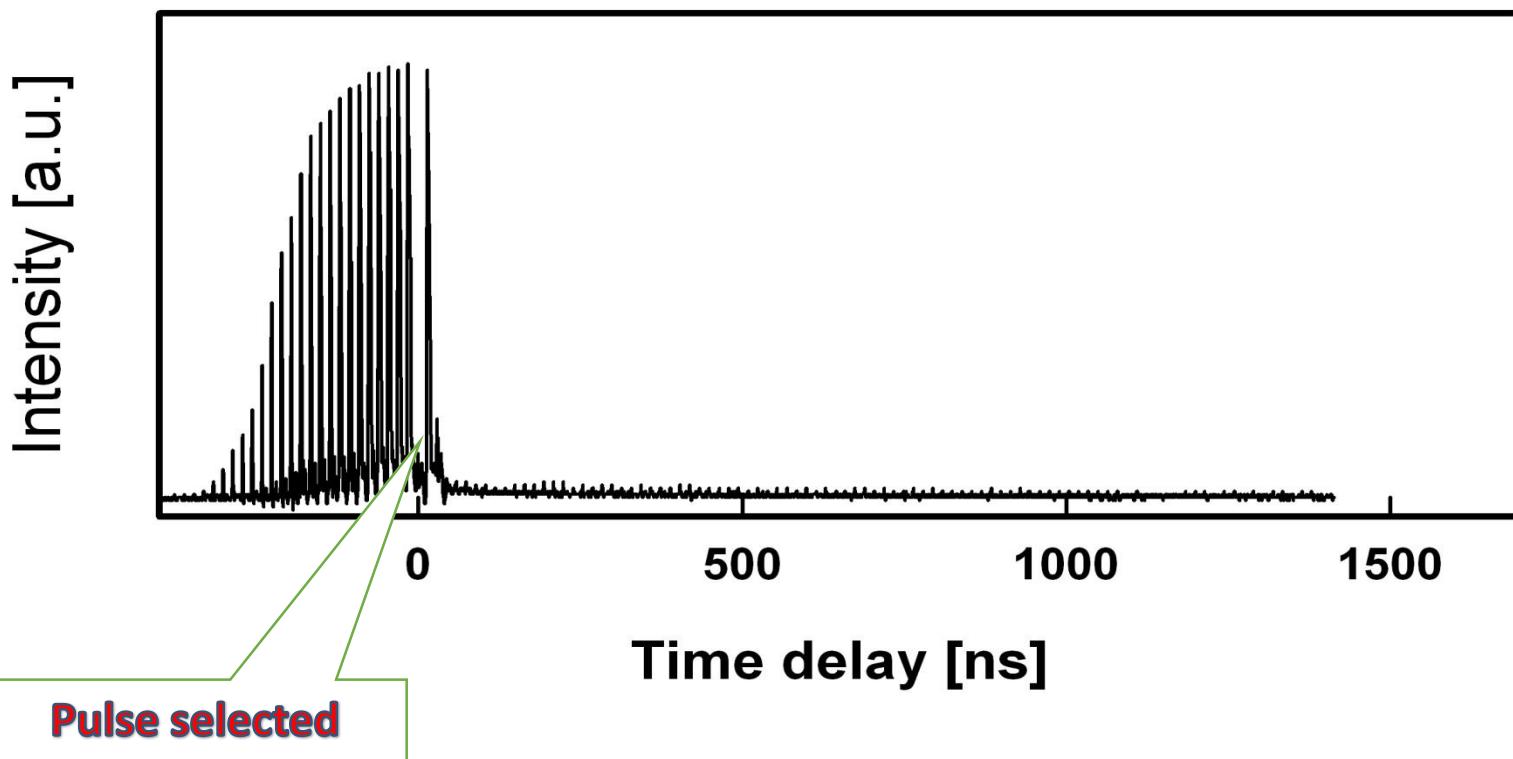
Side view



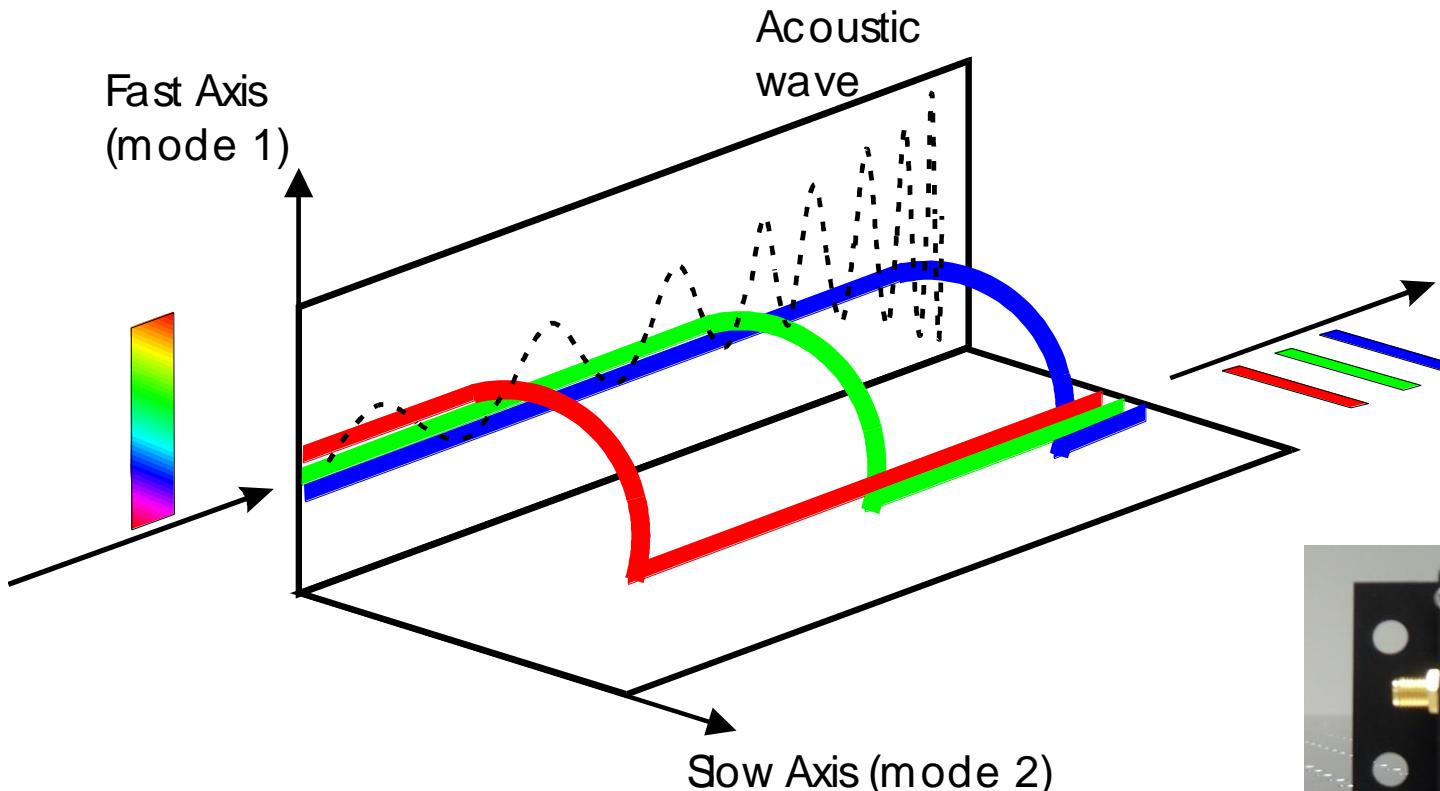
Top view



Evolution of amplification gain saturation



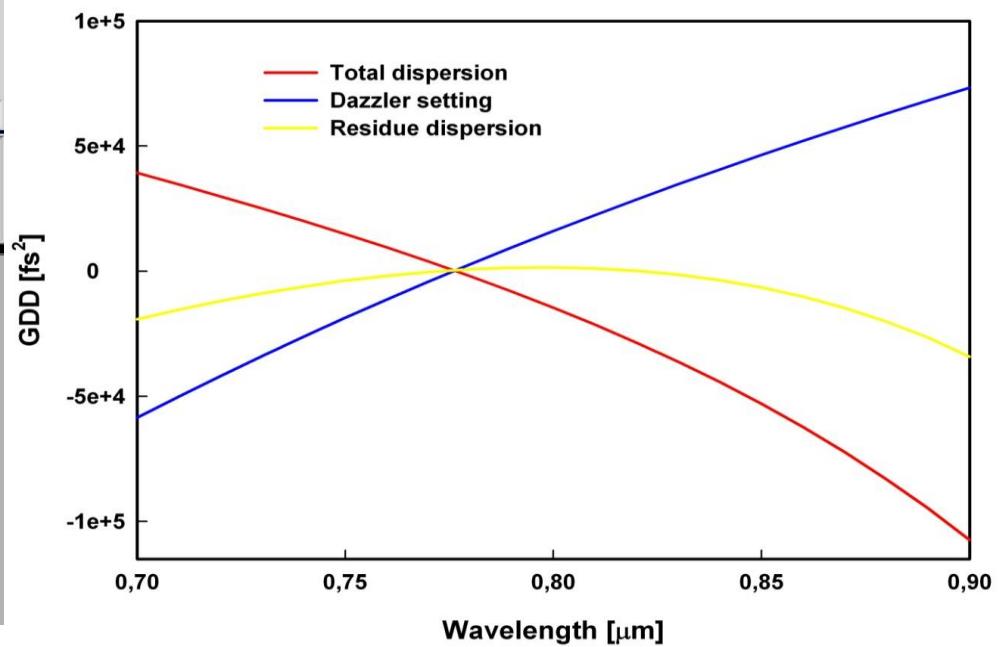
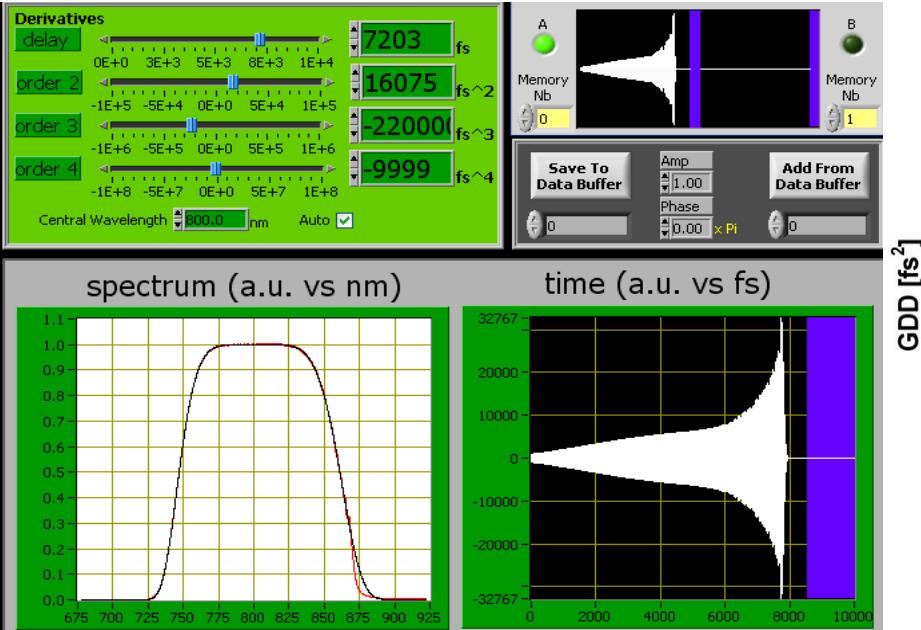
3. Spectrum Shaping Control with AOPDF



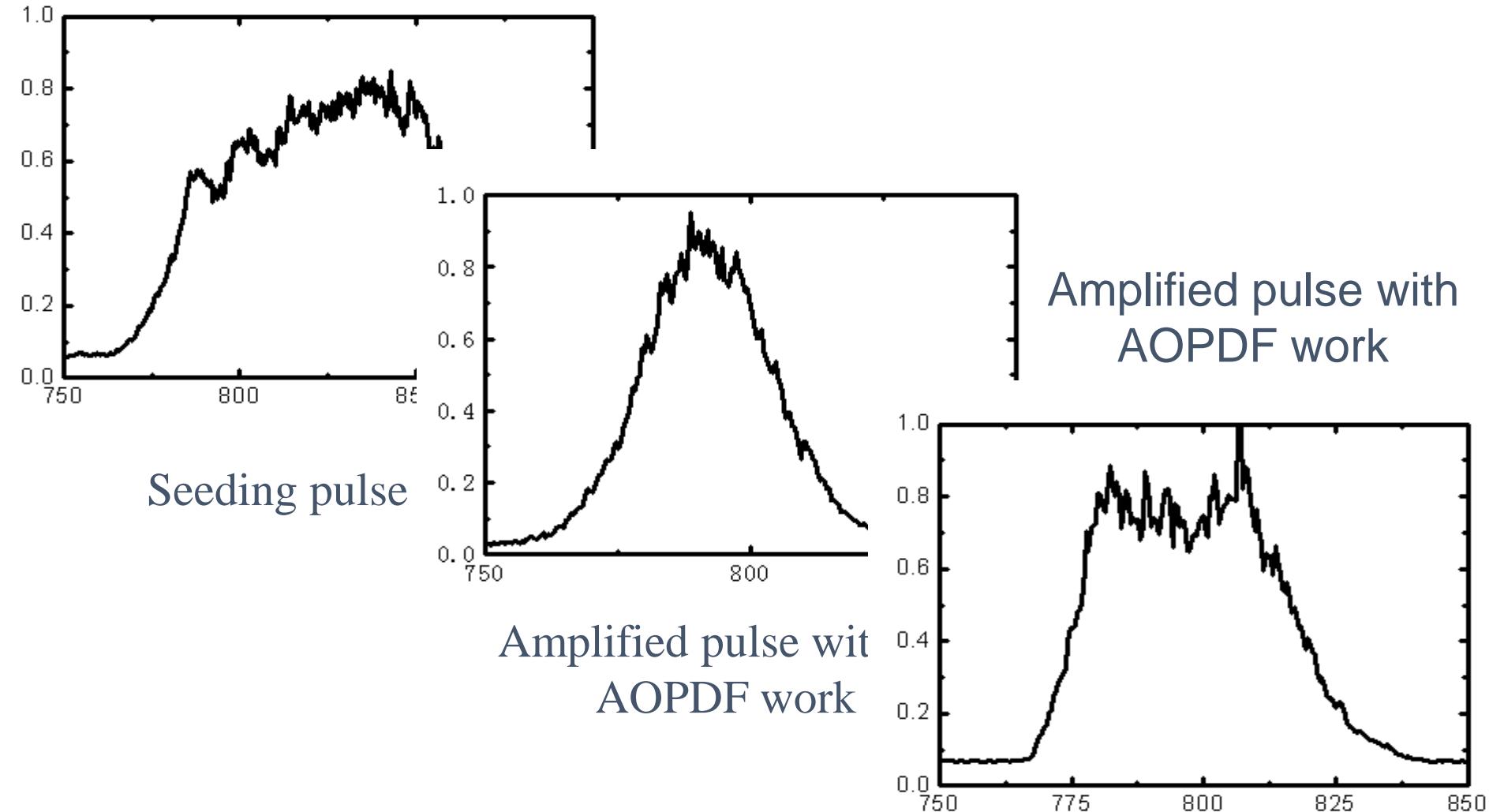
Acoustic-Optic Programmable Dispersive Filter for spectral amplitude and phase control

F. Verluise, V. Laude, Z. Cheng, Ch. Spielmann, and P. Tournois Opt. Lett. 25, 575 (2000)

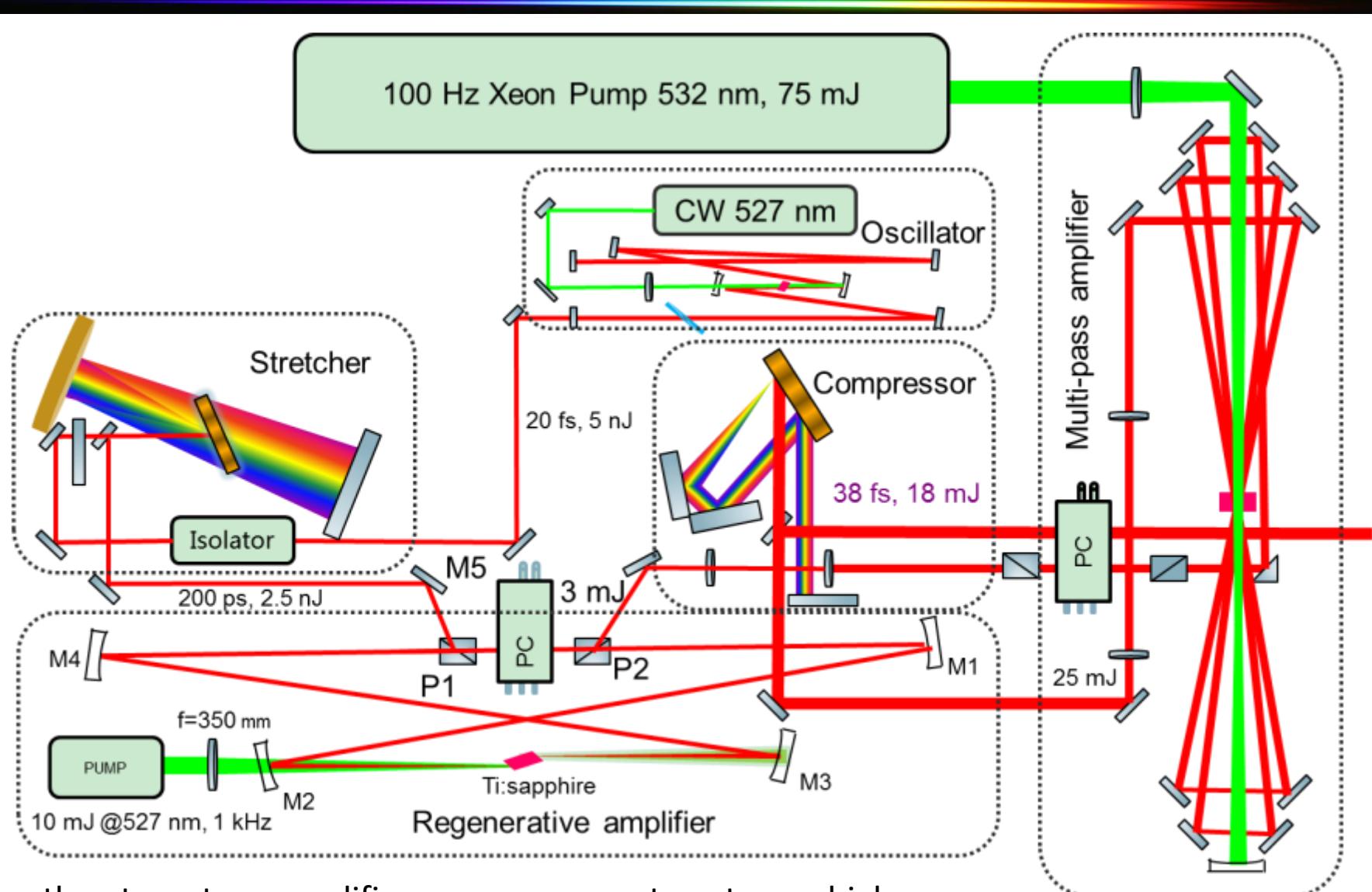
High order dispersion compensation



Spectra with shaping technique

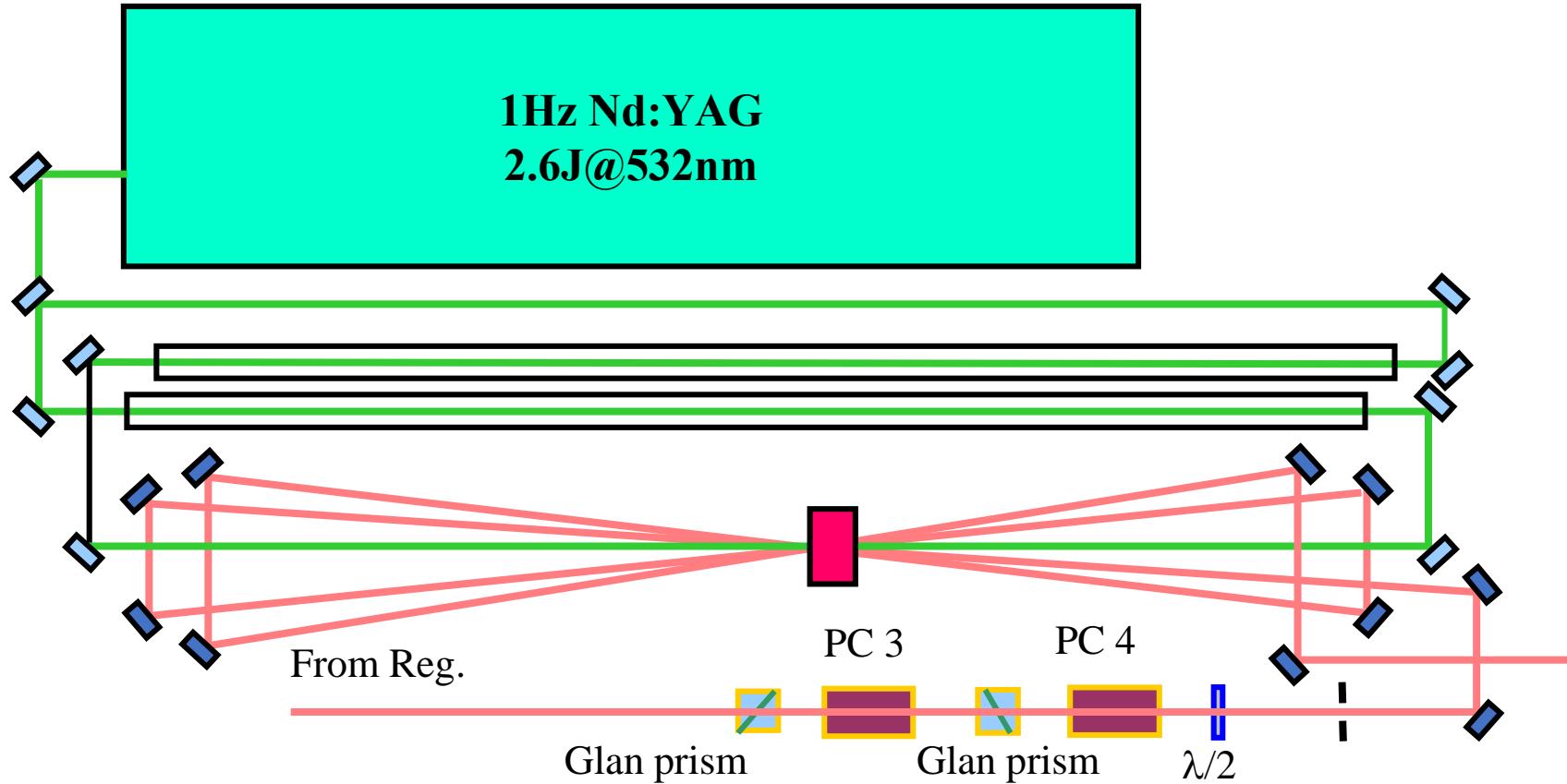


4. Amplify Chirped Pulse with two stages



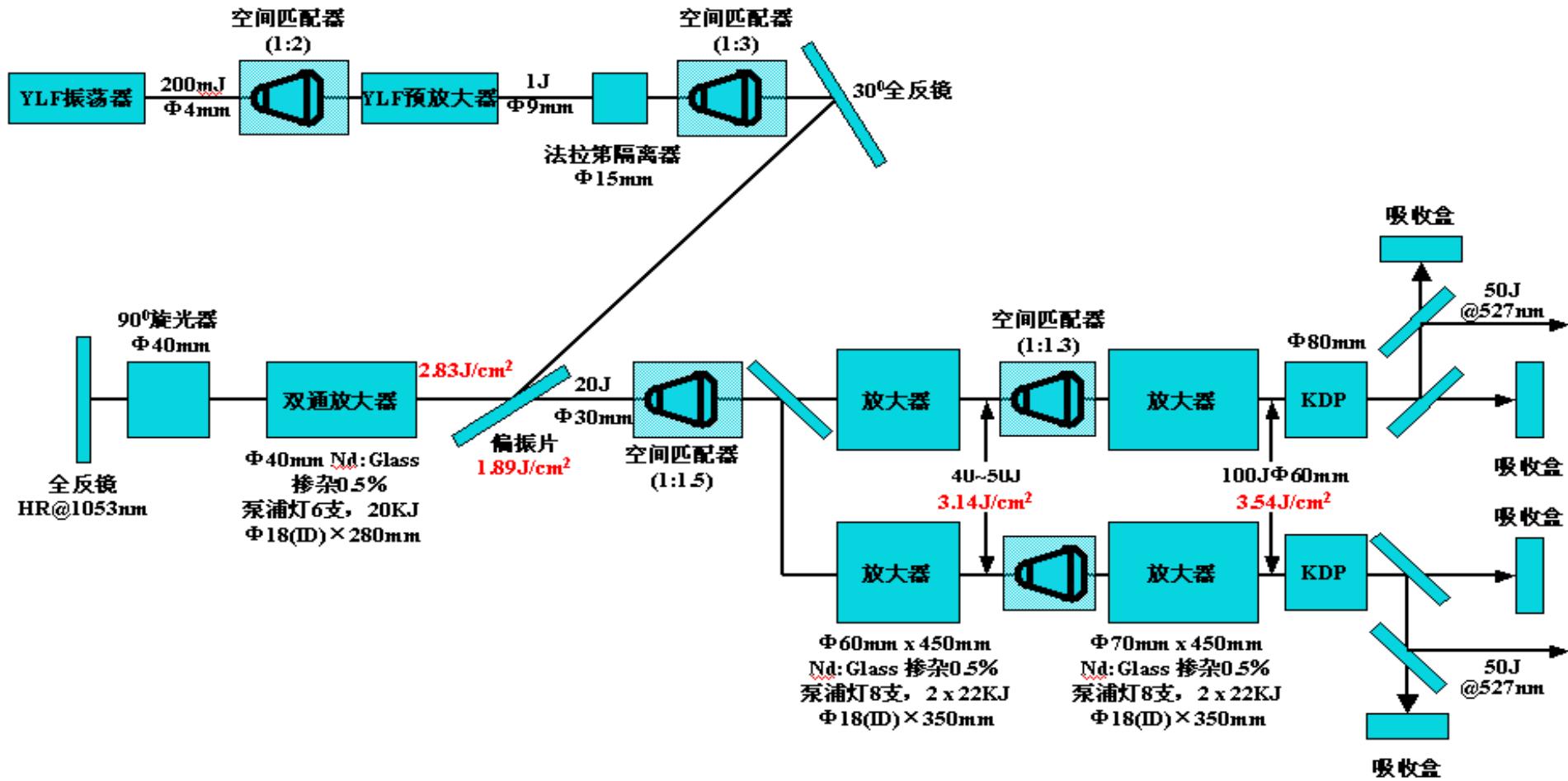
More than two stage amplifiers are necessary to get even higher energy

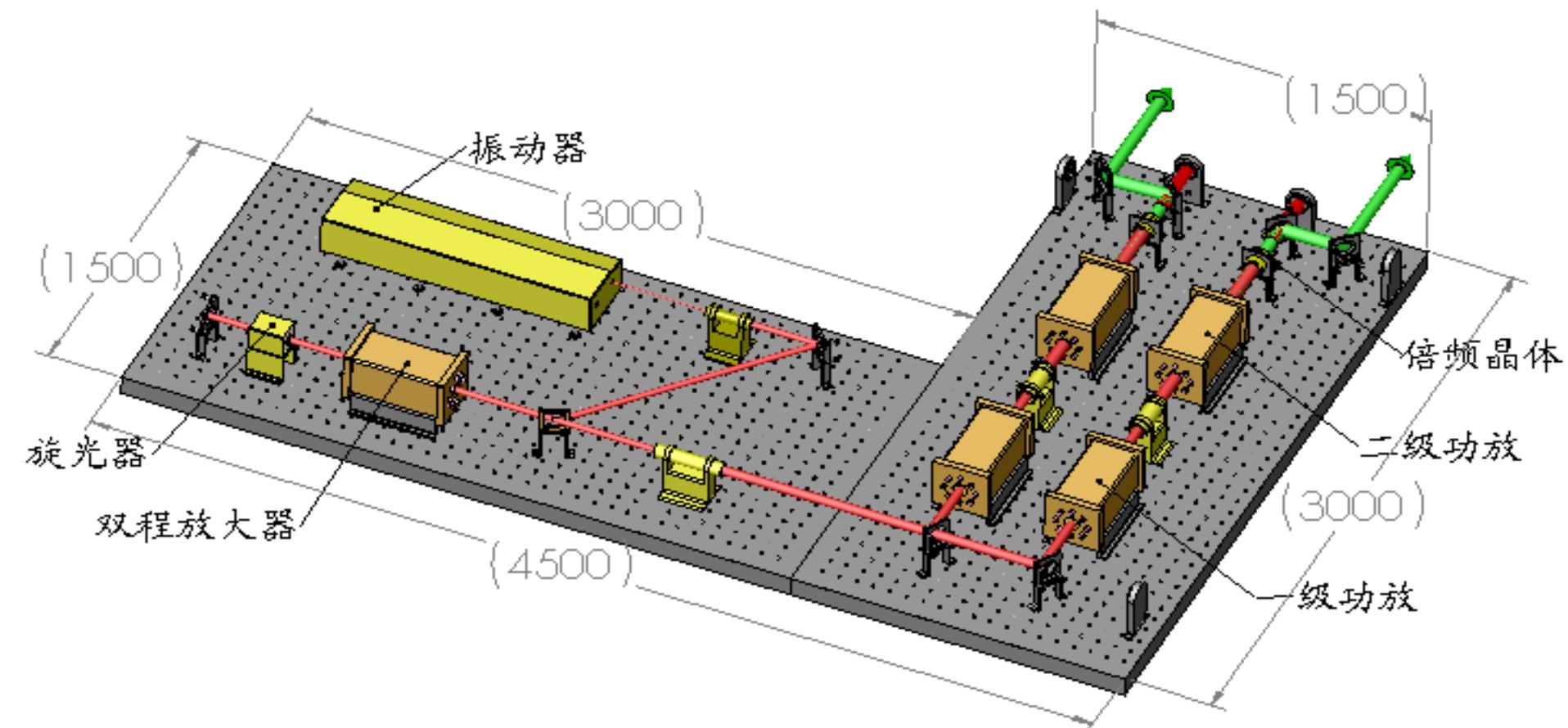
Multi-pass amplifier at 1Hz



Because of limitation by pump laser and thermal effect, the repetition rate should be reduced for high energy goal. With 2.6J pump laser energy, amplified laser of 700mJ was obtained.

Design of high energy pump laser: 100J SHG Nd:glass laser



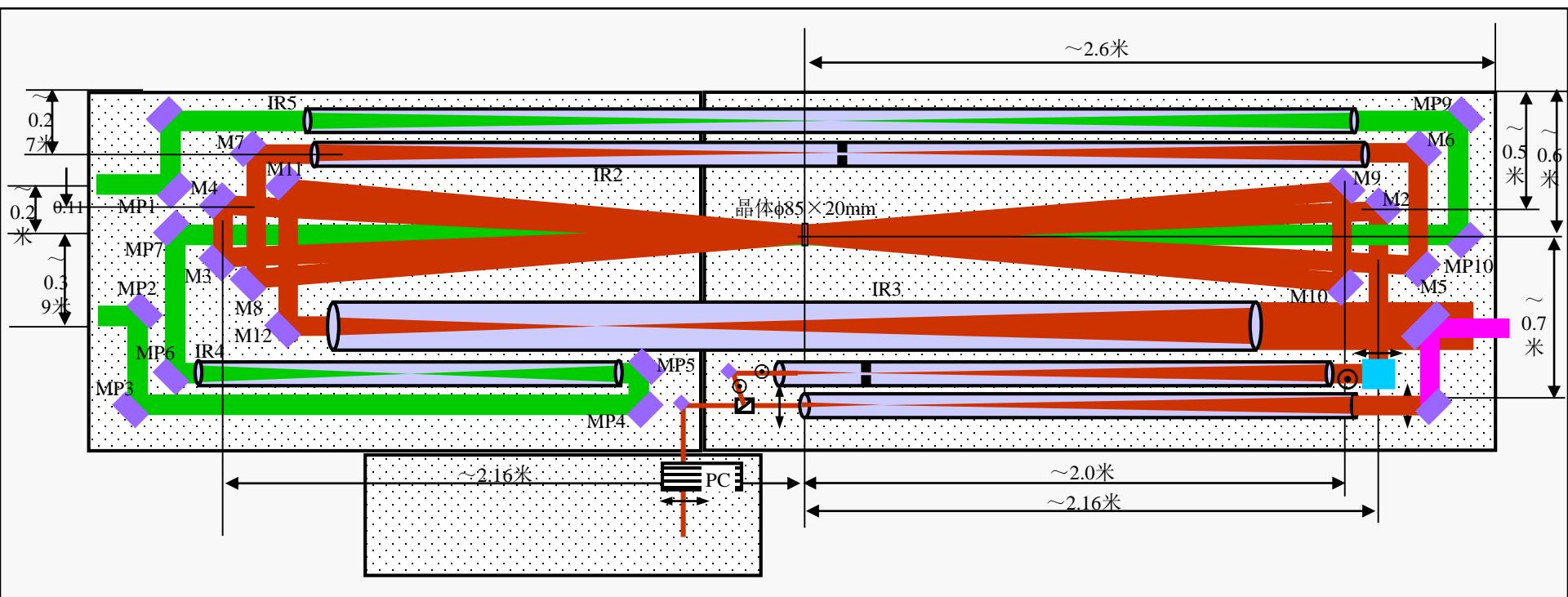


Pump:527nm Nd:glass laser
Energy:100J

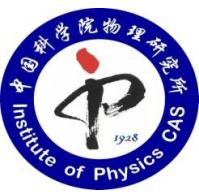




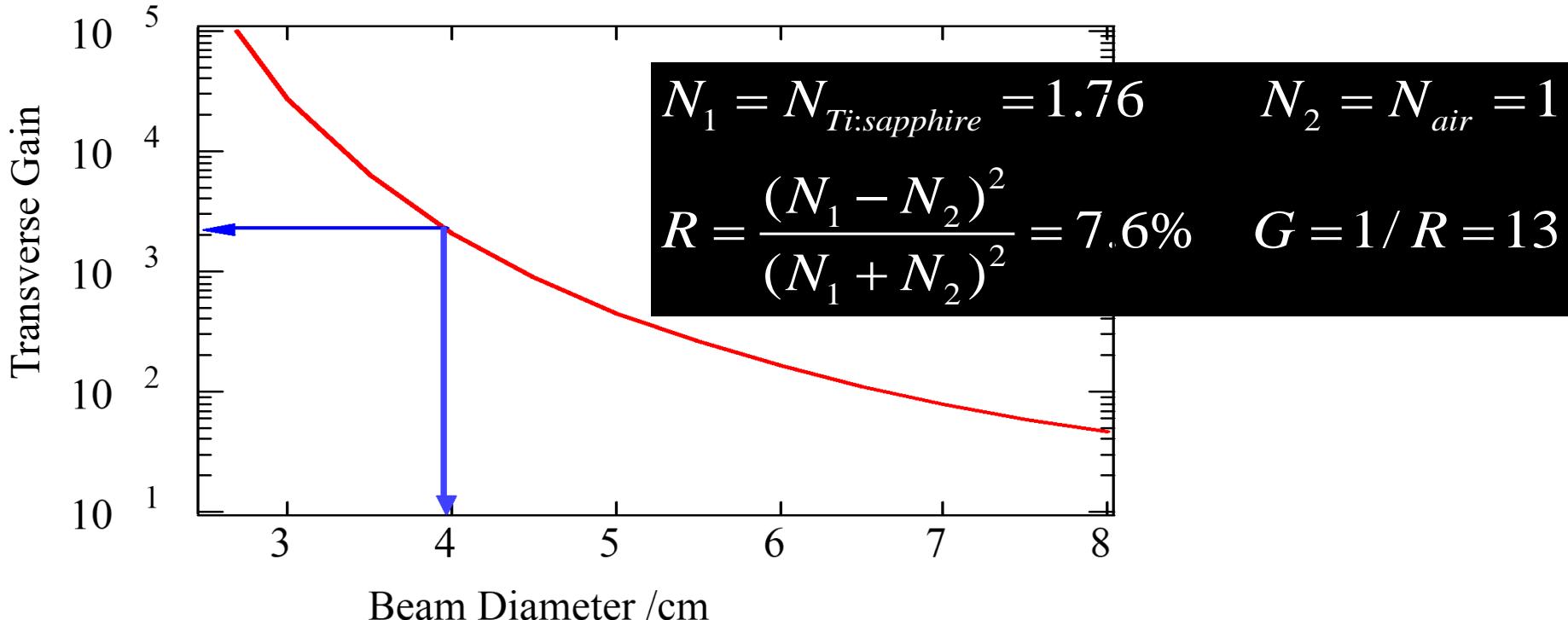
Boost Amplifier



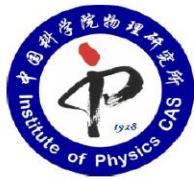
- ◆ Pumped the final amplifier with 80J laser at 527nm, output laser energy was only 5J at initial experiment.
- ◆ The lower efficiency of amplification infer to the possible Amplified spontaneous emission(ASE)



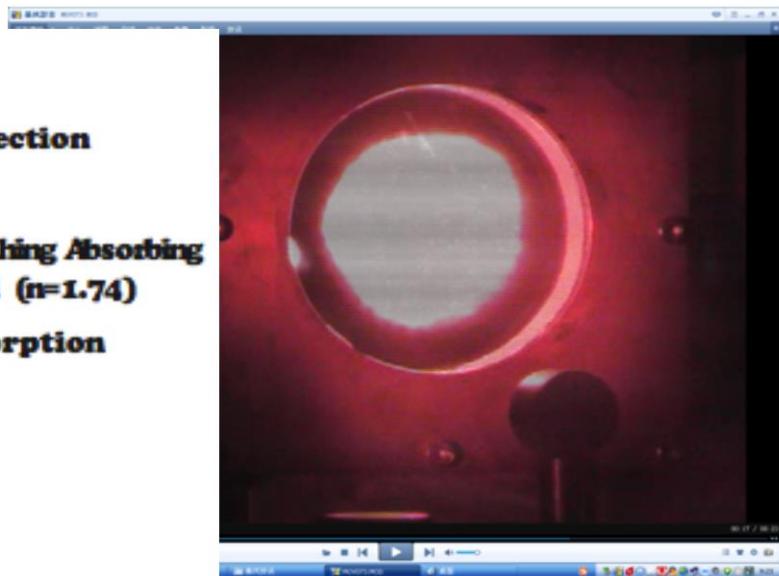
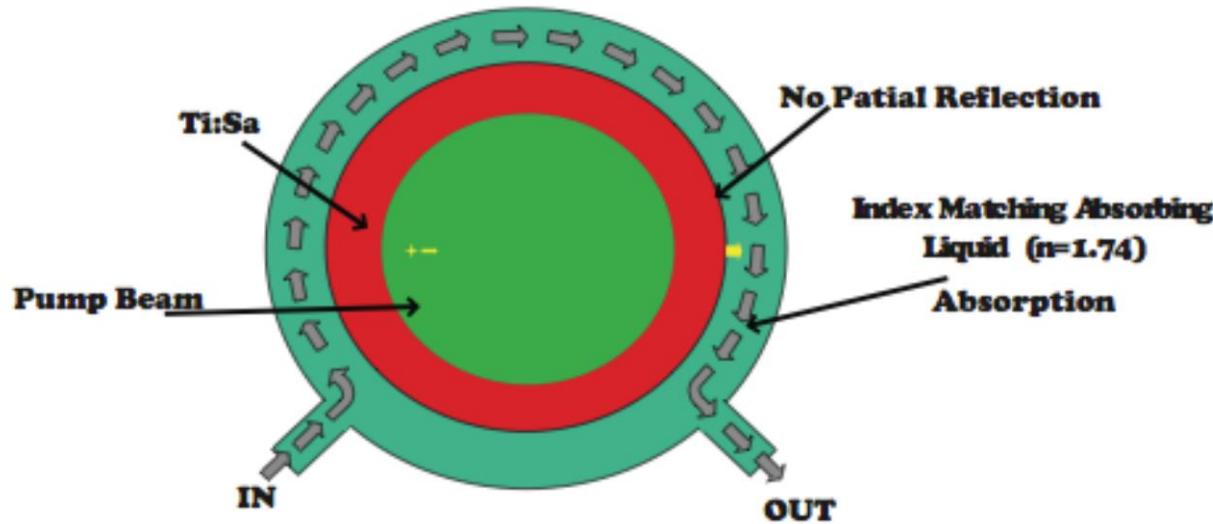
Eliminate ASE and PL with index match material



- Using thermoplastic (Cargille Laboratories, Inc.) material can well eliminate the effect.
- Amplified energy of 20J was obtained finally, increase from 5J to 20J



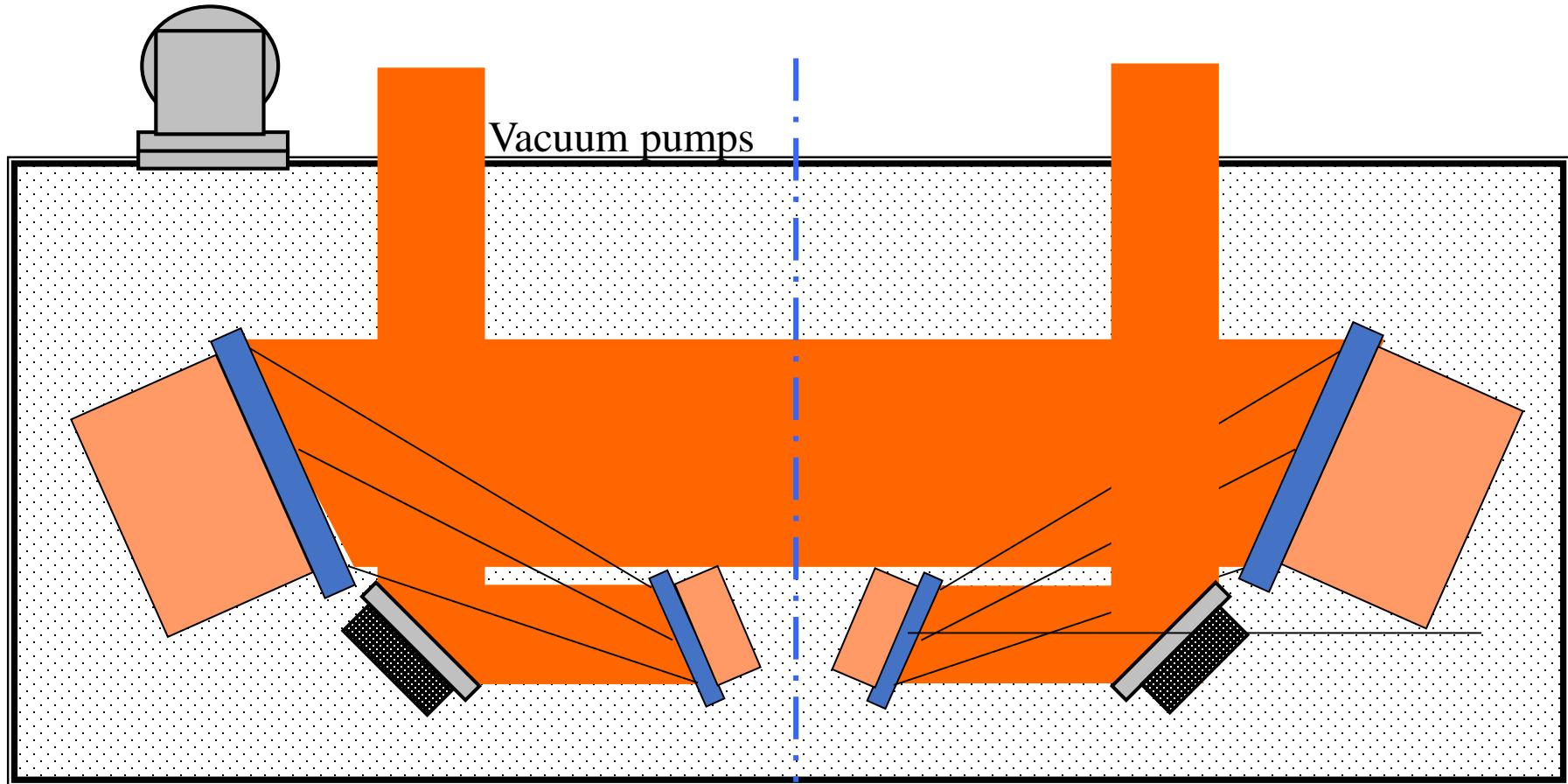
Suppression of parasitic lasing by using index match material



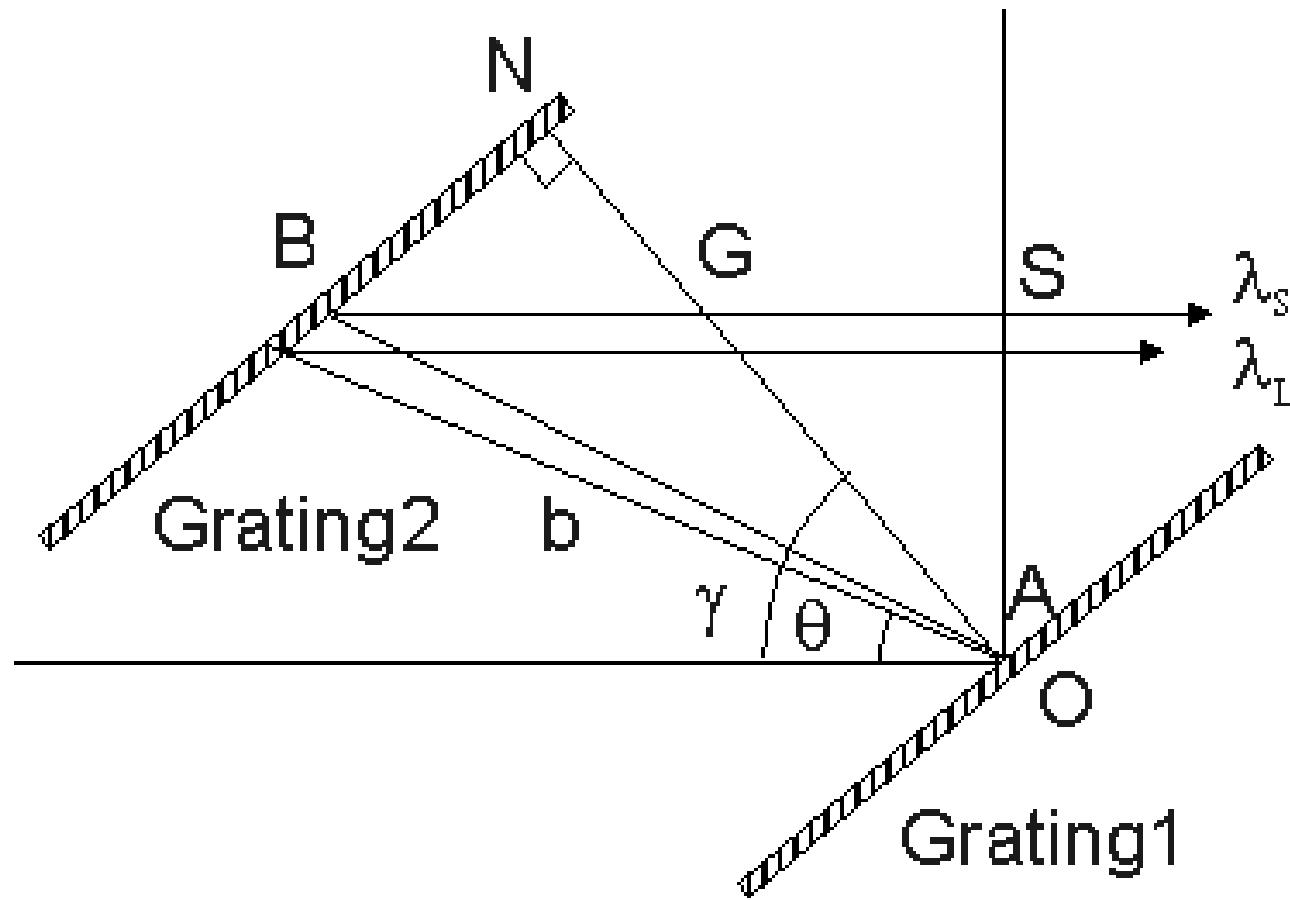
With a Ti:sapphire crystal of f80X40mm in size, 46.8J laser energy was obtained by eliminate the parasitic lasing and enlarge the beam diameter to 70mm to fit the optimized energy flux of about 3.1J/cm². For save operation, we remained at a median efficiency.

Compressor- Compensate dispersion for high peak power

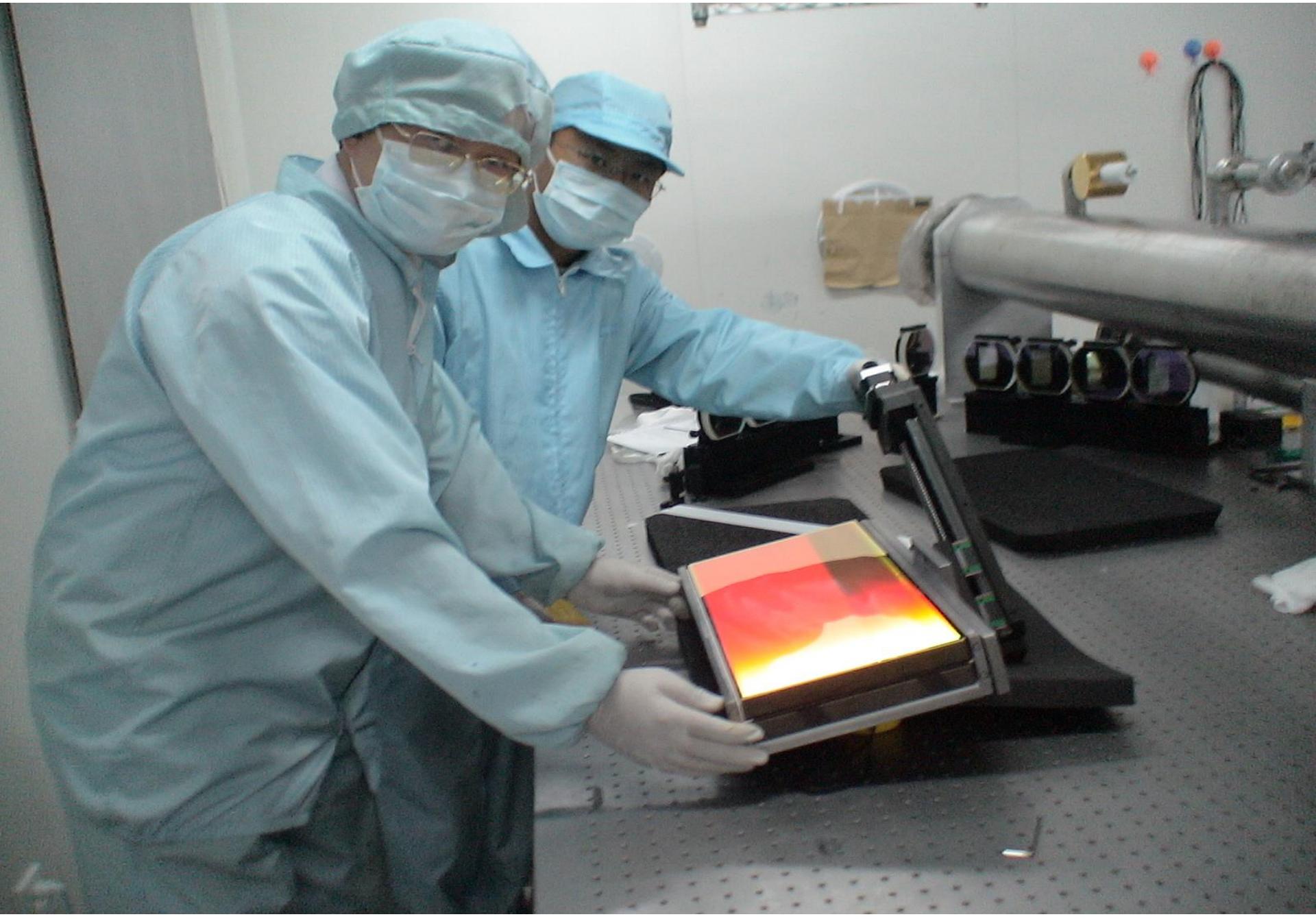
Layout of vacuum compressor



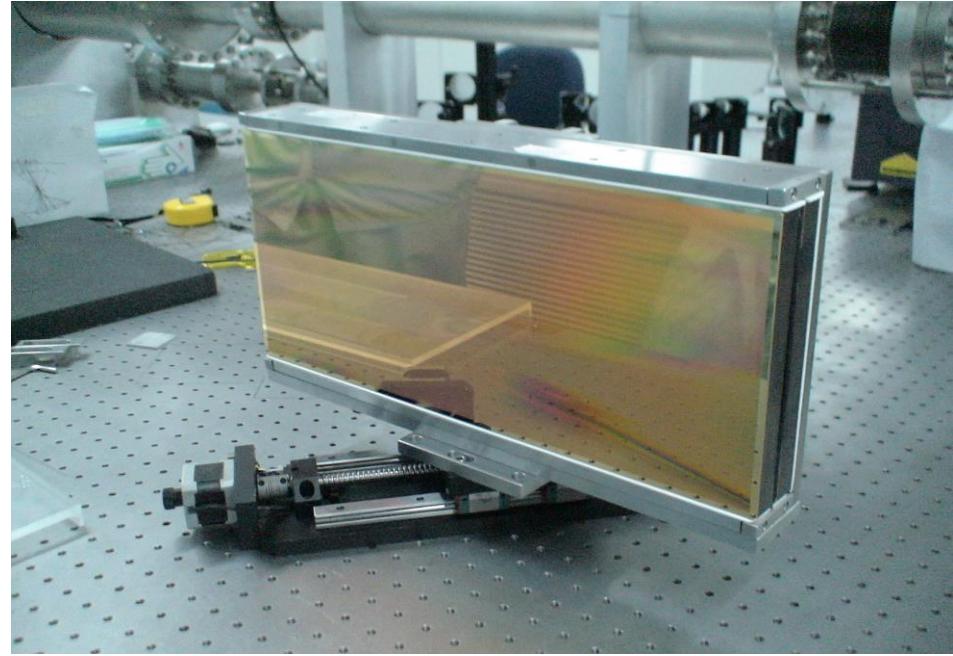
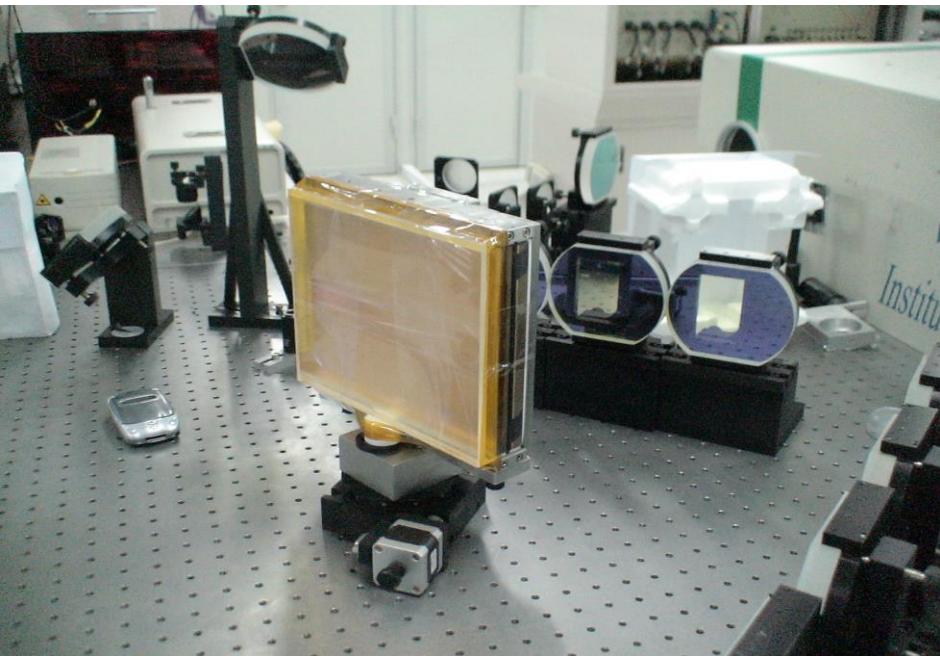
Space size of the chamber: $900 \times 700\text{mm}$,
Incident angle: 24 degree, diffractive angle: 51degree
E.Treacy equation(1969) : the dispersion is opposite to stretcher



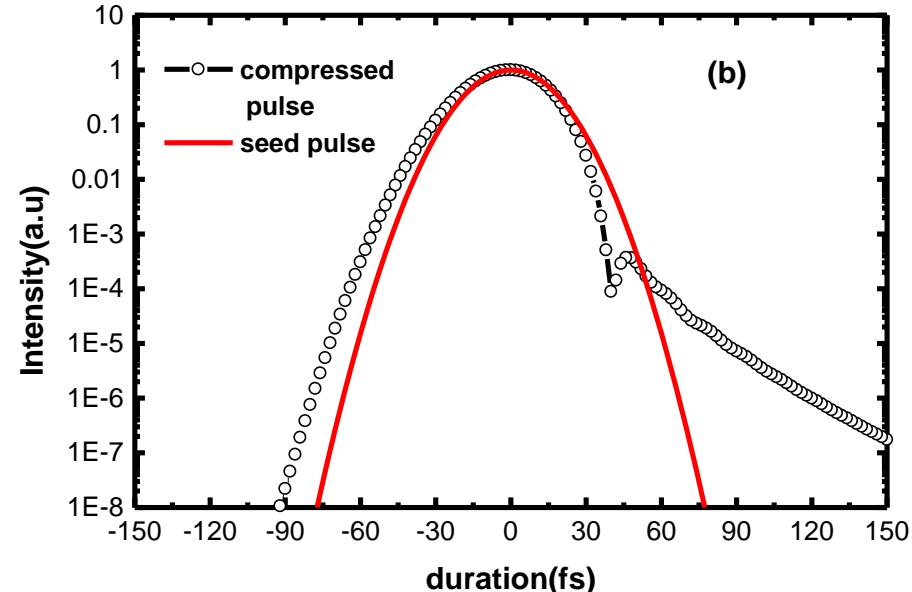
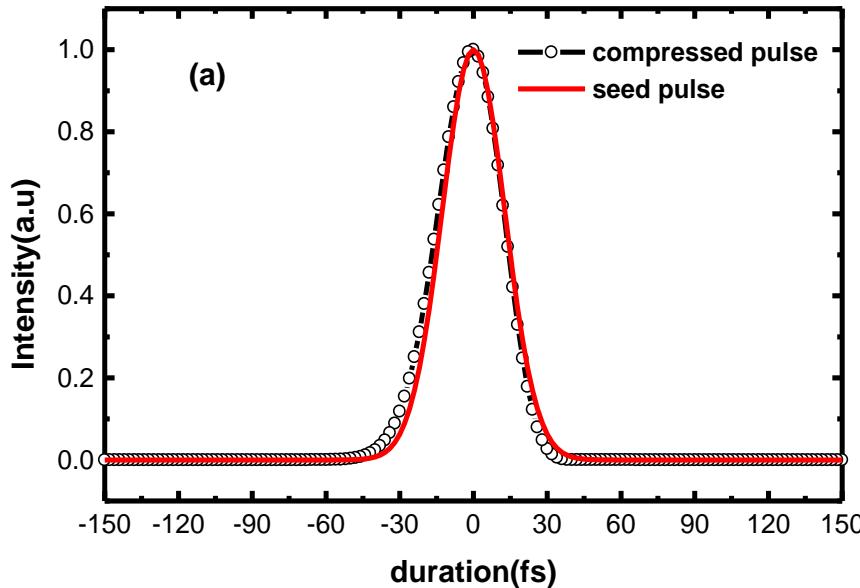
$$\varphi = \frac{\omega}{c} b(1 + \cos \theta) - \frac{2\pi G}{d} \tan(\gamma - \theta)$$



Gratings of compressor



Calculation for compressor



- ◆ Grating groove of the compressor is 1480/mm
- ◆ The experiment shows the transmissivity is larger than 60%, corresponding to the compressed energy is larger than 12J
- ◆ The calculation shows the compressed pulse of less than 25 fs is possible. For 40fs compressed pulse, it corresponds to a peak power is higher than 300TW

Enhancement on contrast ratio

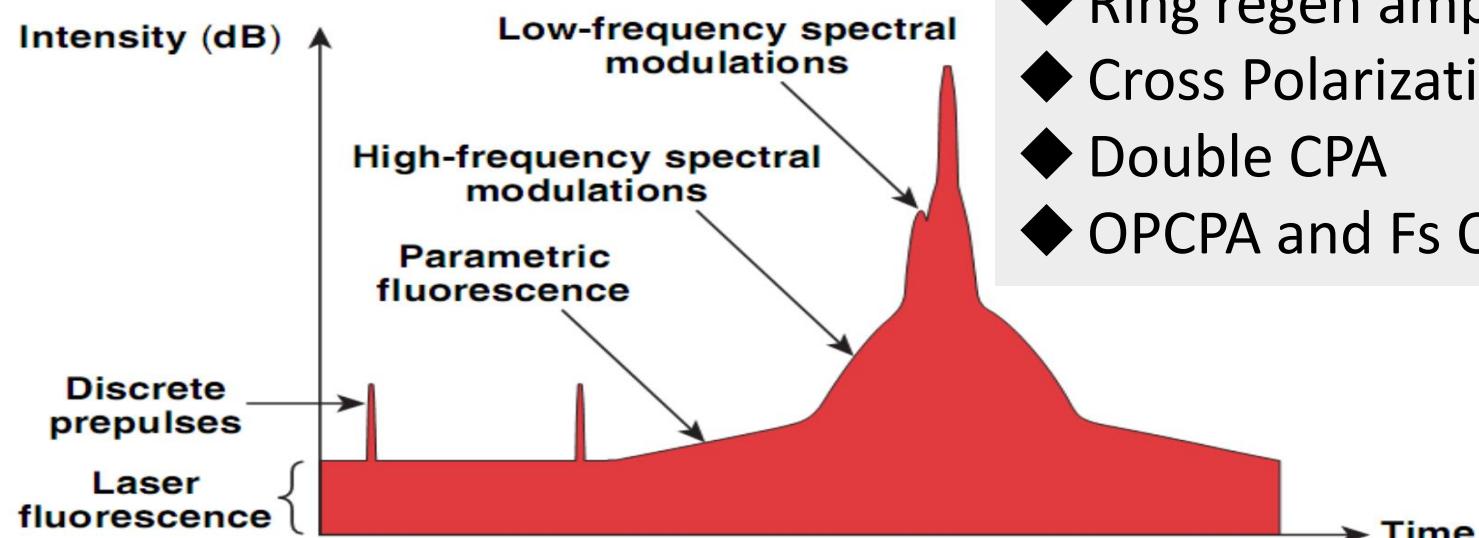
Questions on contrast ratio

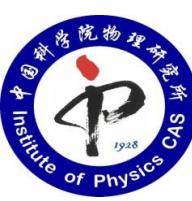
Contrast Ratio (S/N): The intensity of main pulse to background.

Because of the pre-pulses, ASE and fluorescence, result in decreasing of S/N in amplification.

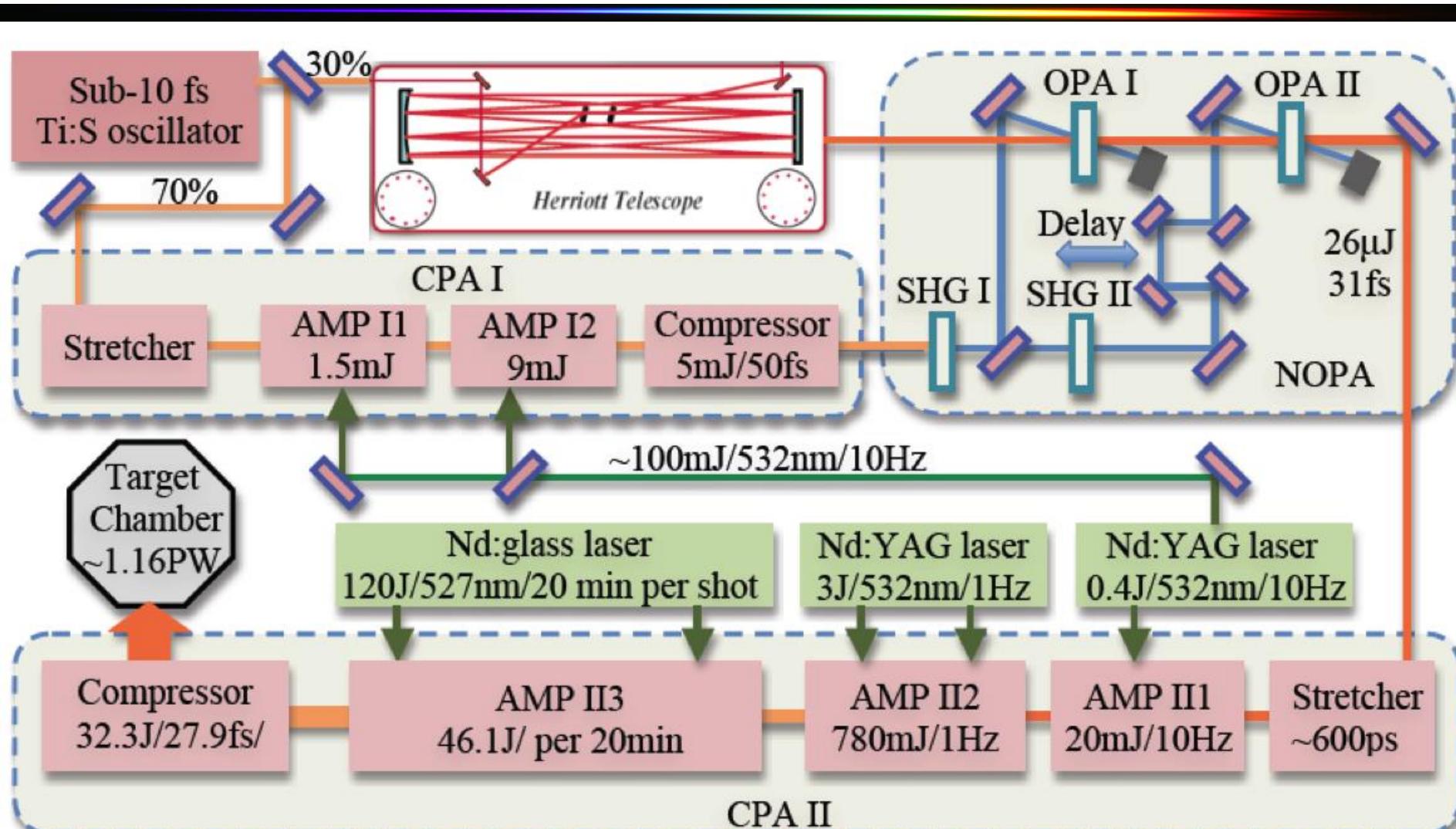
General techniques for improve S/N:

- ◆ More Pocket Cells
- ◆ Saturable Absorber
- ◆ Ring regen amplifier
- ◆ Cross Polarization Wave
- ◆ Double CPA
- ◆ OPCPA and Fs OPA

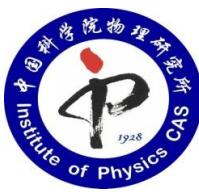




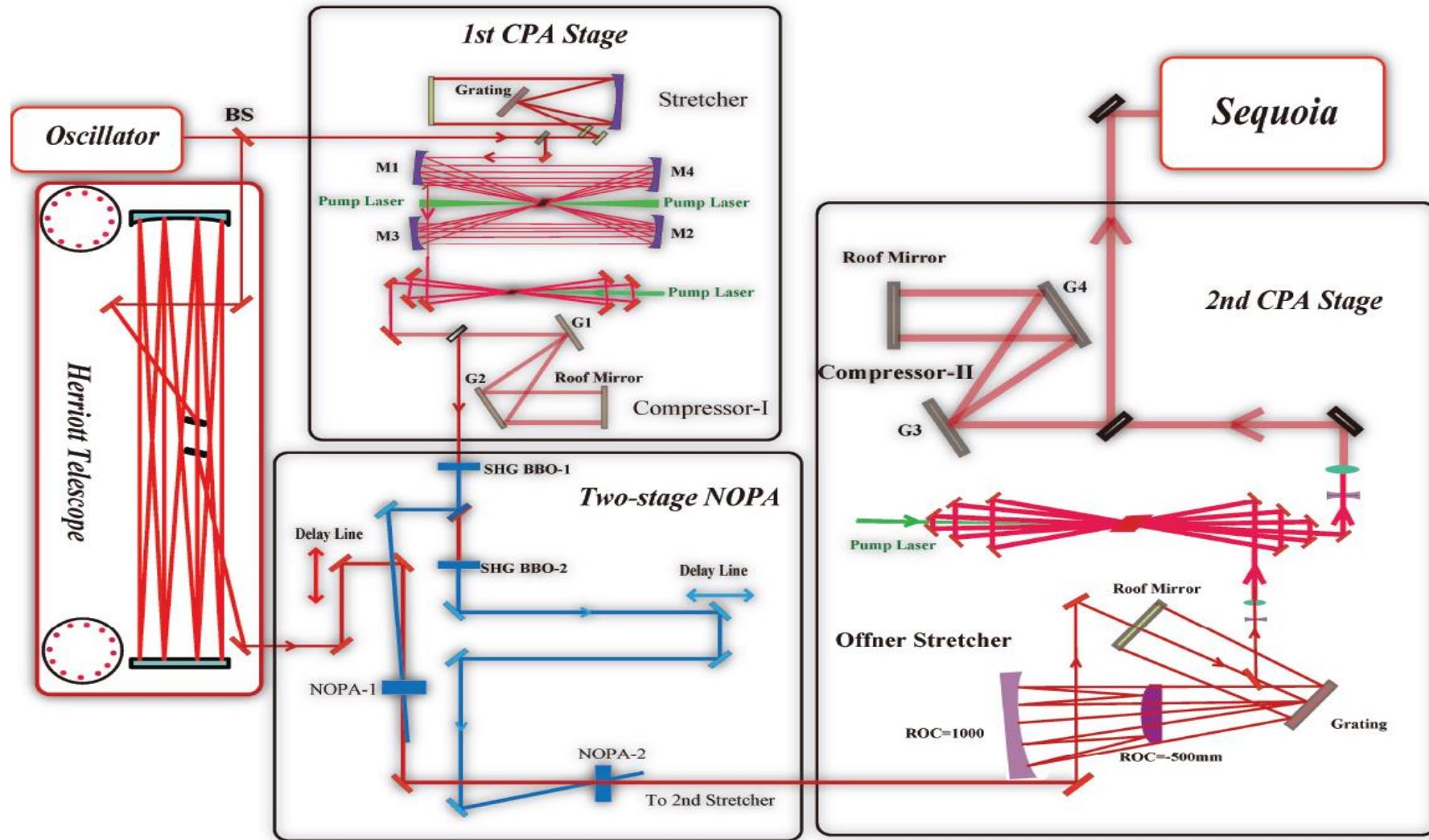
System Design for high contrast ratio



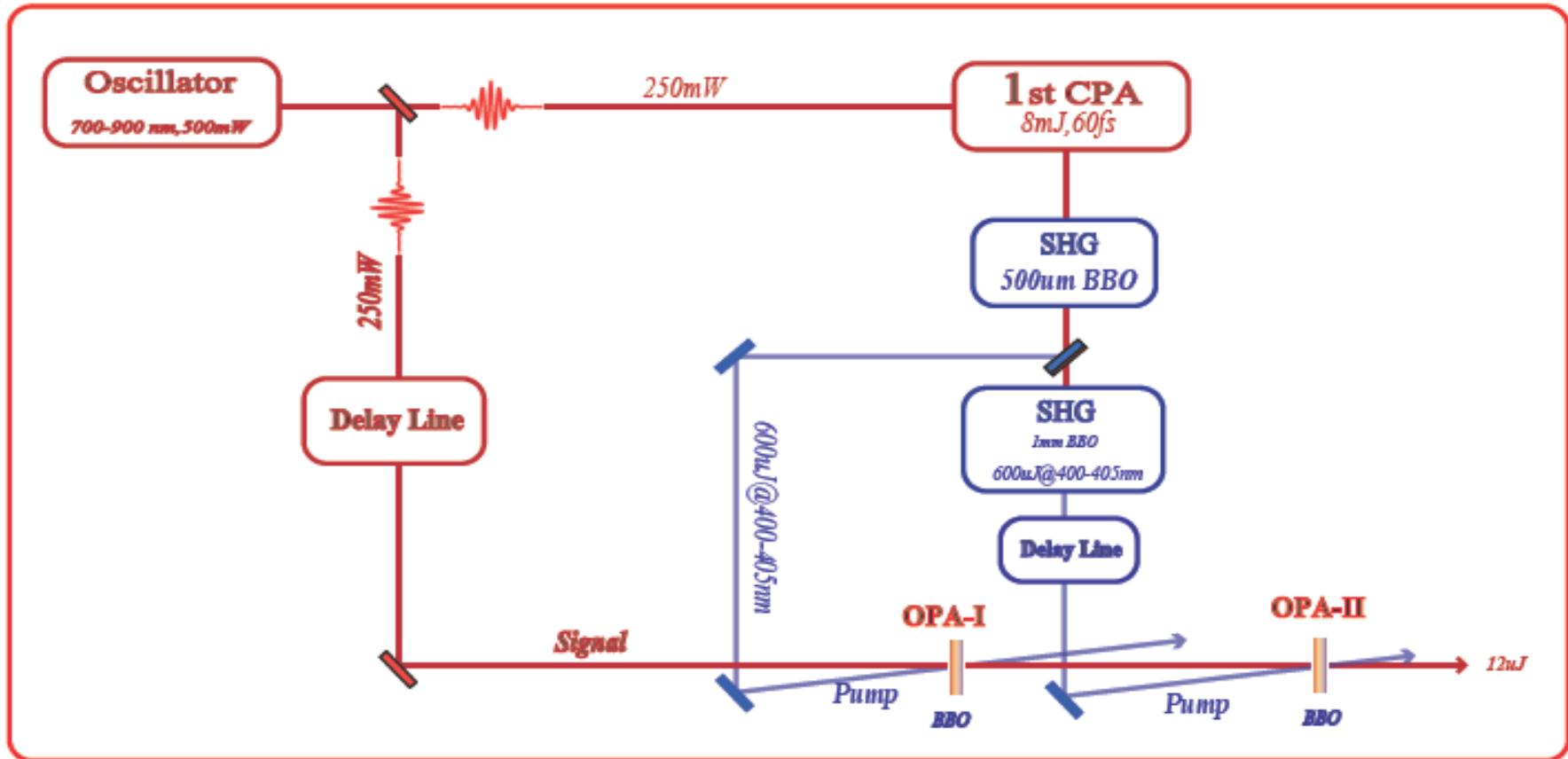
Doubled CPA+fs OPA

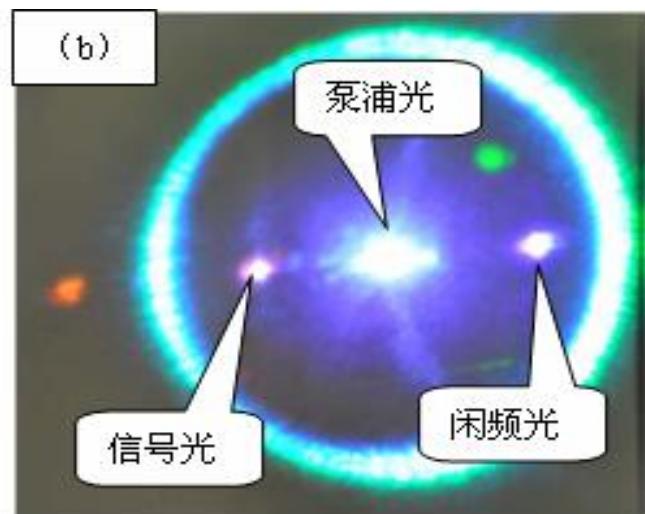
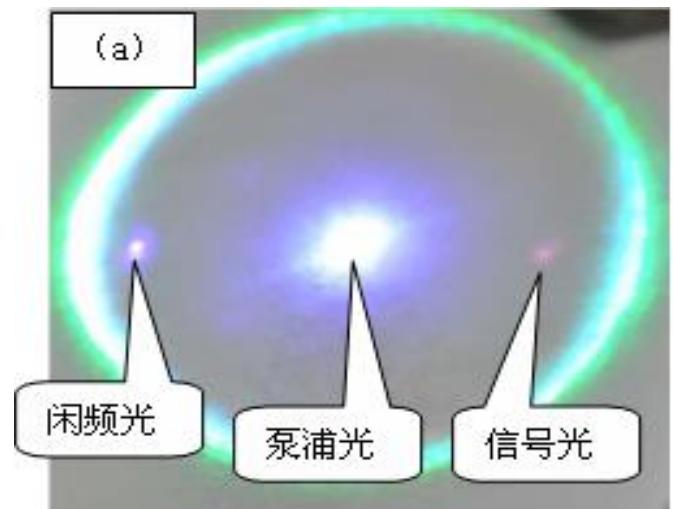
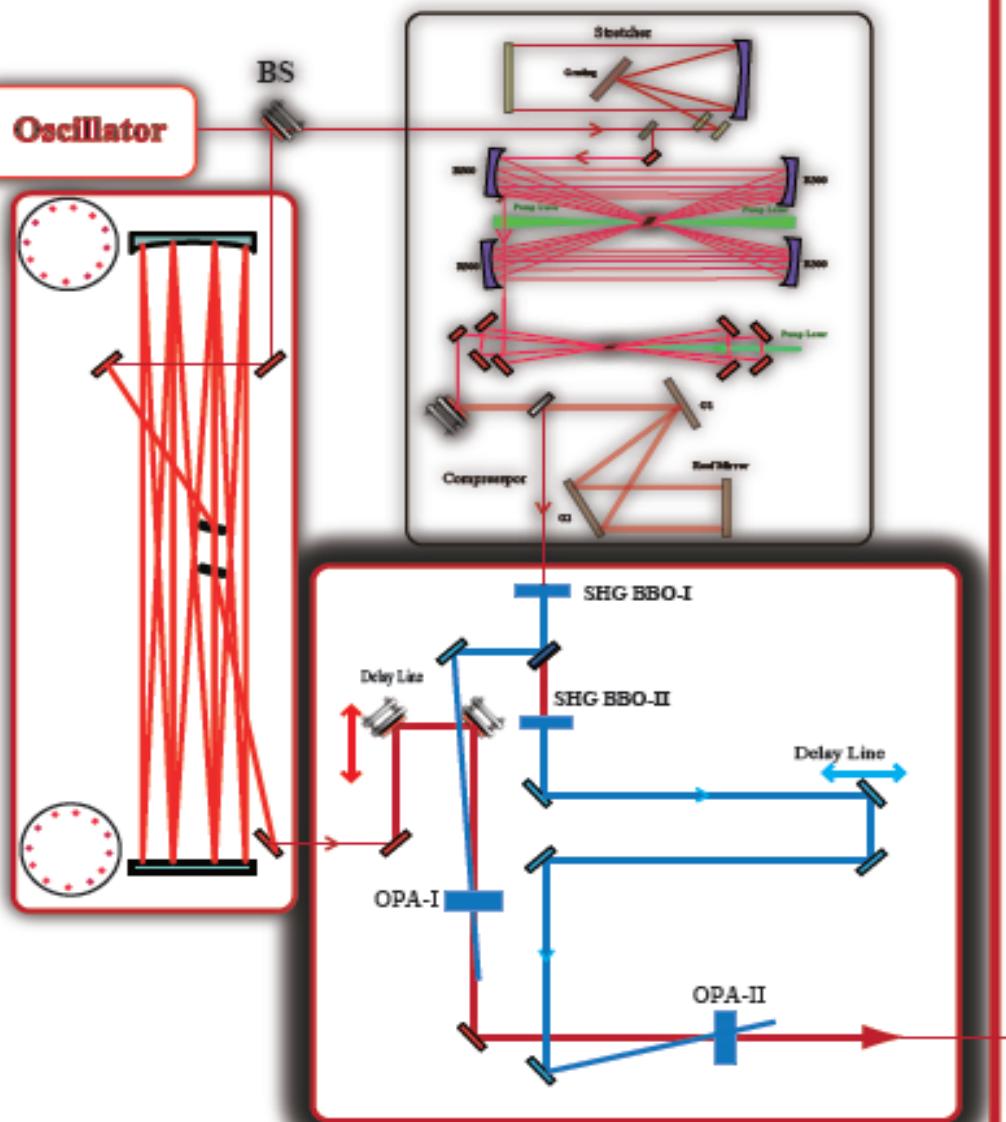


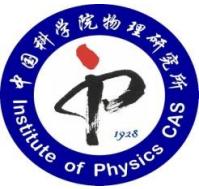
Non-Collinear OPA (NOPA)



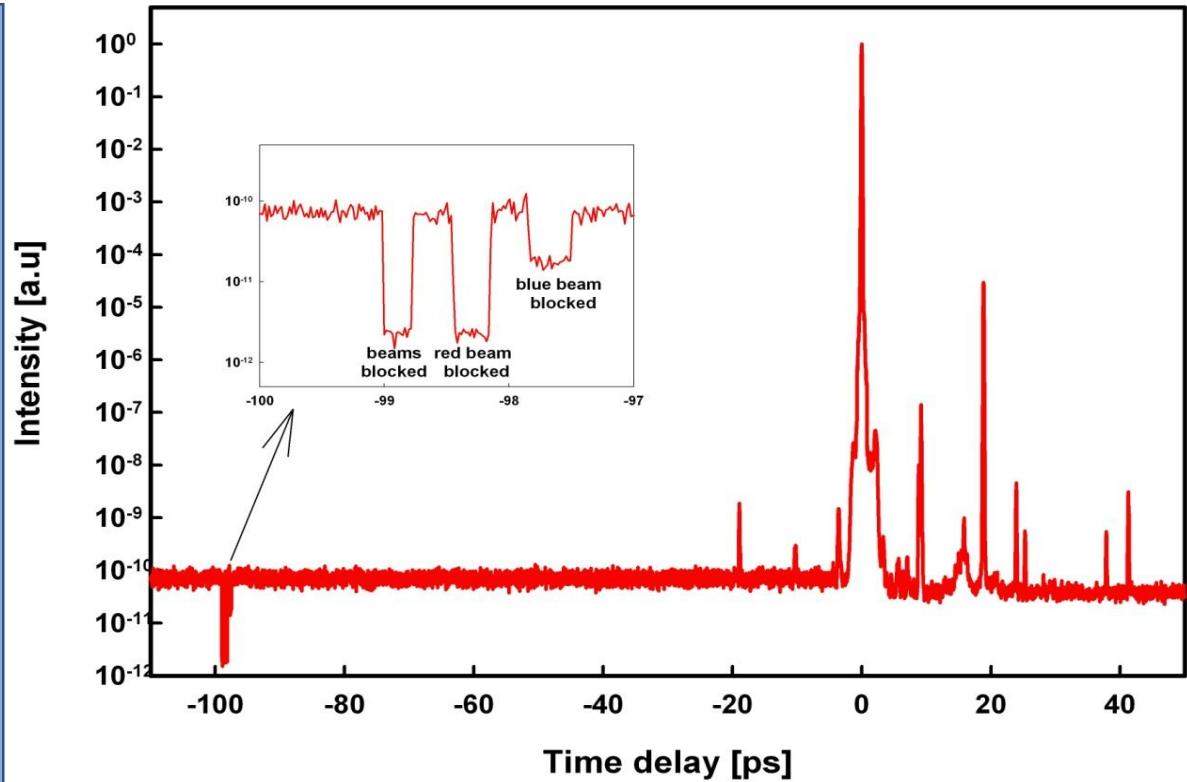
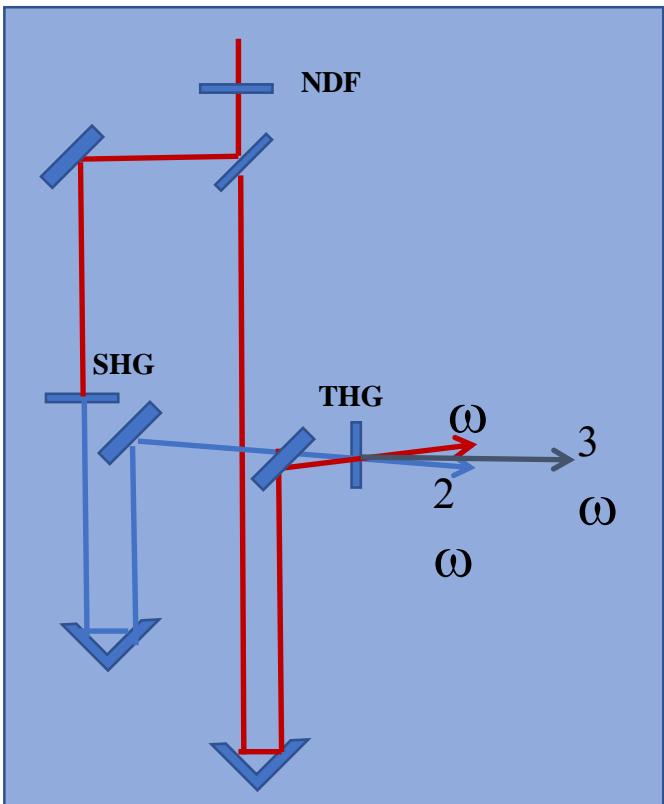
A simple descriptions on NOPA



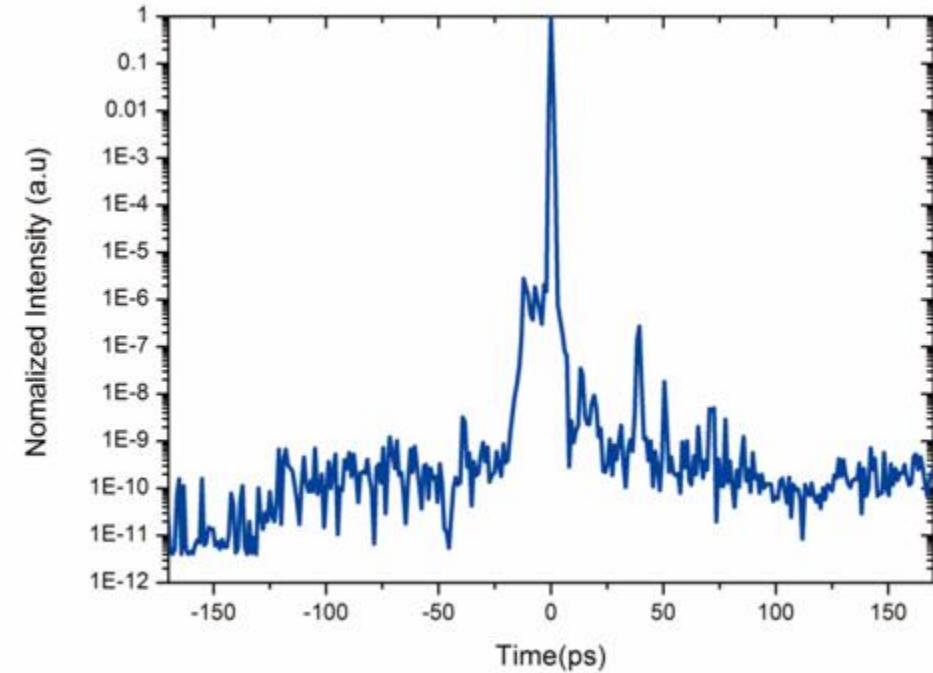
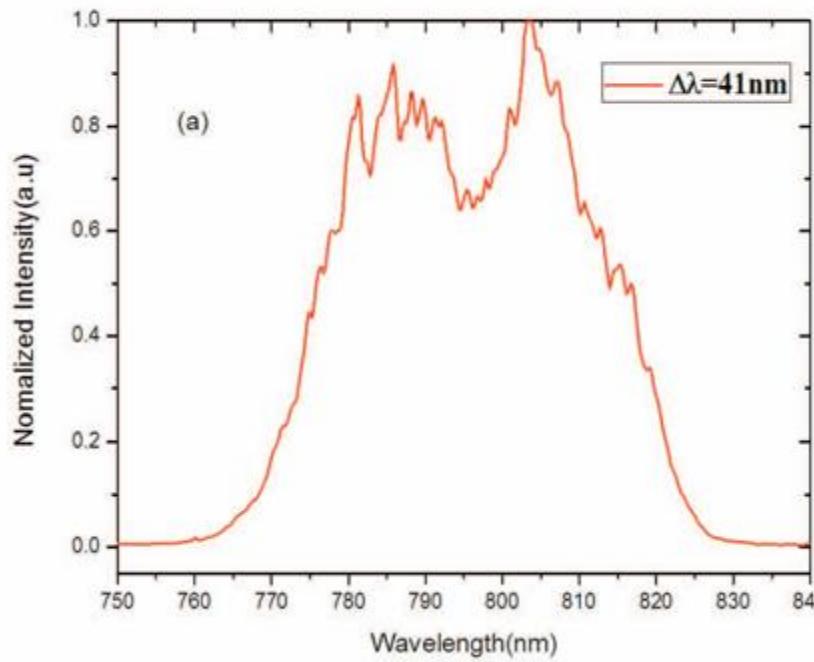




Measurement of Contrast Ratio Third cross-correlator

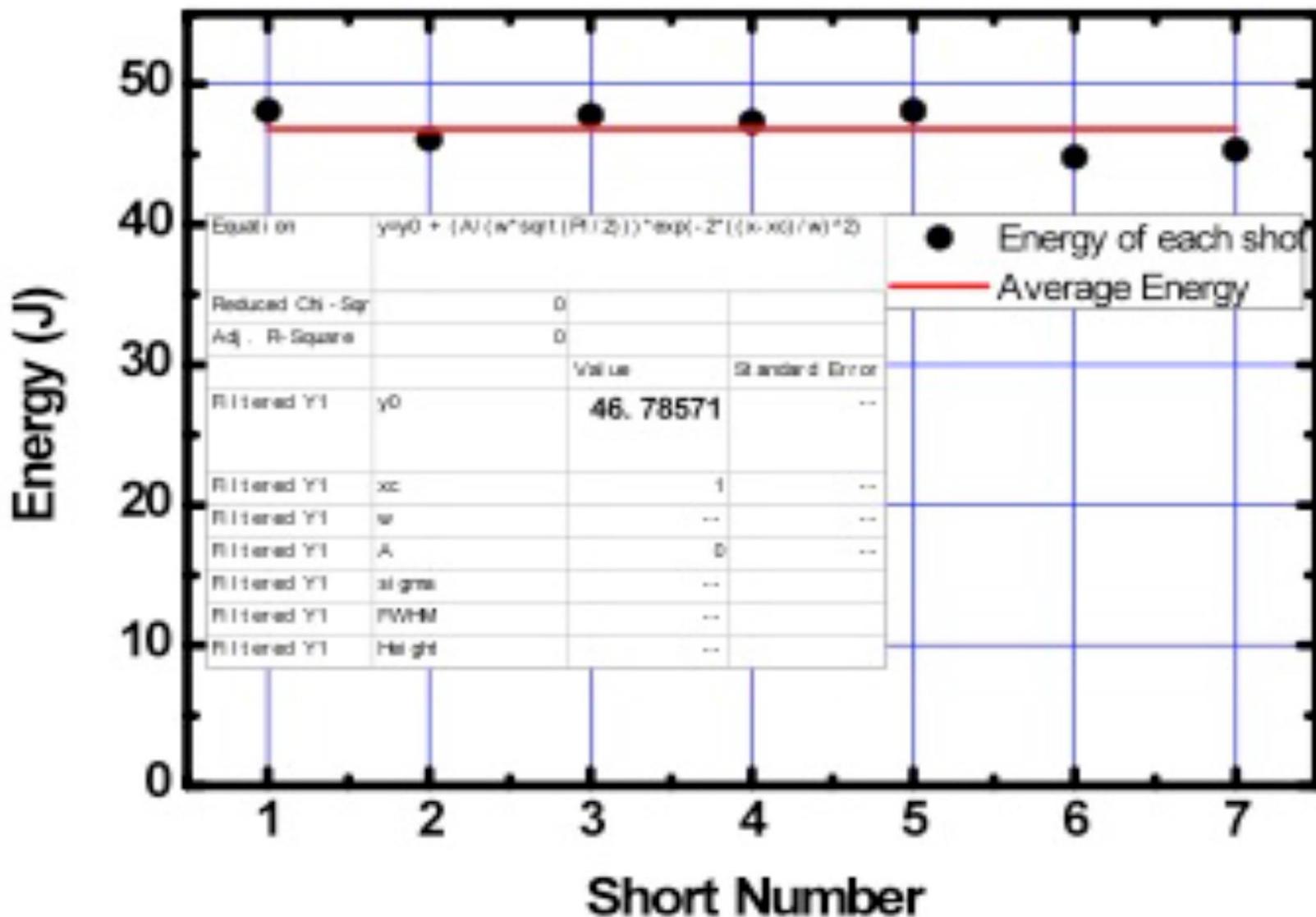


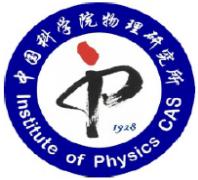
Measurement of contrast ratio



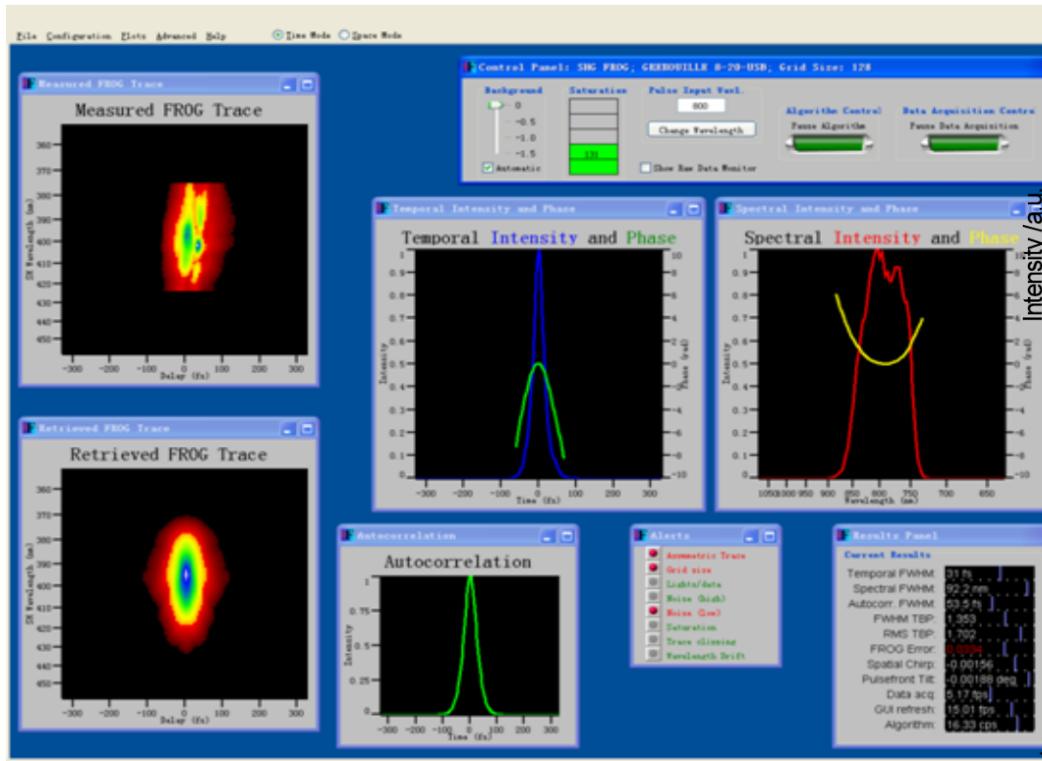
- ◆ With two stage OPA pumped by the SHG of 800nm amplified laser from CPA I, signal energy up to $26\mu\text{J}$ was obtained.
- ◆ Measurement of third-order cross correlation shows the contrast ratio up to 10^{10} in temporal scale of 100ps.
- ◆ The FWHM spectral width is 41 nm, supports a recompressed pulse of shorter than 30fs---Opt. Lett. 35, 3096(2010)

Laser shot energy per 20 mins





Laser measurement with FROG

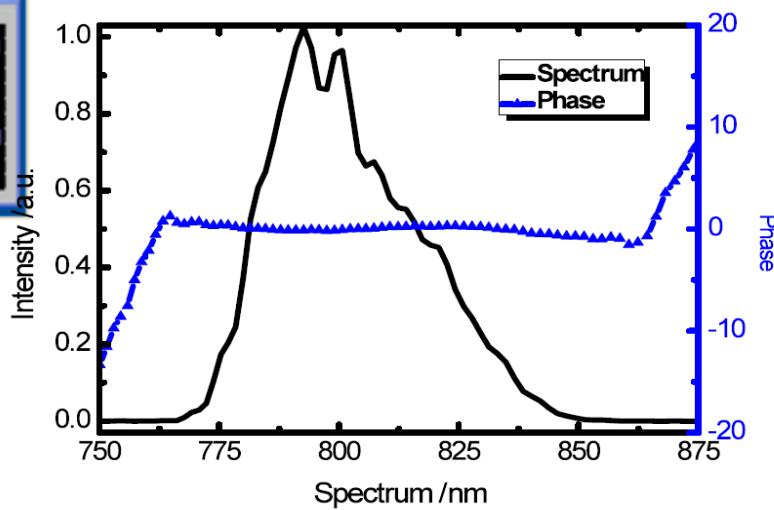
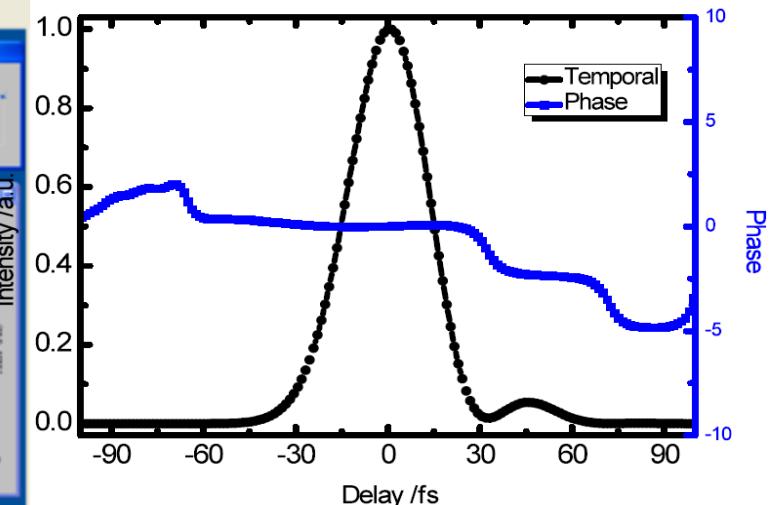


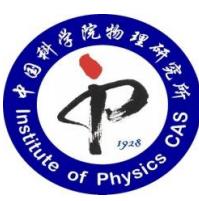
Measured results by SHG-FROG

FWHM spectral width: ~41 nm.

Pulse duration: ~27.9fs,

⇒ **1.16PW**





eXtreme Light (XL) III Facility

Progresses step of laser facility at IoP
in last decade:

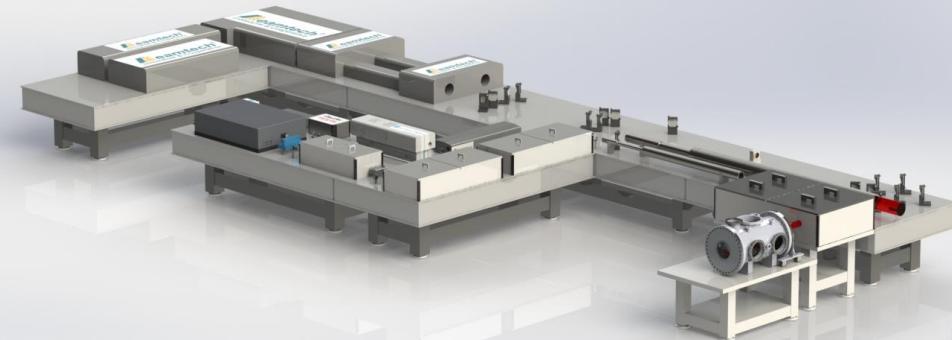
350TW@2007,

750TW@2008,

1.16PW@2011. contrast: $\sim 10^{10}$

Opt Lett, 3096(2010) & 3194(2011)

Repetition rate: Single shot per 20 mins.



Electron and proton acceleration have been realized.

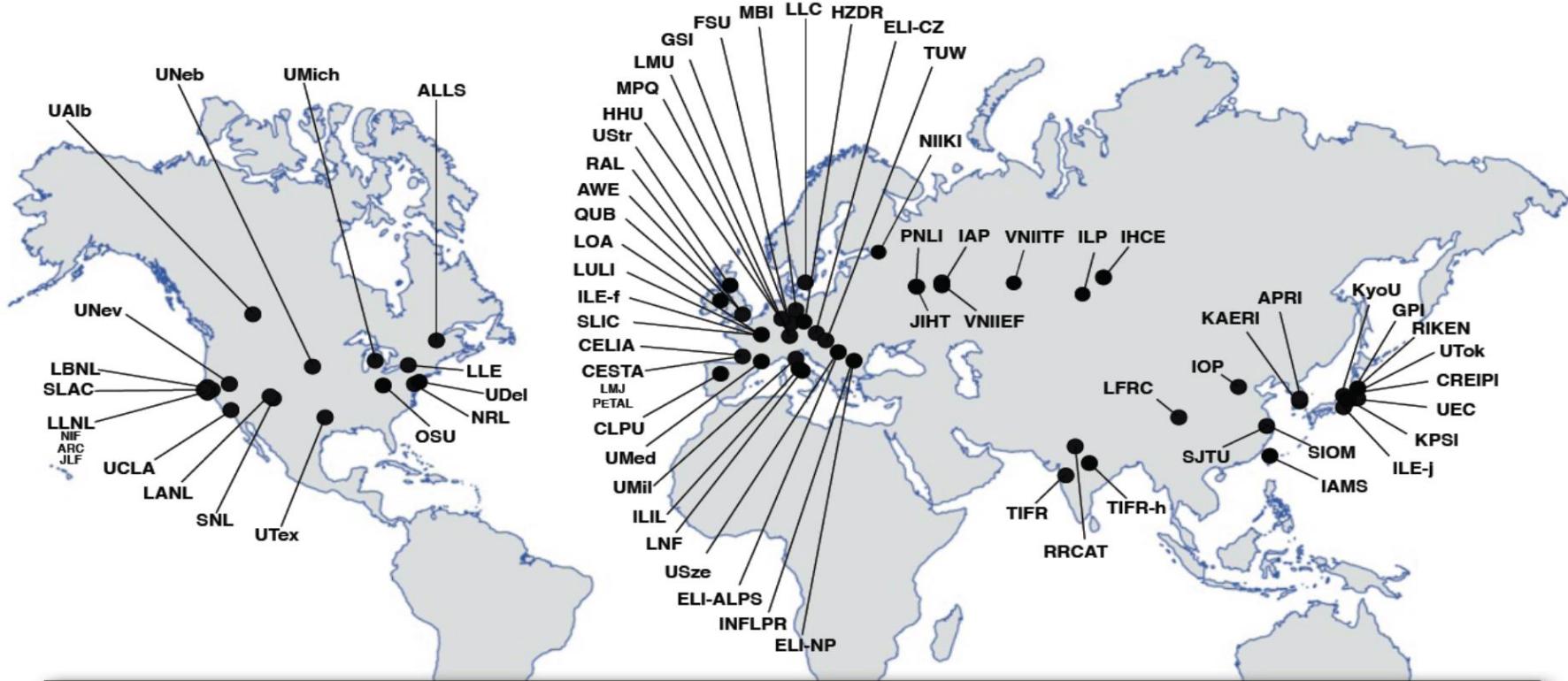
Typical PW laser facilities in the world

Some femtosecond Ultrahigh Intensity Laser Facilities in the World

- ◆ 1999. M. D. Perry, 1.4PW, OL 24, 160
- ◆ 2003, M. Aoyama *et al.*, 0.85PW/33fs, OL 28, 1594
- ◆ 2007, Z. Y. Wei *et al.*, 355TW/30fs, CLEO JWC2
- ◆ 2007, X. Liang *et al.*, 890TW/29fs, OE 15, 15335
- ◆ 2008, K. Ertel *et al.*, ~500TW, OE 16, 8039
- ◆ 2008, E. Gaul, 1.1PW/Hybrid, ICUIL
- ◆ 2010, J. H. Sung *et al.*, 1.0 PW, OL 35, 3021
- ◆ 2011, Z. Y. Wei *et al.*, 1.16PW, OL 36, 3194
- ◆ 2012, Tae Moon Jeong *et al.*, 1.5PW, OE 20, 10807
- ◆ 2015, X. Liang *et al.*, for 5PW, OL 40, 5011
- ◆ 2017, SIOM, China, 10PW

.....

2010 ICUIL World Map of Ultrahigh Intensity Laser Capabilities



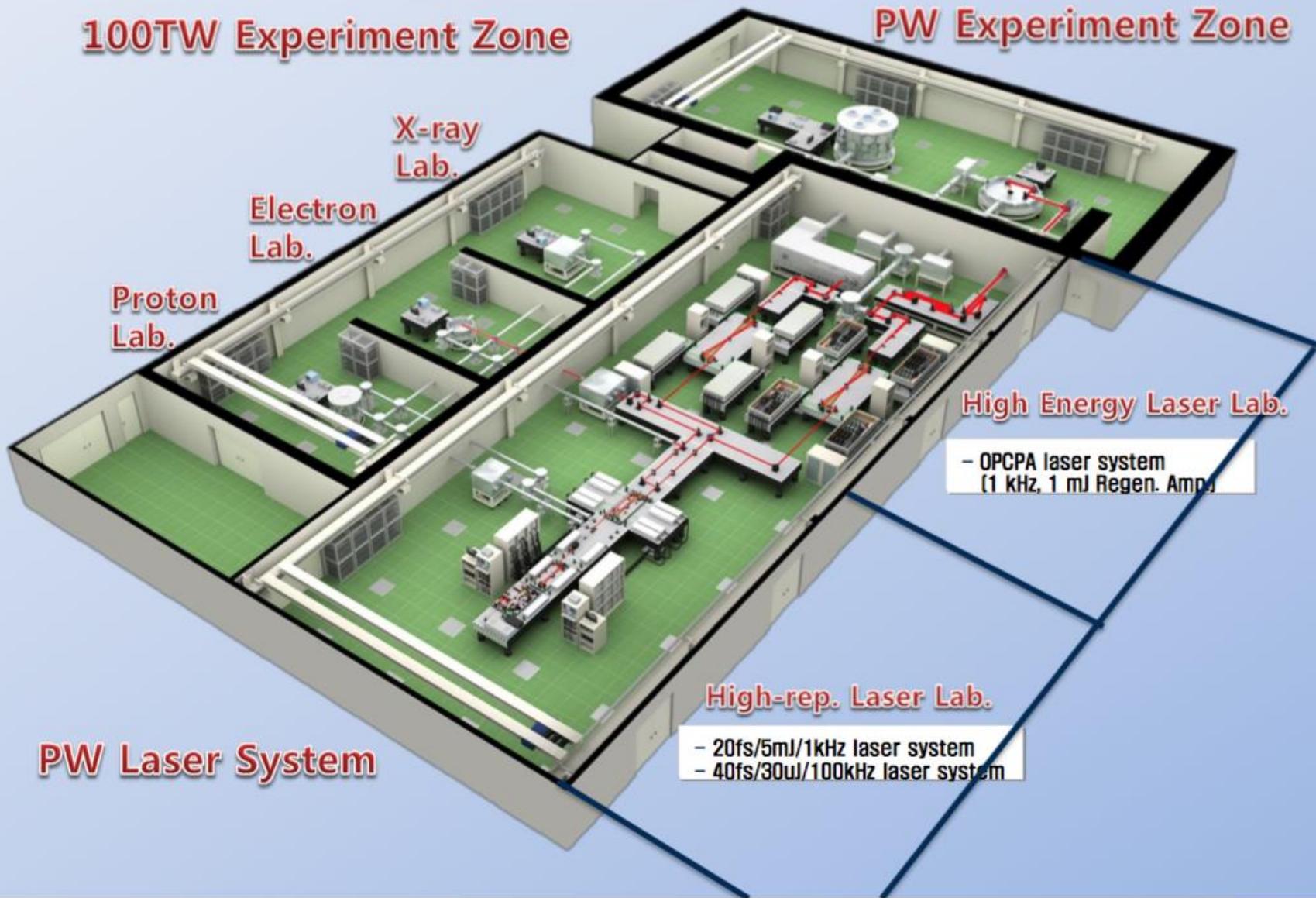
- the total peak power of all the CPA systems operating today is ~11.5 PW
- by the end of 2015 planned CPA projects will bring the total to ~127 PWs
- these CPA projects represent ~\$4.3B of effort by ~1600 people (no NIF or LMJ)
- these estimates do not include Exawatt scale projects currently being planned

National user facility for the user in femto science and technology



Laser systems in UQBF

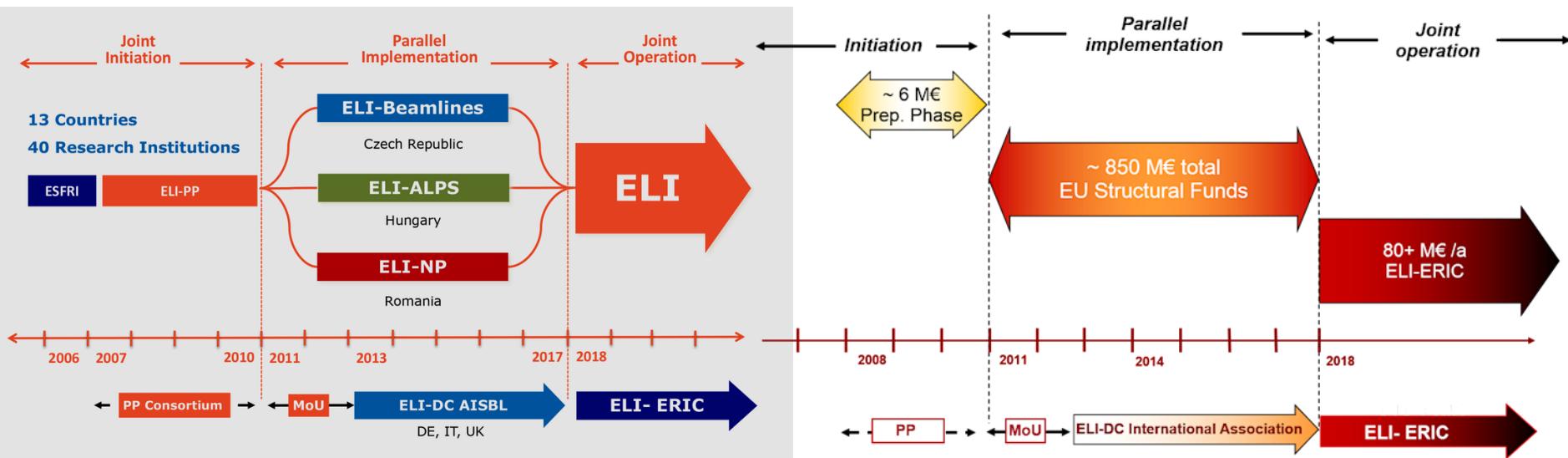
- Low-power laser (< 1 TW) : Pulse width (20~100fs), pulse energy (nJ~mJ), repetition rate (10, 1kHz, etc)
- Mid-power laser (< 100 TW) : Pulse width (30fs~10ps), pulse energy (~3J), repetition rate (10Hz)
- High power laser (PW) : Pulse width (30fs~10ps), pulse energy(~30J), repetition rate (0.1Hz)
- The component of UQBF (10,257.9 m²): Research building, conference hall, seminar room and guest house



ELI-The most powerful laser in future

THE EXTREME LIGHT INFRASTRUCTURE

A distributed pan-European laser user facility open to the world

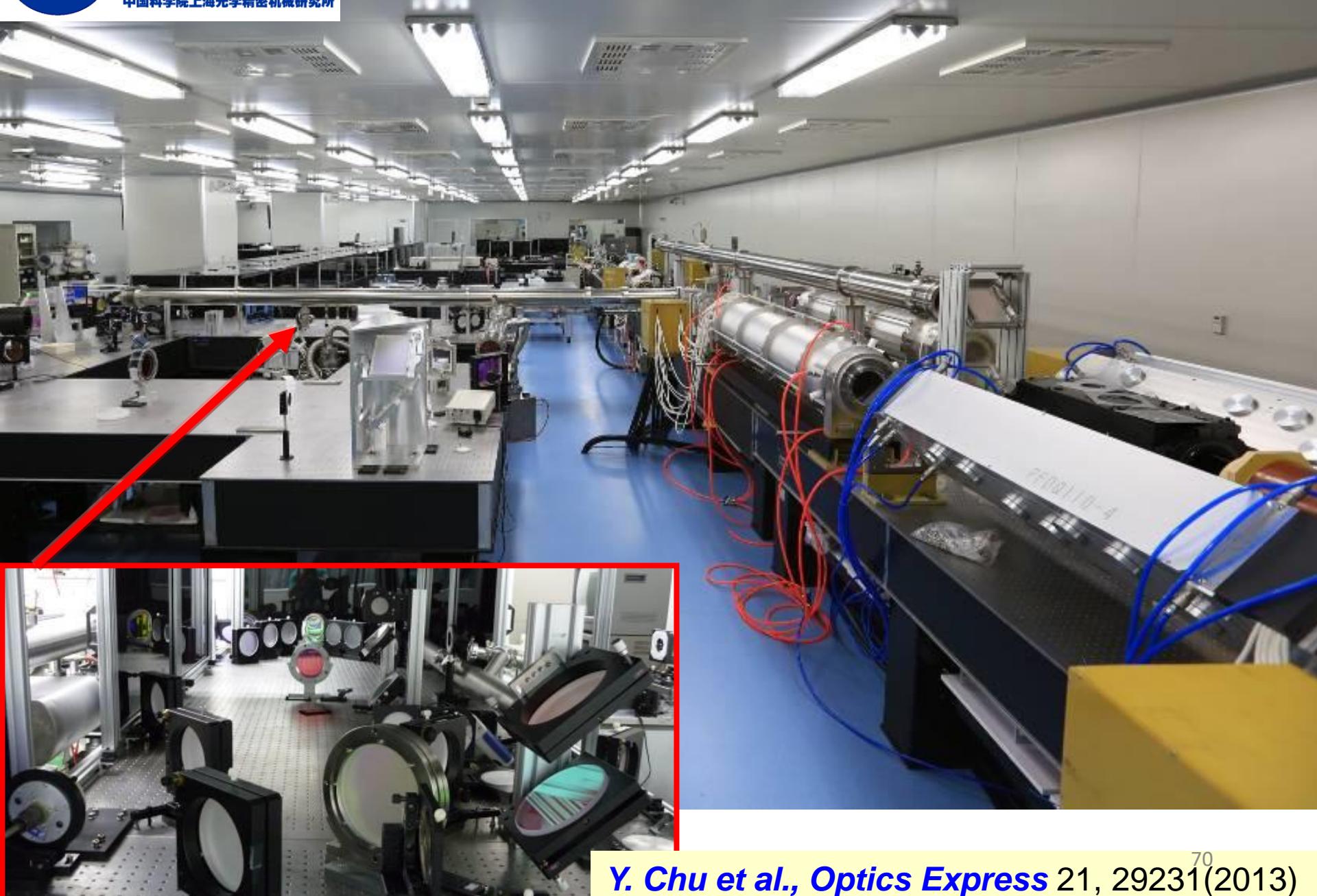


ELI-NP Facility



2 lasers, 10 PW each

The 2PW laser facility in 2013





- Four-pass Ti:Sapphire Amp.-I

- Ti:Sapphire: $\Phi 80$
- E_{pump} : 60J
- E_{injected} : 3.0J
- E_{output} : 28J-35J

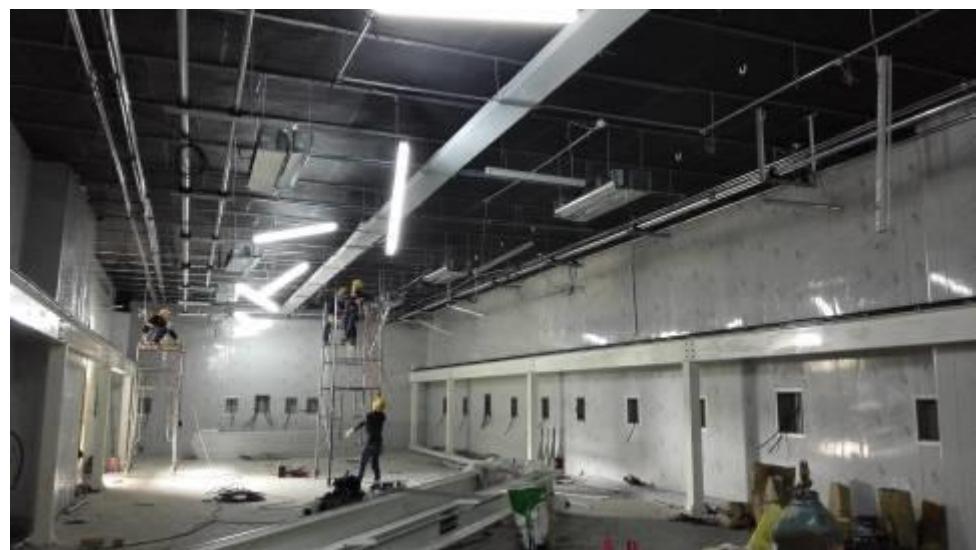
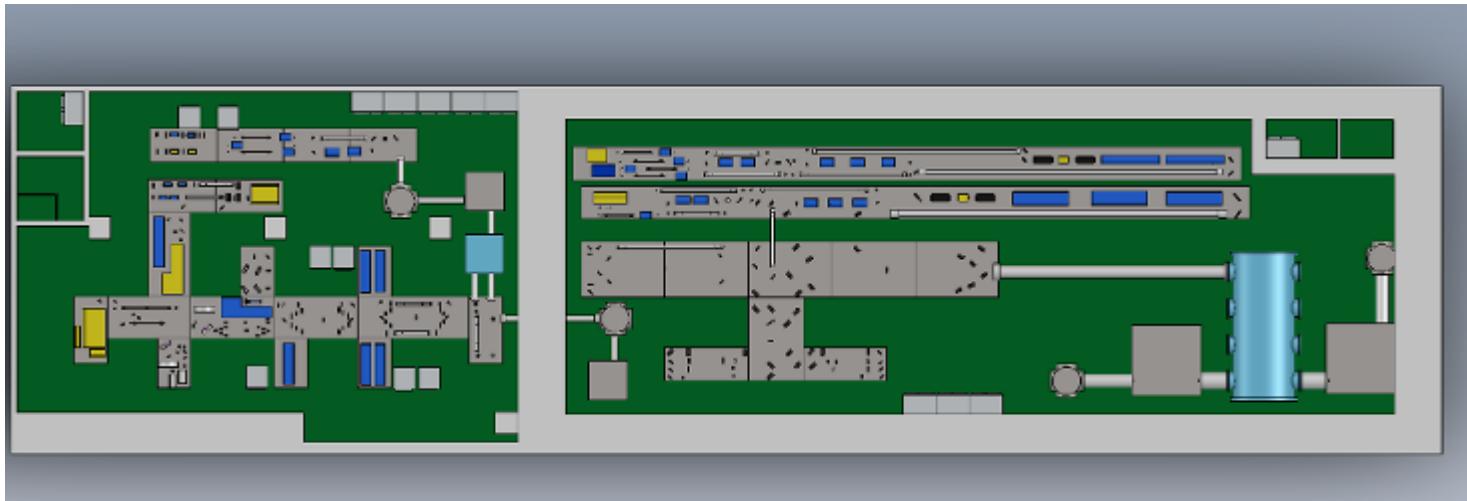


- Four-pass Ti:Sapphire Amp.-II

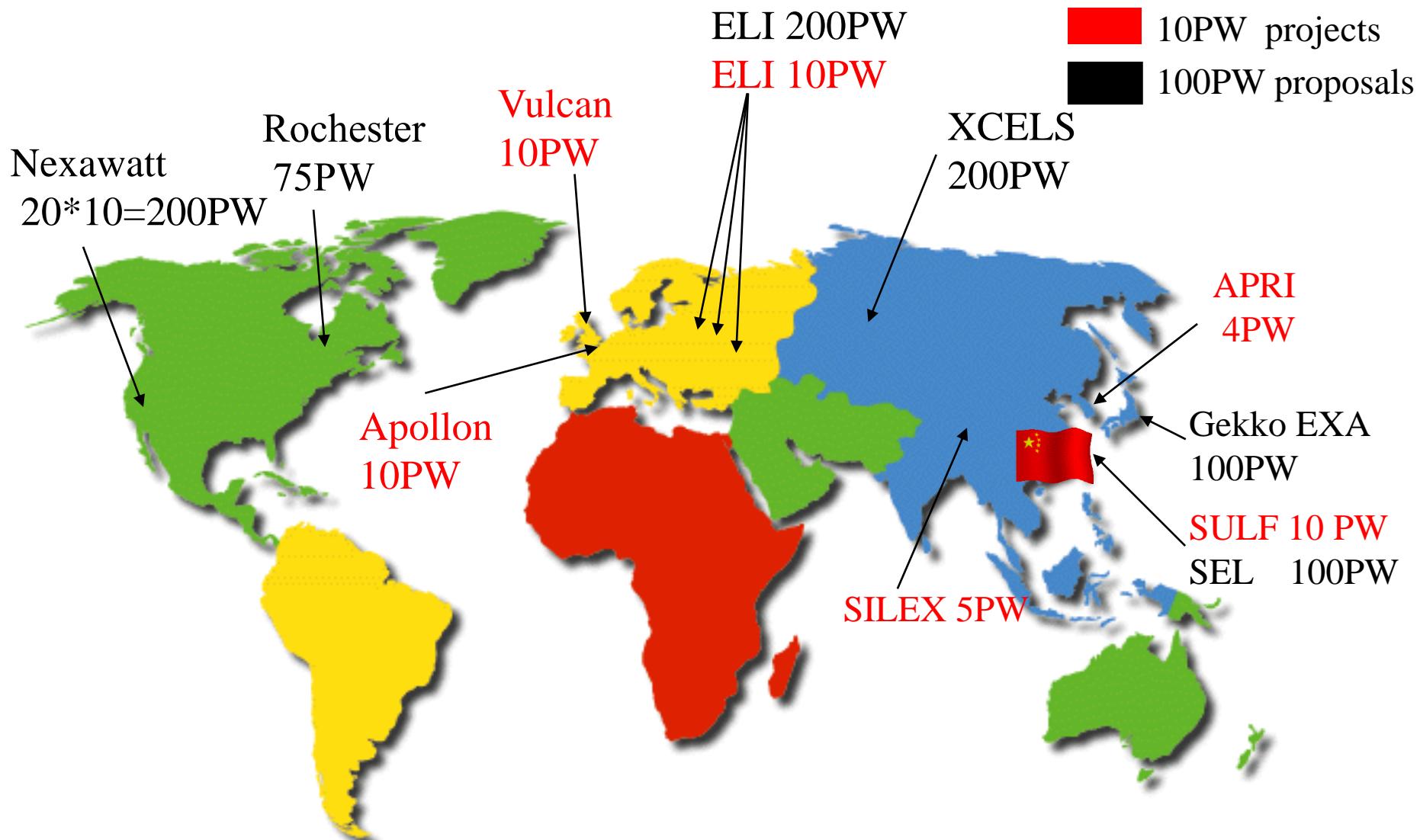
- Ti:Sapphire: $\Phi 150$
- E_{pump} : >300J
- E_{injected} : 35J
- E_{output} : 192J



The 10PW Laser Facility under construction (2015)



10PW-100PW laser projects and proposals



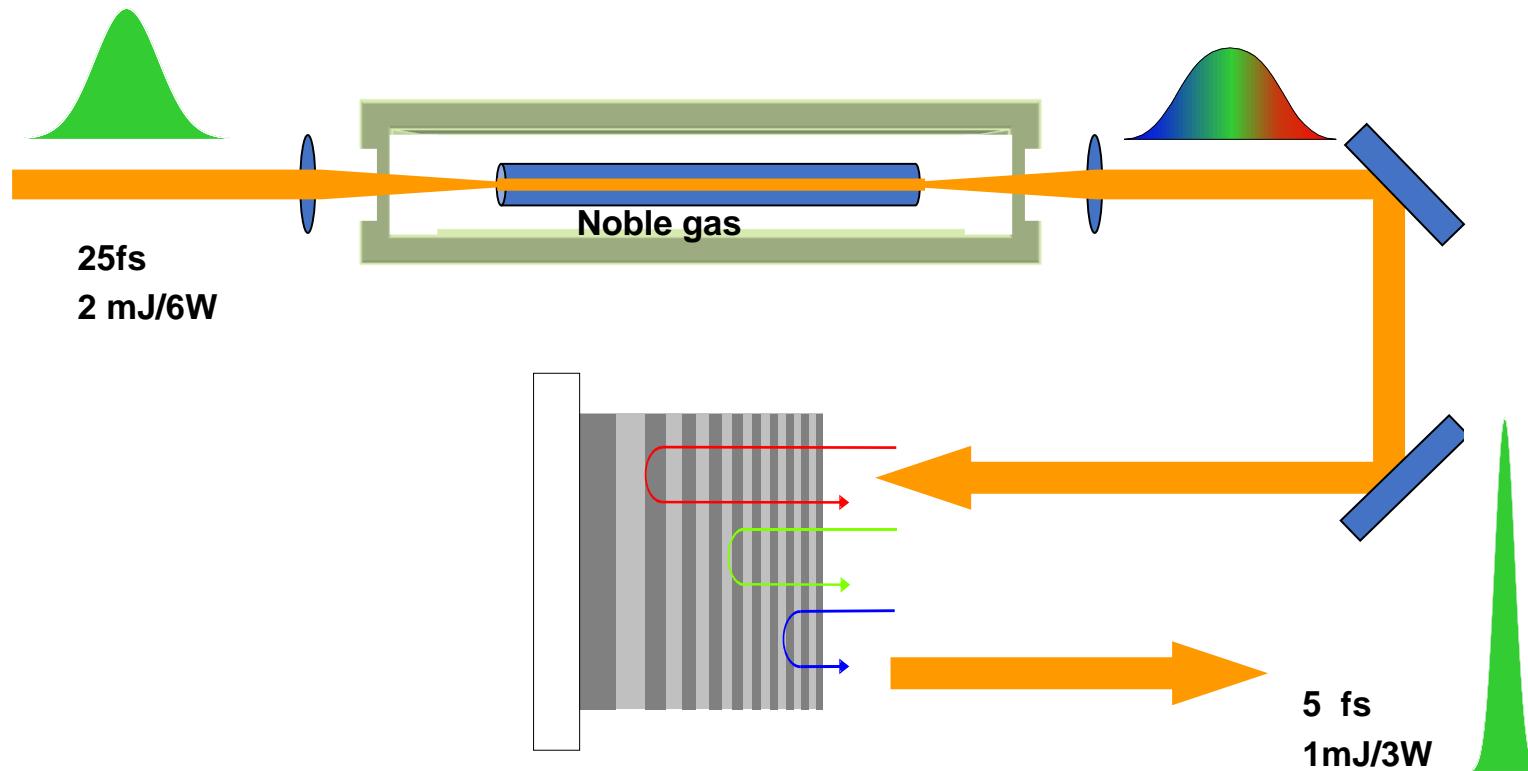
In 2016 SIOM has produced 5.3PW laser pulses

Science 355, 785 (2017)
Opt. Express 25, 5169(2017)

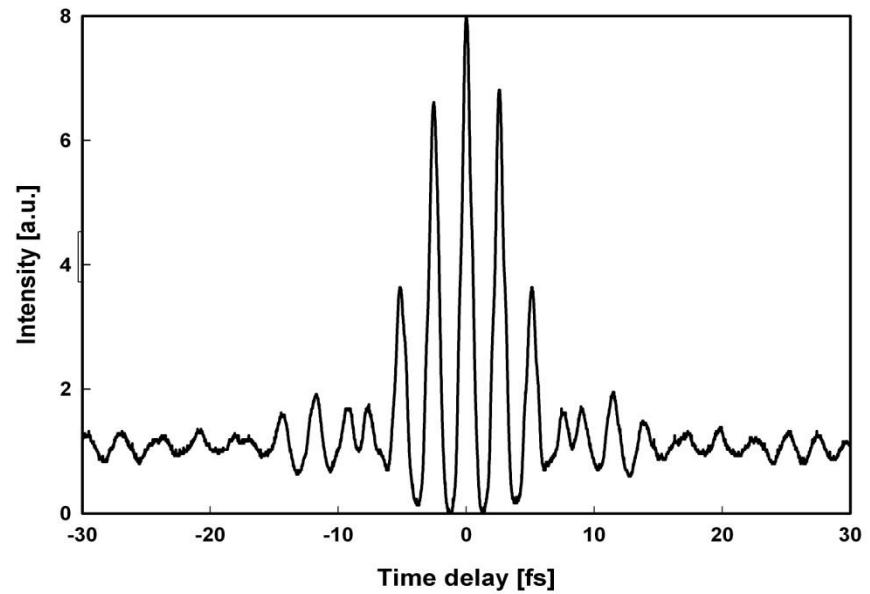
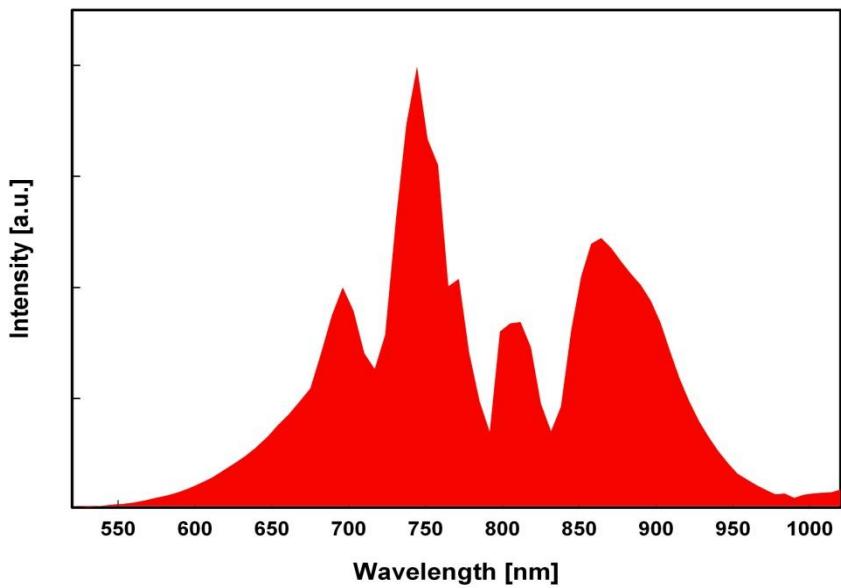
Outline

- General Introduction
- Ultrahigh Intensity Laser-Toward multi-PW power
 - ◆ Oscillator-Generation of femtosecond laser
 - ◆ Stretcher-Management of dispersion
 - ◆ Amplifier-Boost laser energy
 - ◆ Compressor-compensate dispersion for high peak power
 - ◆ Enhancement on contrast ratio
 - ◆ Typical PW laser facilities in the world
- Ultrafast Laser-Toward Few Cycles and Attosecond Pulse
- Optical Parametric Amplifier-Toward mid-infrared range
- High average power-Toward All-Solid State Amplifier
- Acknowledgement

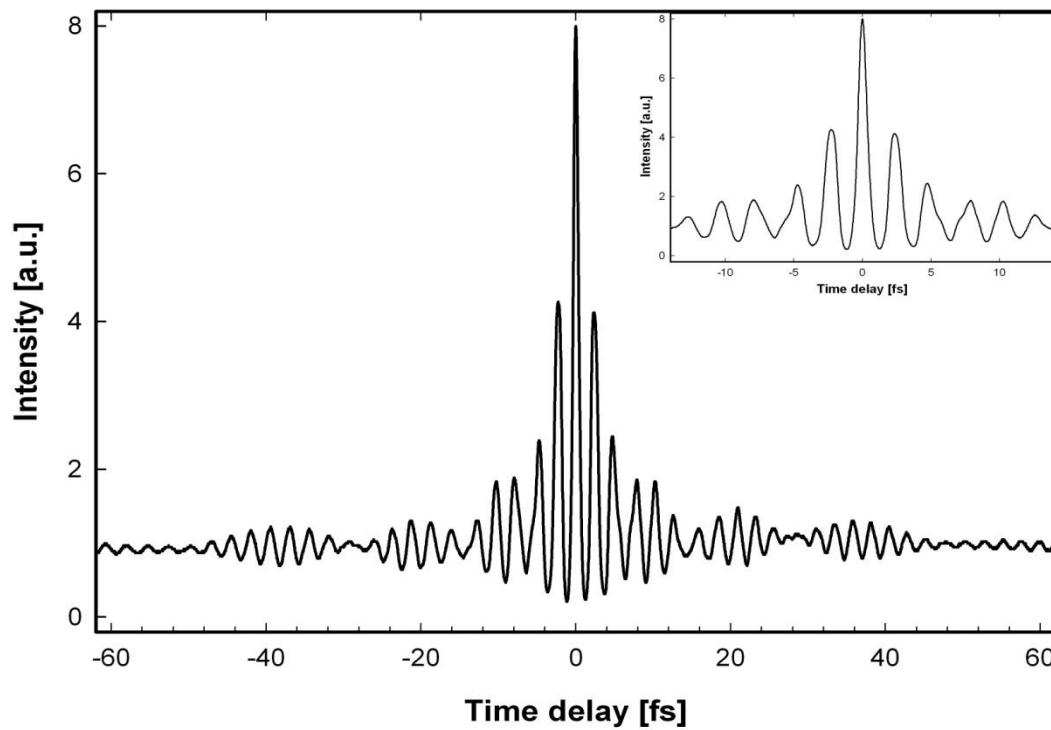
Hollow fiber spectrum broadening—Chirped mirror compressor



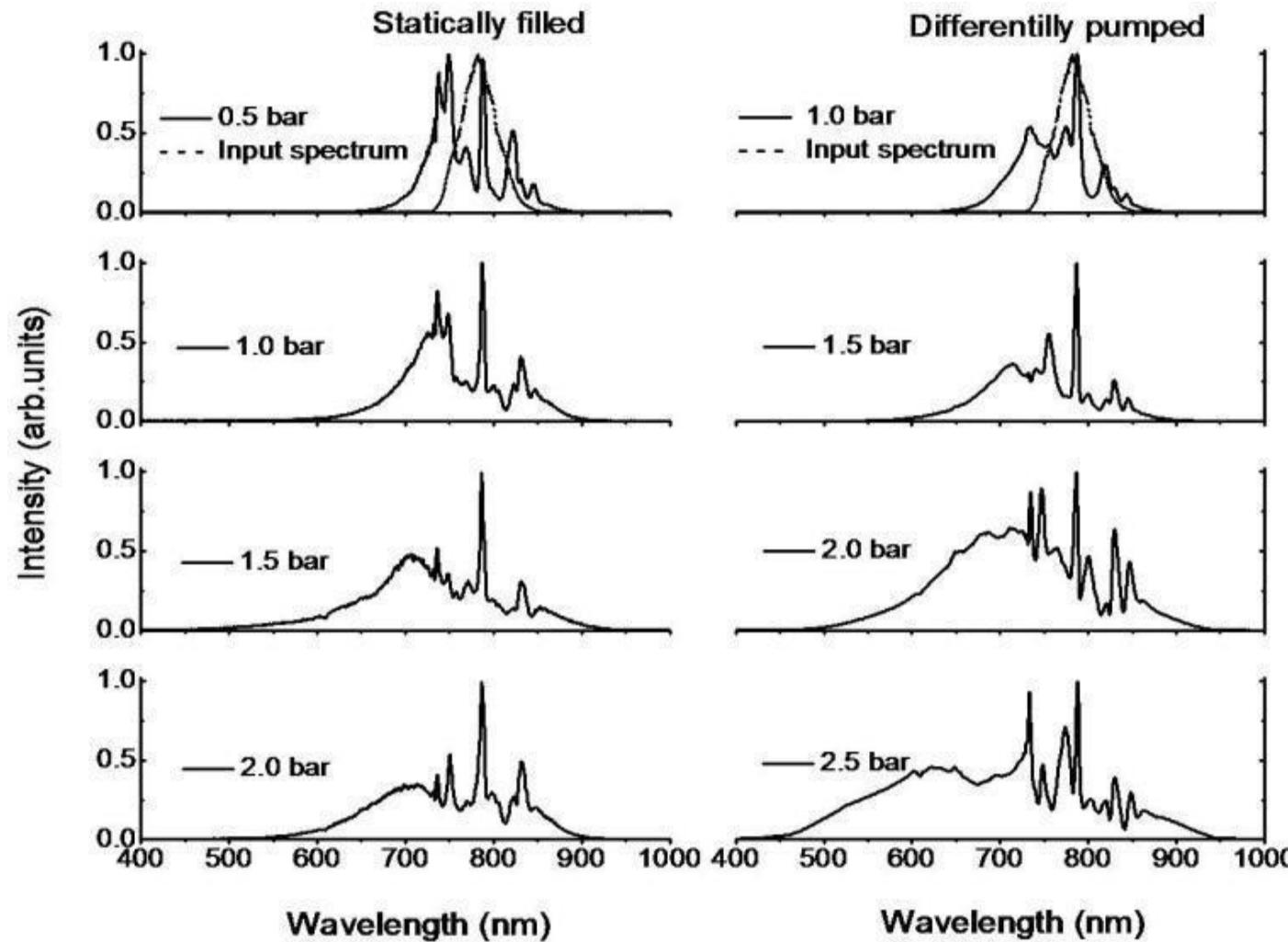
Spectrum broadening— pulse compressing



Two fringes autocorrelation

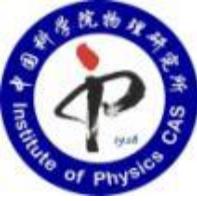


Spectral broadening in hollow fiber



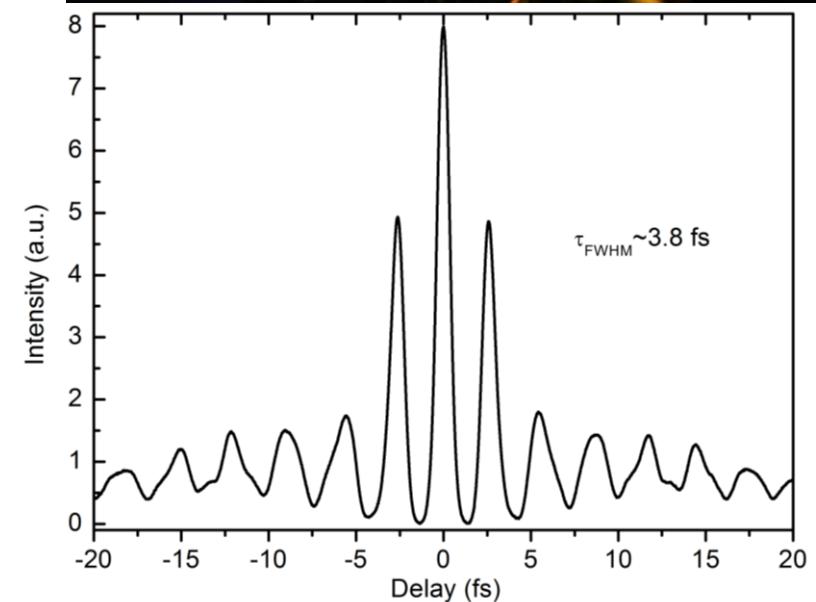
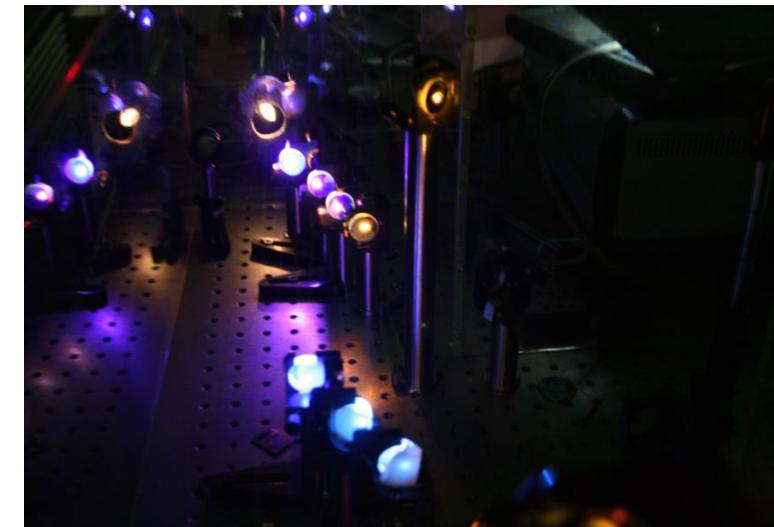
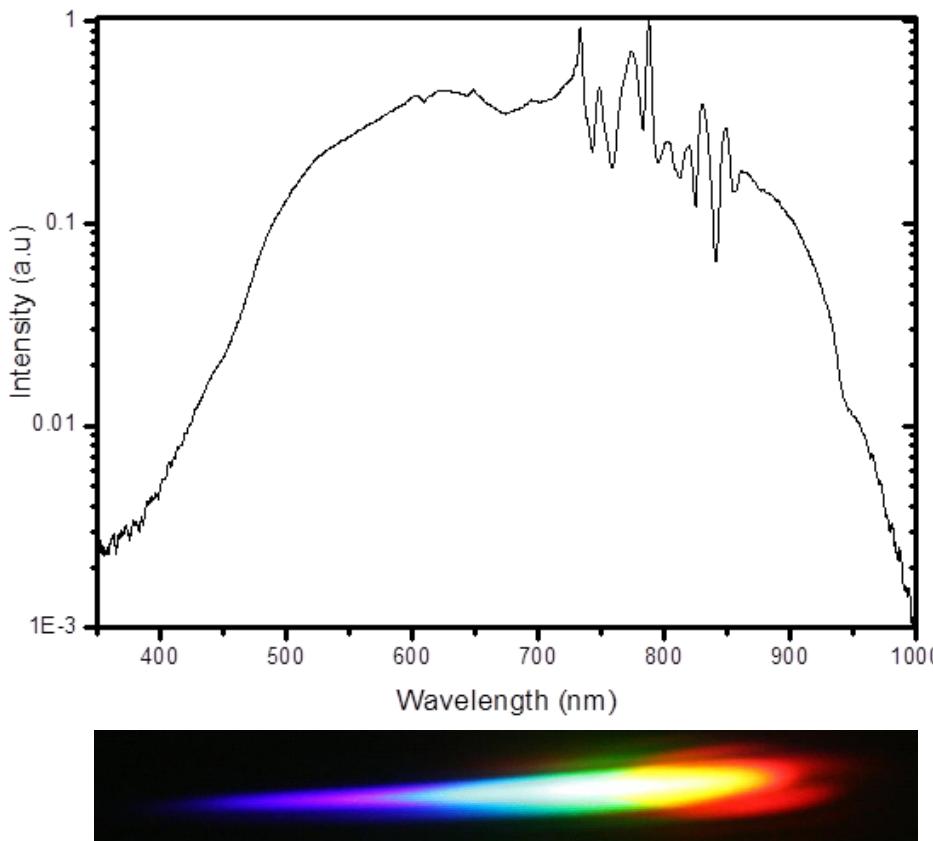
800 mW—460 mW
Transmission efficiency 57.5%

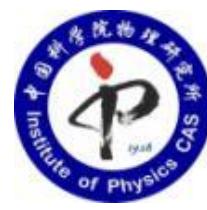
800 mW—550 mW
Transmission efficiency 68.8%



Spectrum and compressed pulse

Super continuum spectrum after hollow fiber

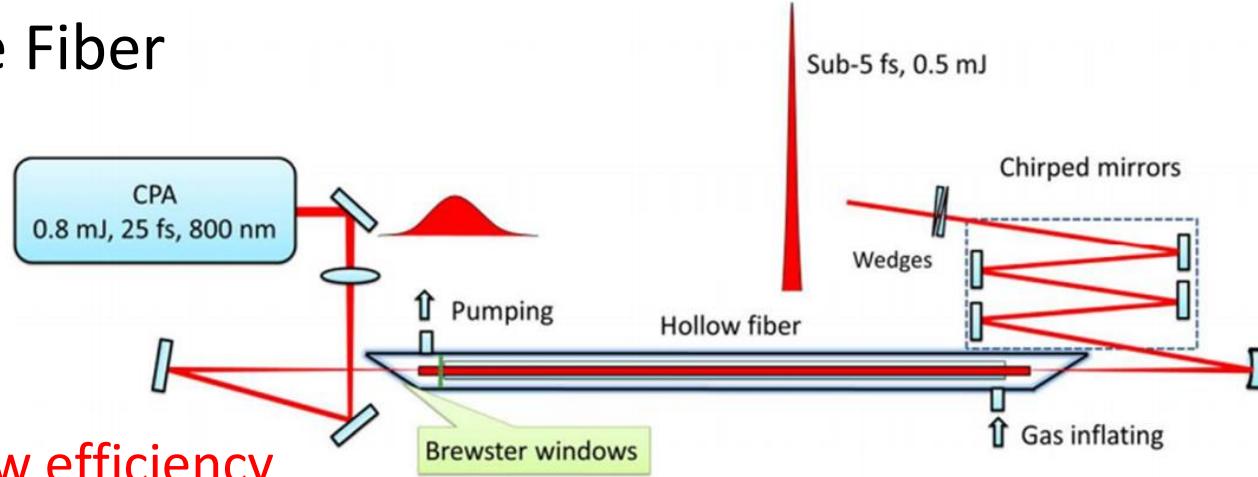




Supercontinuum Generation-Current

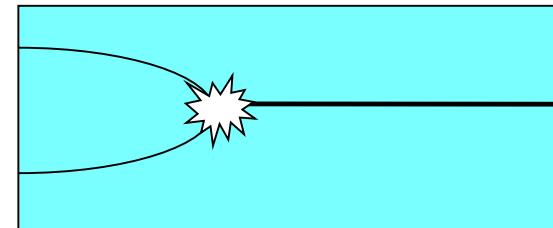
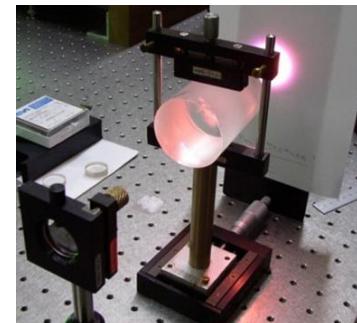
Hollow-Core Fiber

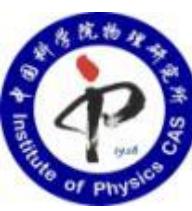
Low energy, Low efficiency
Complexity, Instability



Bulk Material

Filamentation
Material Damage





Super-continuum in Quasi-Waveguide

Nonlinear quasi-optical waveguide for ps pulses

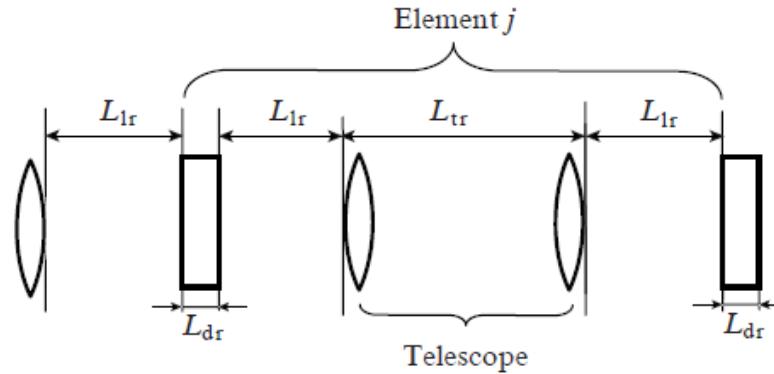
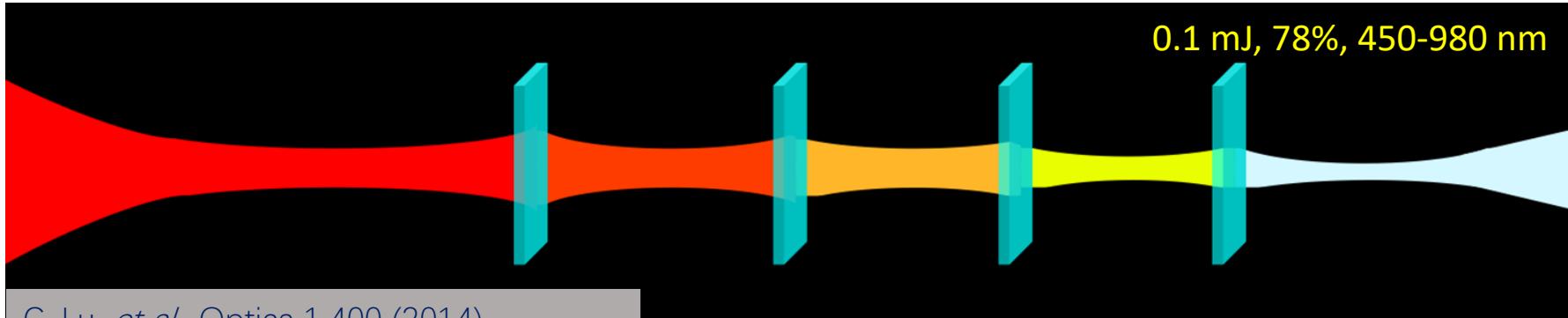
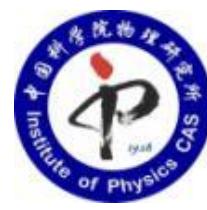


Figure 1. Fragment of a transmission line (quasi-optical waveguide) with a relay telescope.

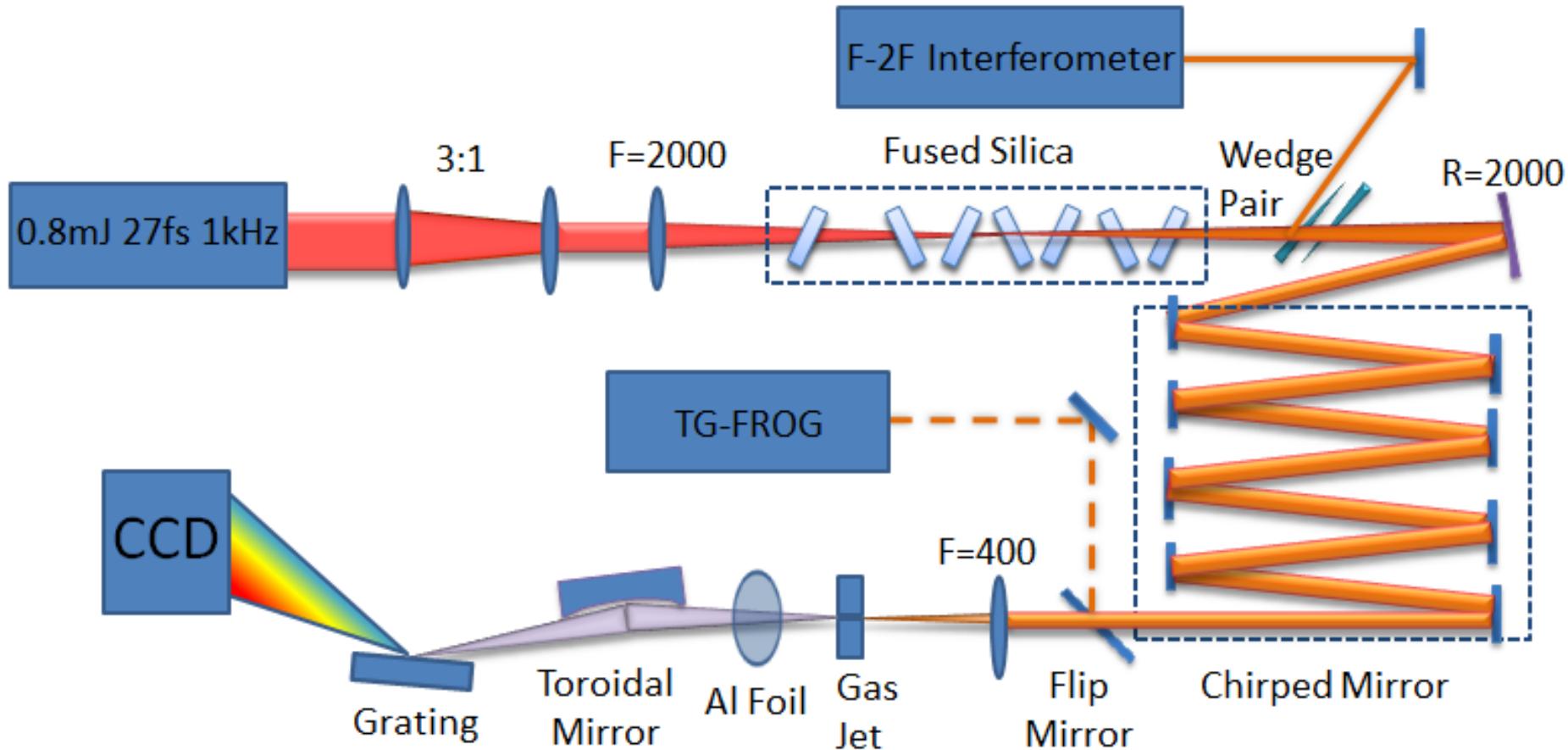
S. Vlasov, *et al.*, Quantum Electron. 42, 989 (2012)

Multiple Thin Plates

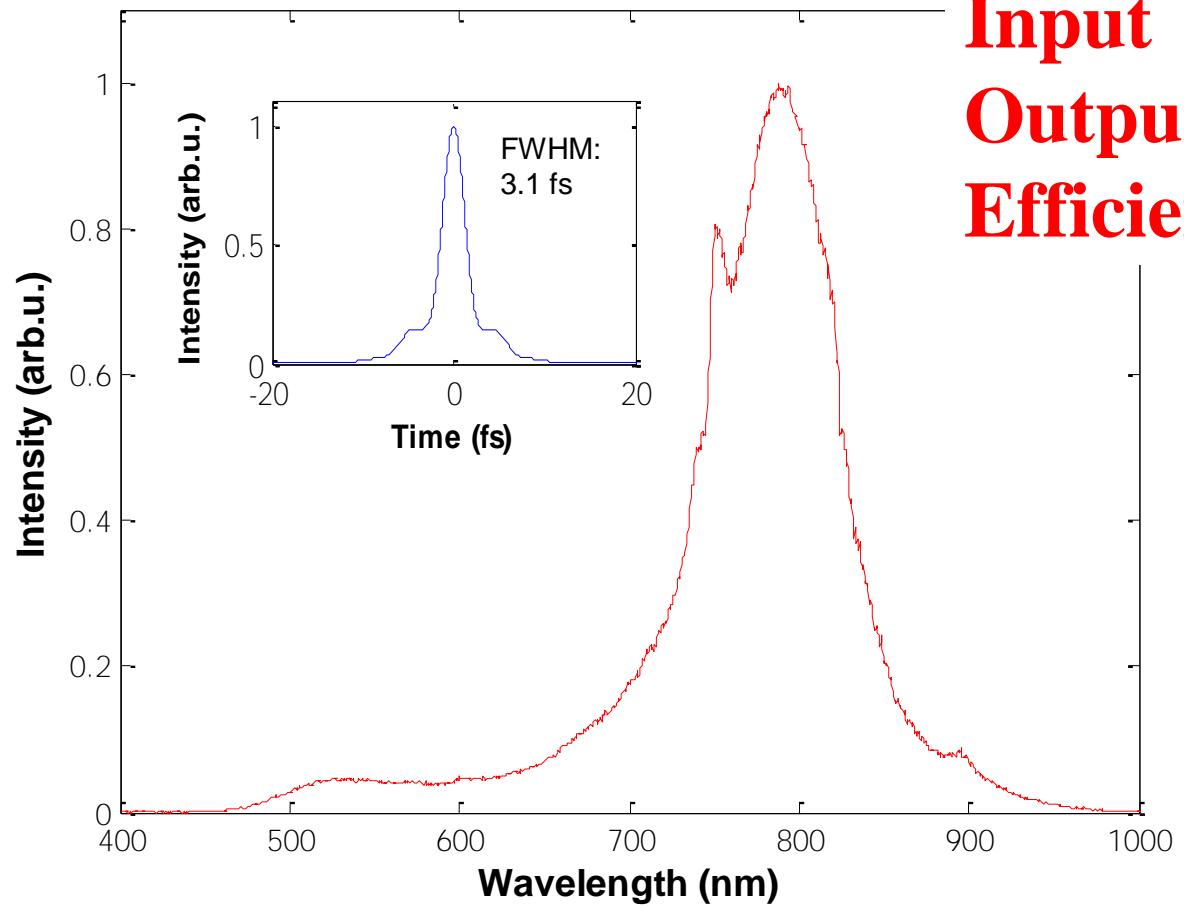




SC in solid:Generation-Setup



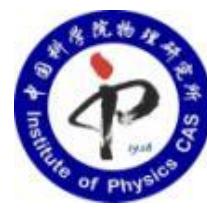
Results



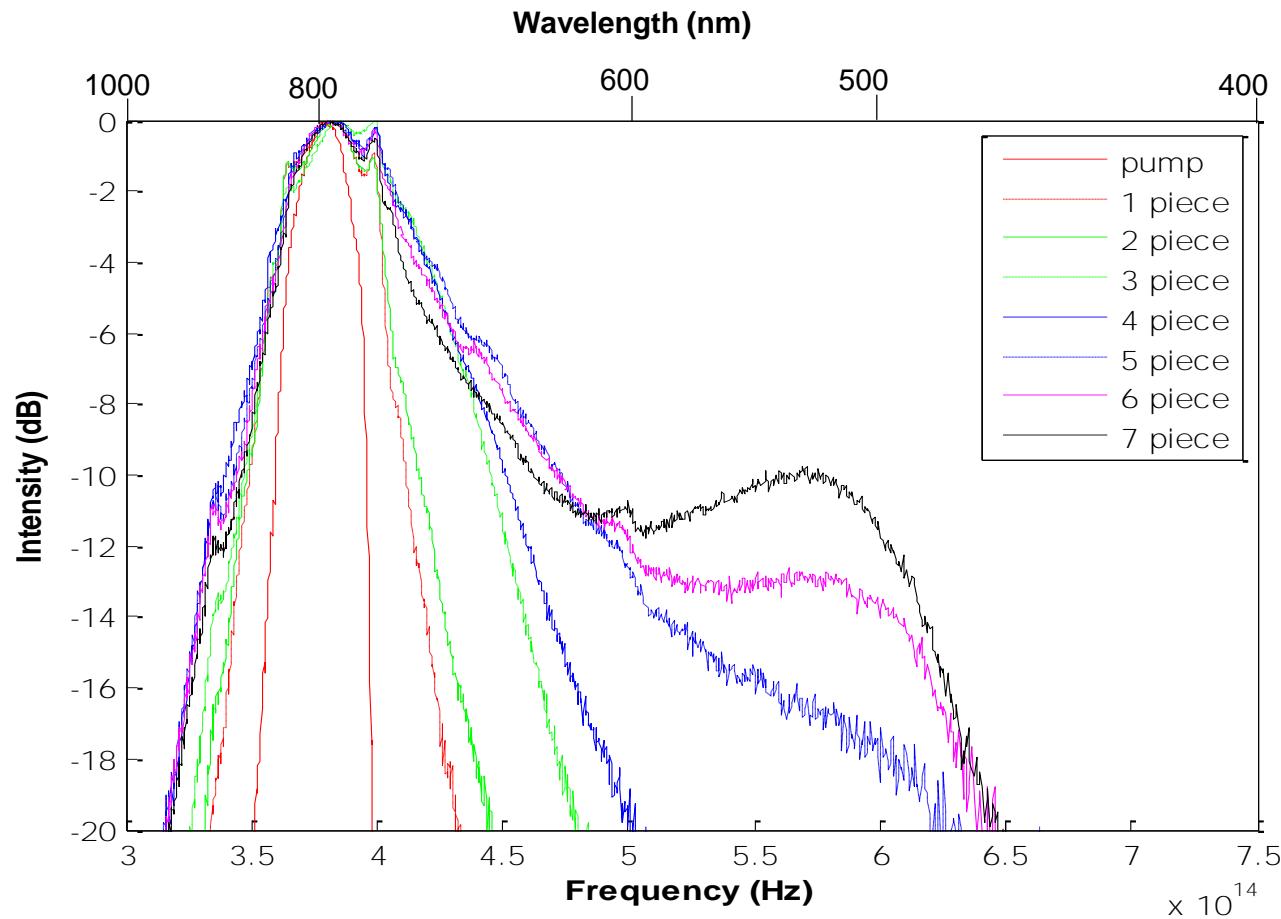
Input : 0.8mJ
Output : 0.68mJ
Efficiency: 85%



Near an octave-spanning supercontinuum (Fourier transform limit of 3.5fs)

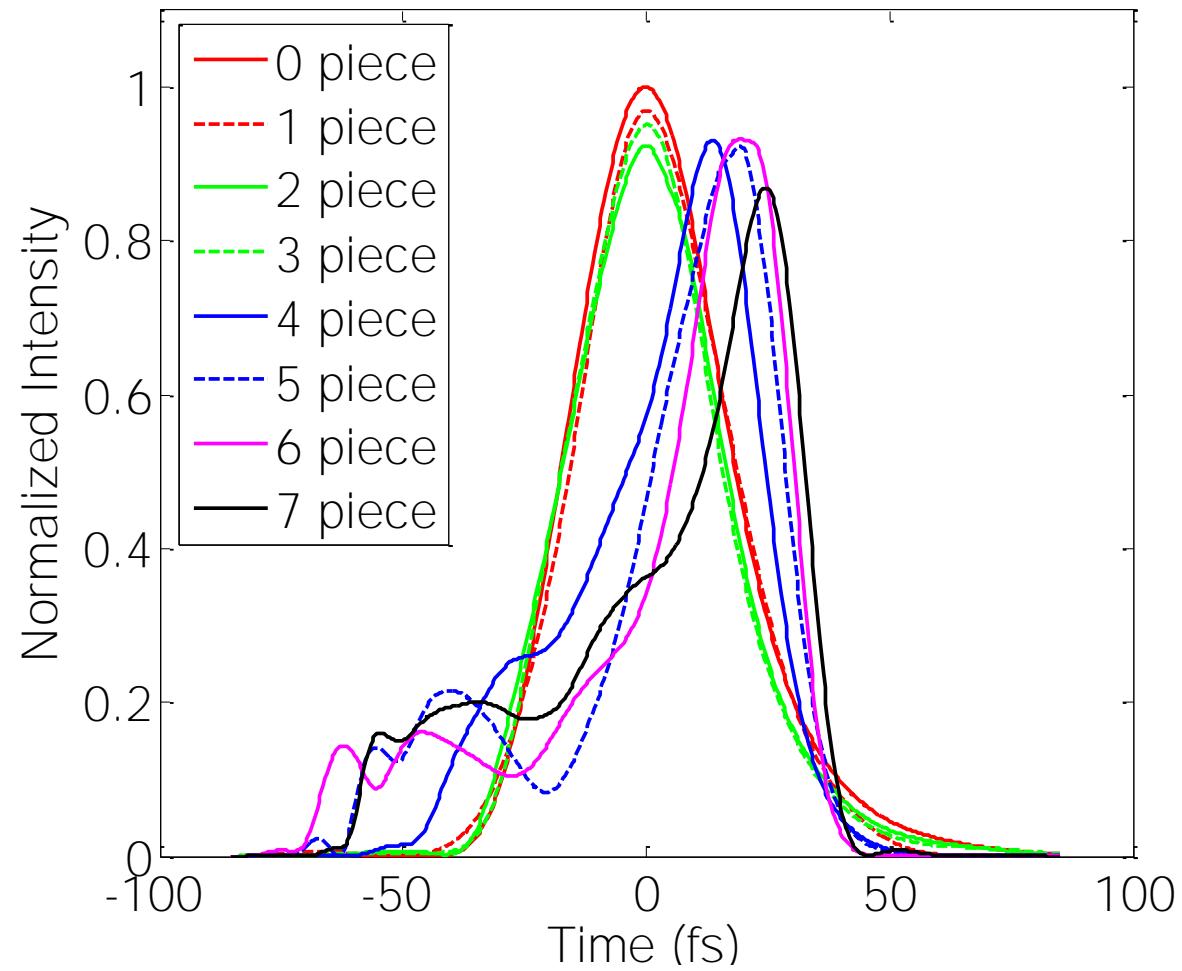


Evolution of Super-continuum

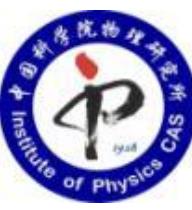


First 4 plates: symmetric broadening -- self phase modulation
Last 3 plates: asymmetric broadening -- self steepening

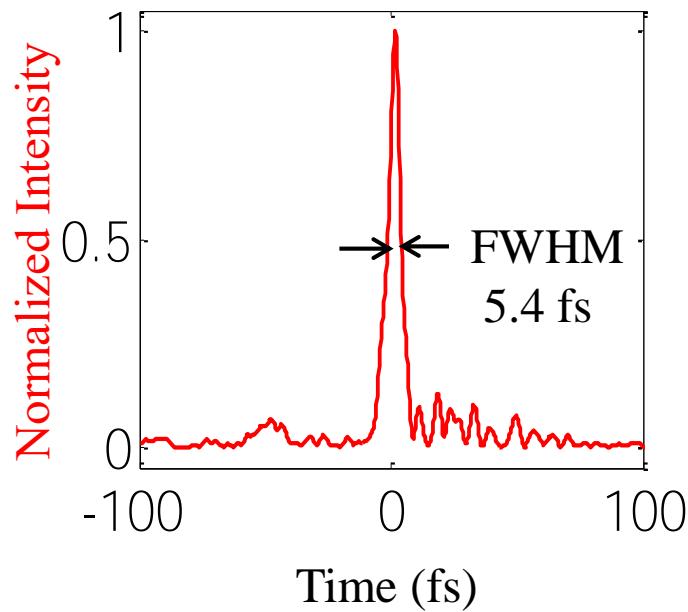
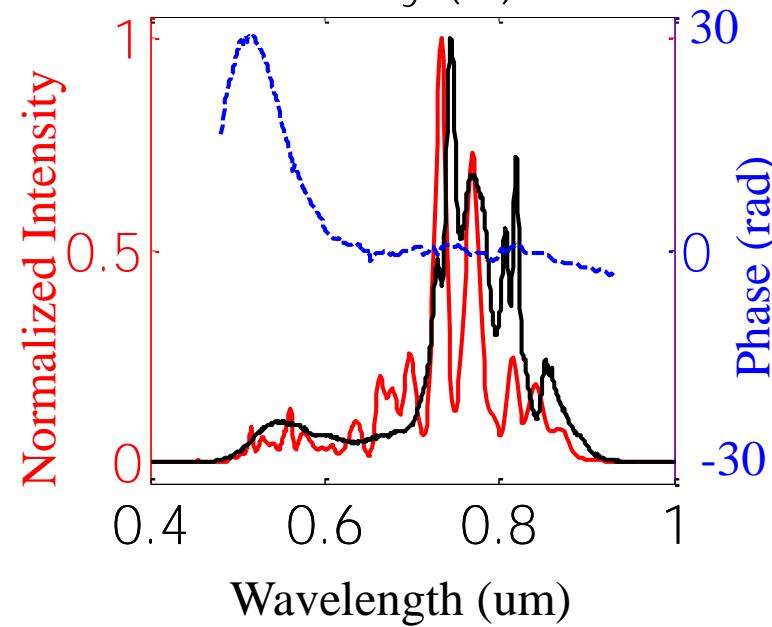
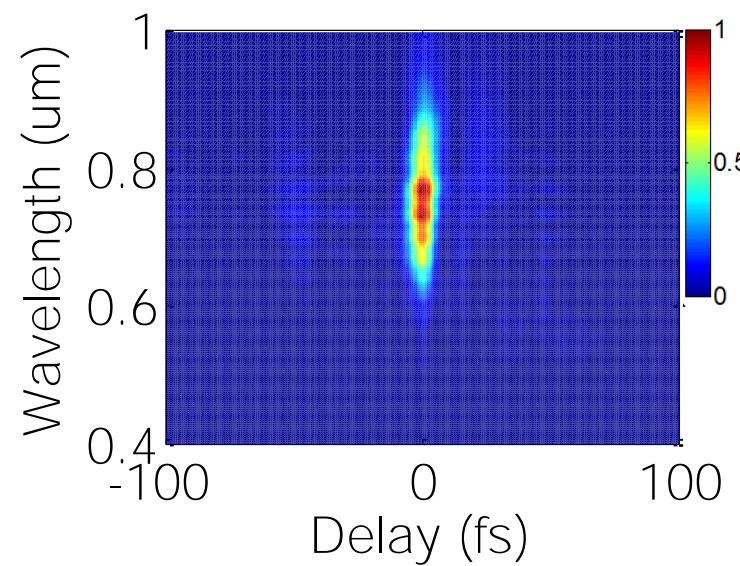
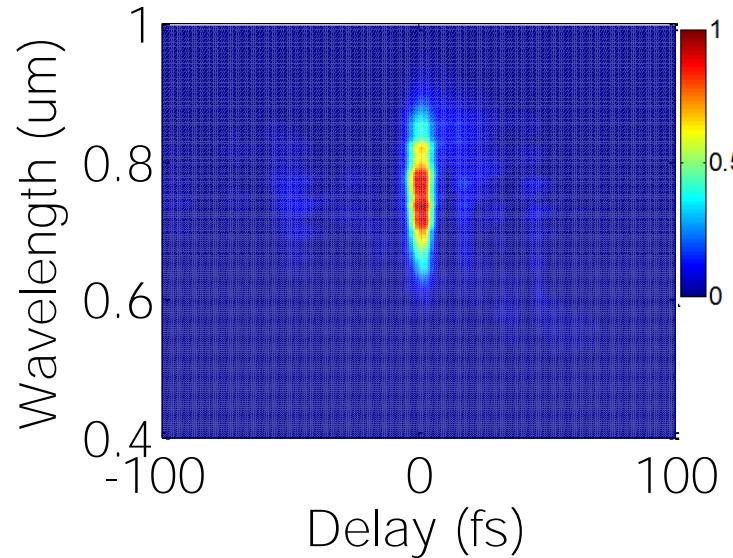
Evolution of Pulse Shape



Self steepening in the last three plates



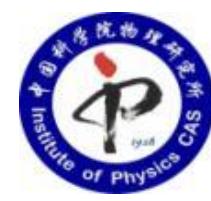
Compress to 5.4 fs by Chirp Mirrors



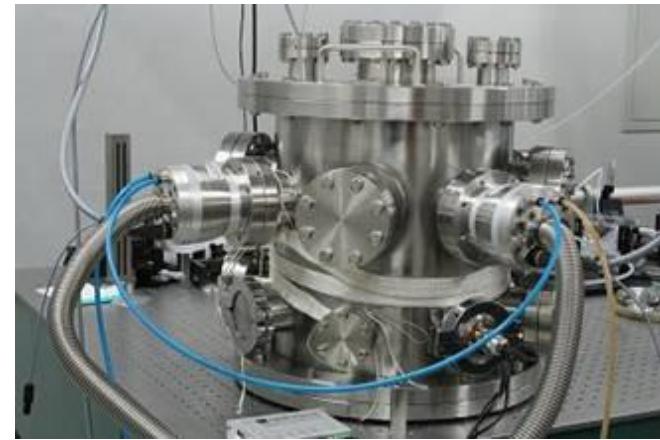
Comparison hollow fiber and Multi-plates scheme for continuum



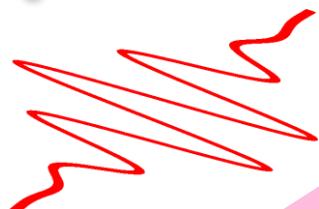
Hollow-core fiber	Fused silica plates
Core size limits the input energy	Scalable to much higher energy
Sensitive to beam pointing	Active stabilization not required
Unstable	Robust
Efficiency : 50-60%	Up to 85%



Experimental layout for HHG and attosecond pulse



few-cycle laser pulse
 $\lambda_L \approx 750 \text{ nm}$
 $T_L = 3.5 - 5 \text{ fs}$
 $W_L = 0.3 - 0.5 \text{ mJ}$



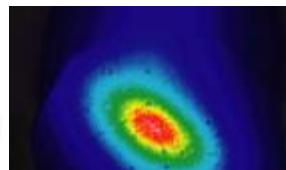
focused $I \approx 10^{15} \text{ Wcm}^{-2}$

time-of-flight electron spectrometer

xuv pulse
knocks electrons
free by the
few-cycle laser
field

attosecond pulse
soft X-ray

atomic
gas

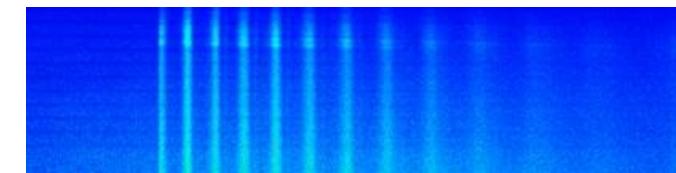
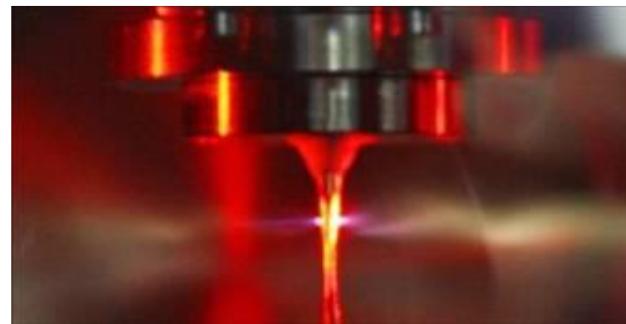


XUV spot

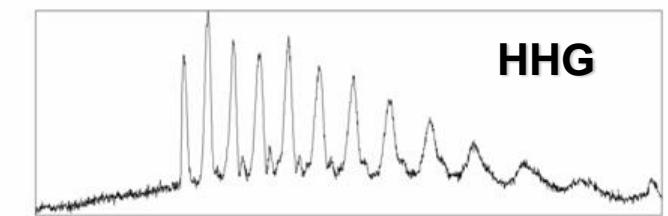
near-diffraction-limited
xuv/soft-x-ray beam



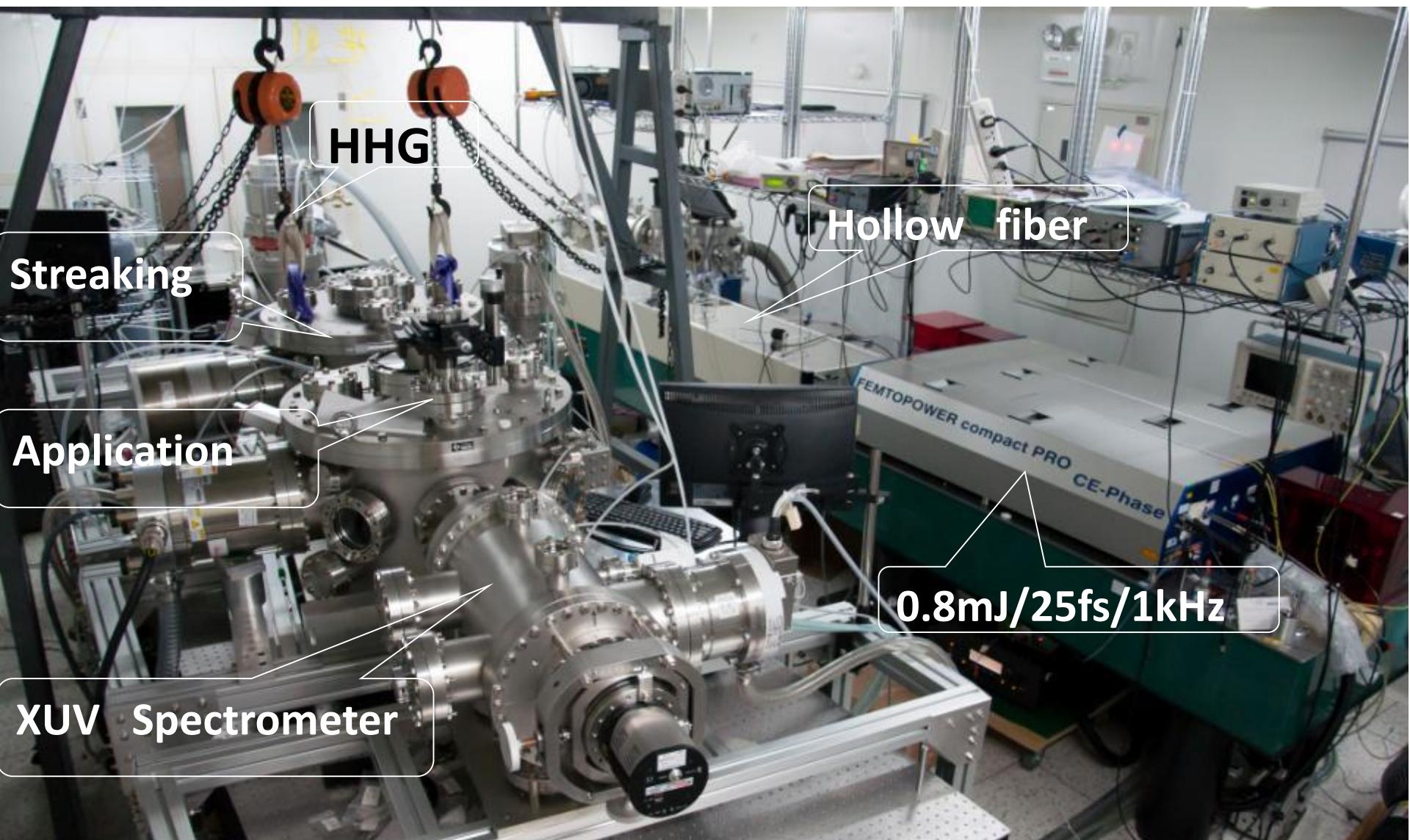
“Jitter-free”
delay stage



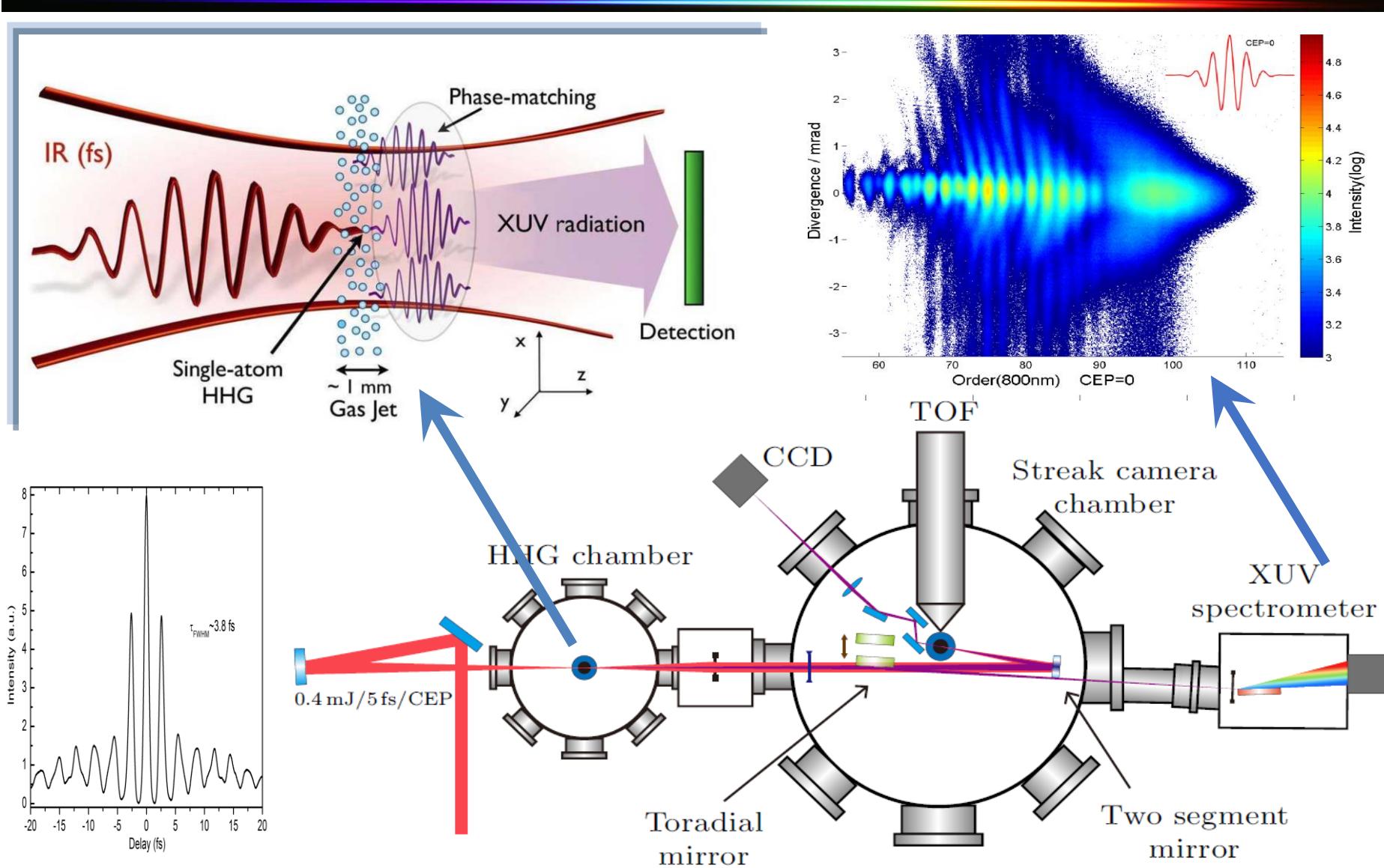
HHG



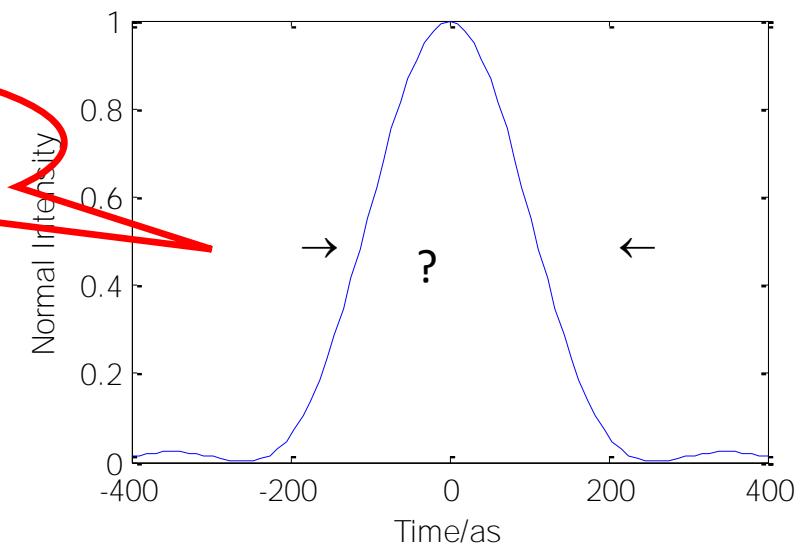
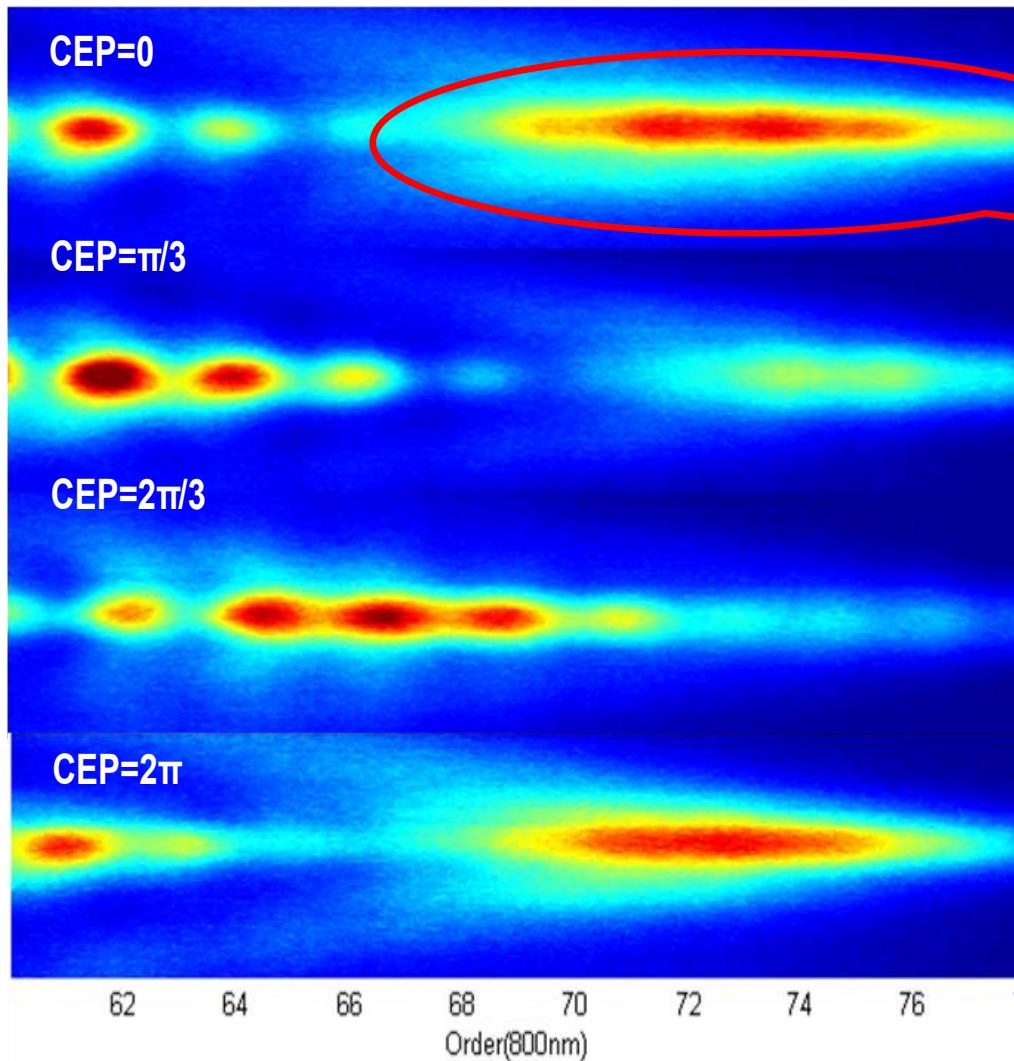
Attosecond beam facility at IoP



Attosecond beam facility at IoP



CEP controlled harmonic generation

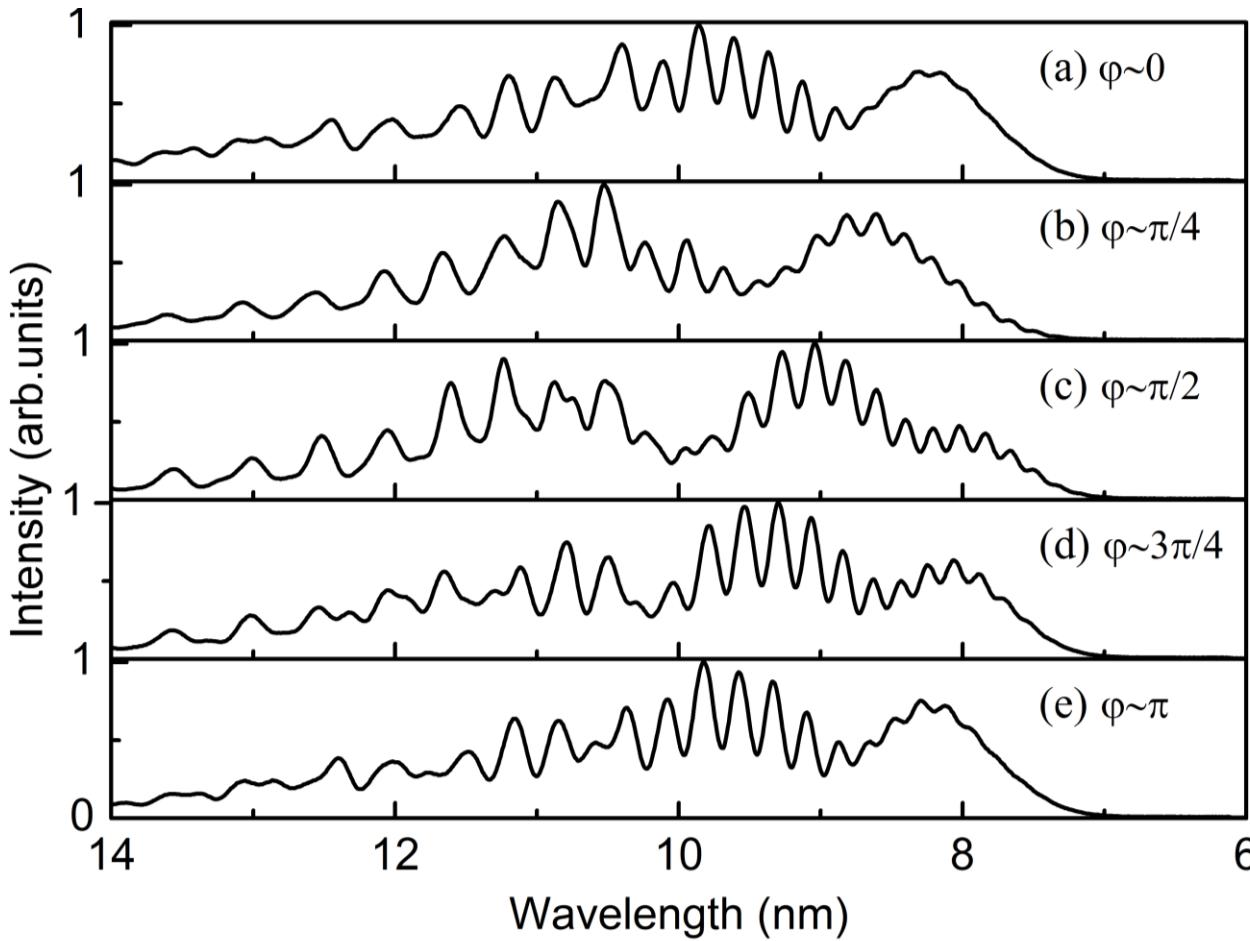


Isolated attosecond pulses

HHG with CEP:

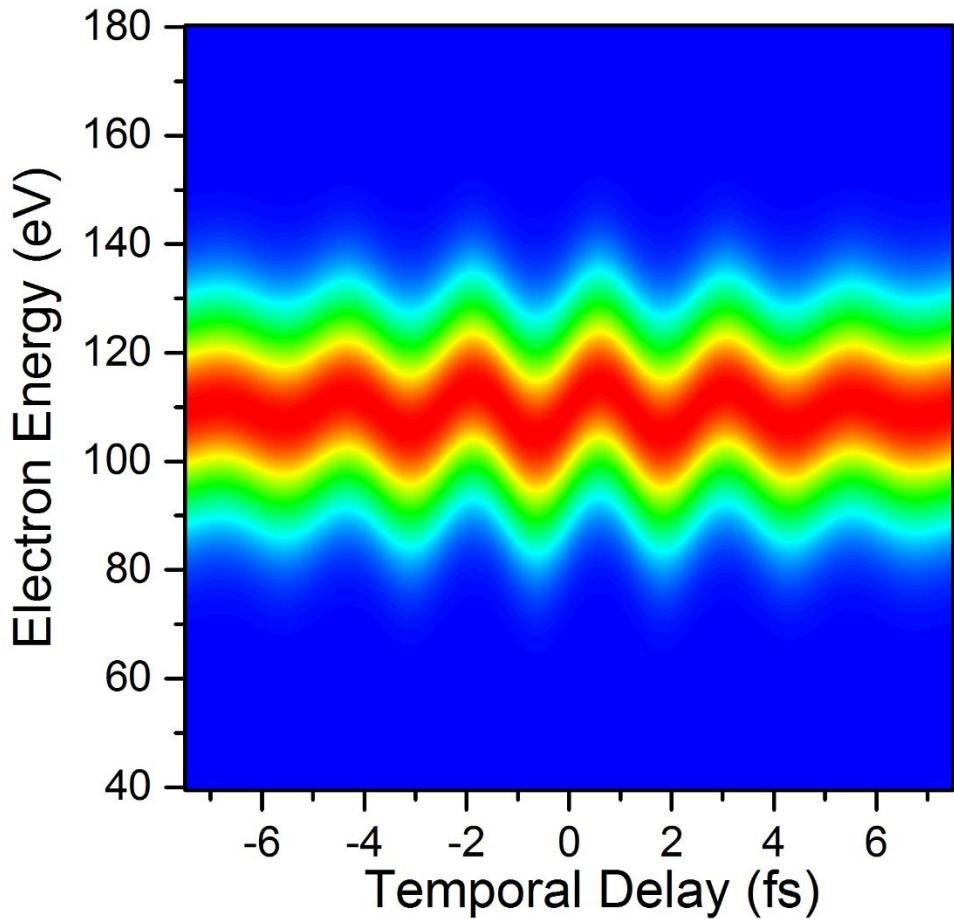
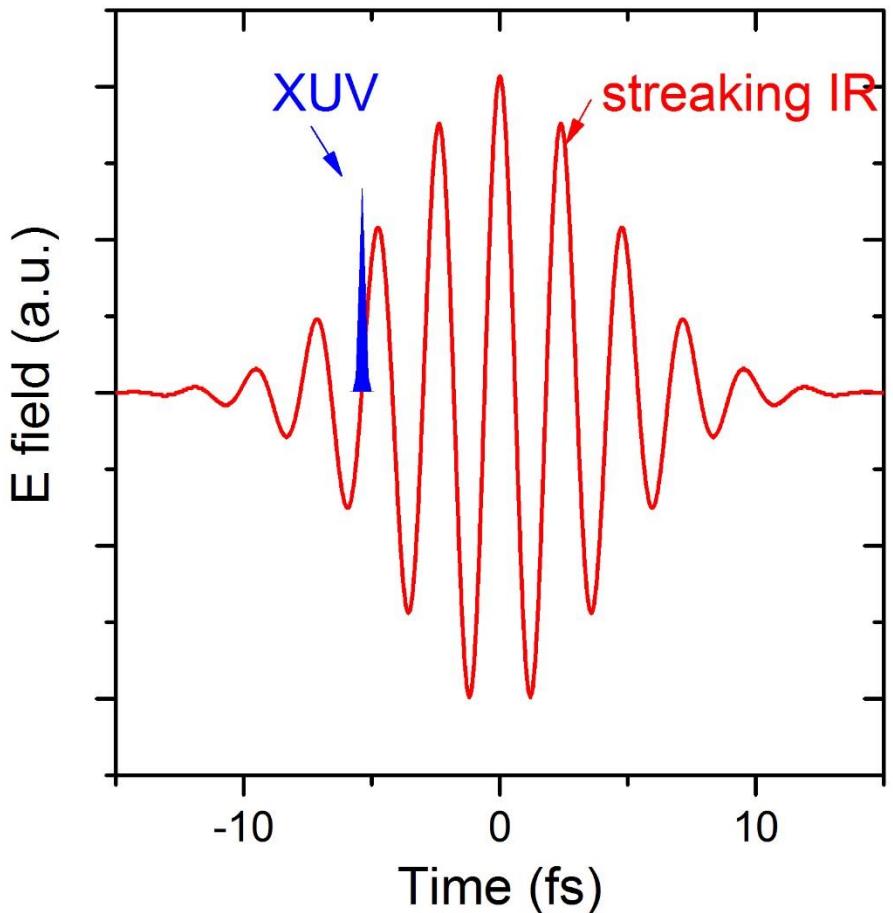
It shows the CEP can control the electrical field of attosecond light.

HHG spectrum driving by CEP locking with long temporal domain



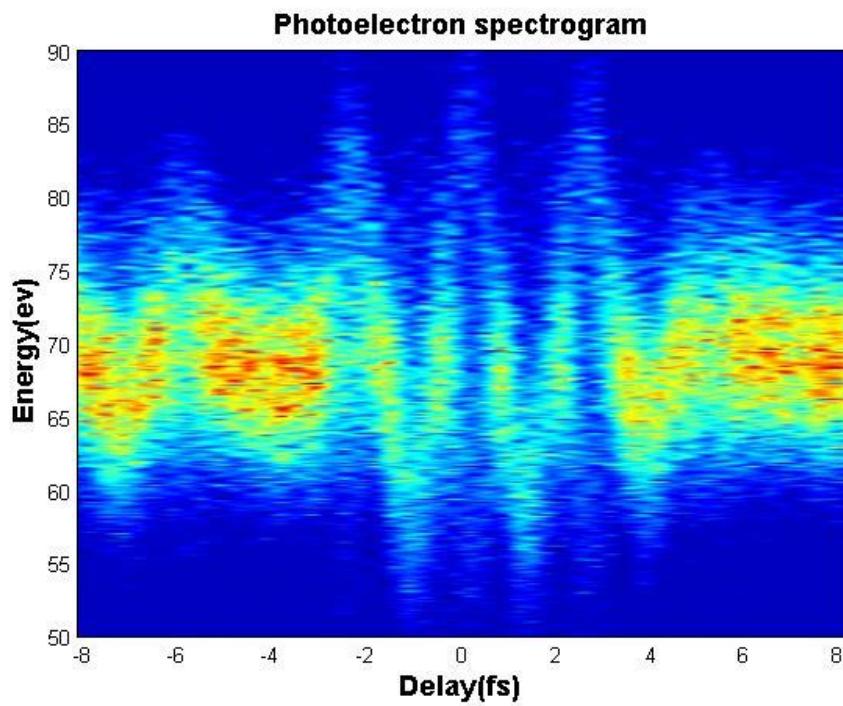
HHG vs CEP, (a)~(e) show HHG spectra with CEP change from 0 to π , step is $\pi/4$.

Attosecond Streaking Spectroscopy(ASS)

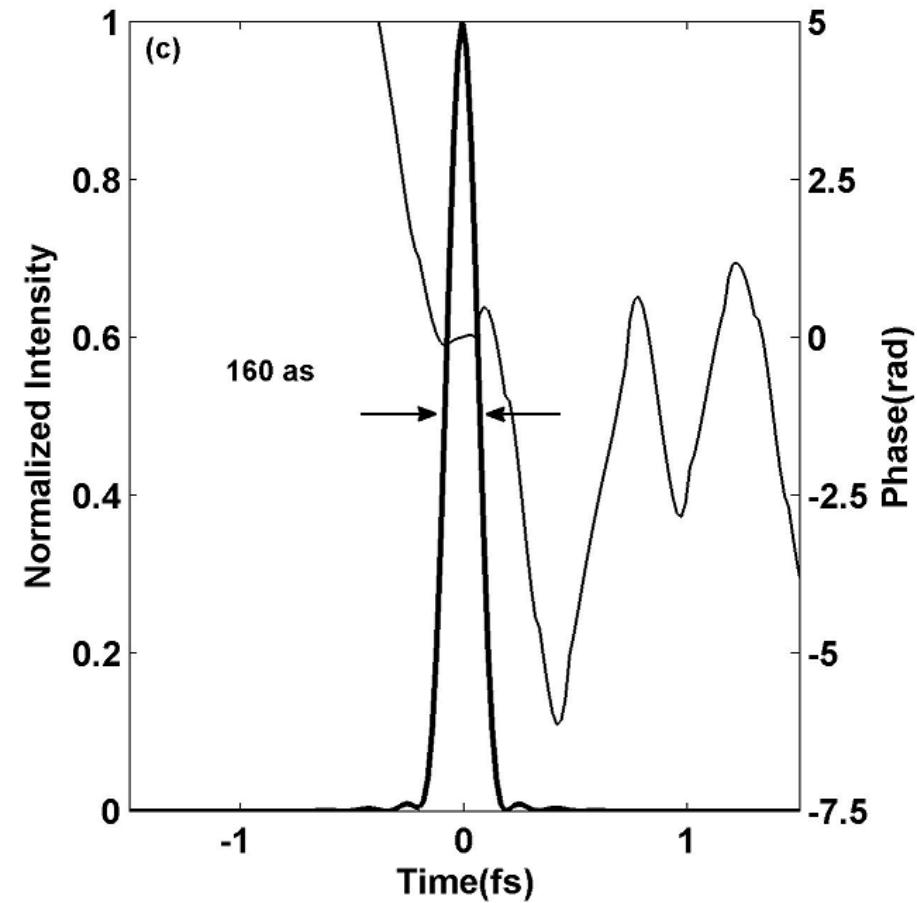


Itatani *et al.* Phys. Rev. Lett. **88**, 173903 (2002).

Generation and measurement of isolated attosecond pulse



Chin. Phys. Lett. 30, 093201(2013)
Opt. Express 21(15), pp 17498(2013)



We successfully measured the streak fringe of photoelectron spectrogram for characterizing the attosecond pulse. **This is first time to get attosecond laser in China.**

Trend in future

- ◆ Ultrahigh intensity femtosecond laser driver+GDOG — High Flux
Z. Chang et al, 200TW/5fs, PW in future, ELI
- ◆ UV femtosecond laser driver — Higher efficiency HHG, high flux,
Ming Chang Chen, Tsing-Hua University
- ◆ MID femtosecond laser driver — High cutoff eV, short pulse
T.Popmintchev et al, Science 336, 1287(2012)
- ◆ Dual wavelength laser driver — High efficiency.
E. J. Takahashi *et al.*, PRL. **104**, 233901 (2010), Nat Commun. **4**:2691 (2013)
- ◆ Solid state HHG — High efficiency,
Luu T T et al. *Nature*, 2015, **521**(7553): 498-502_{TOF}

Toward emerging science:

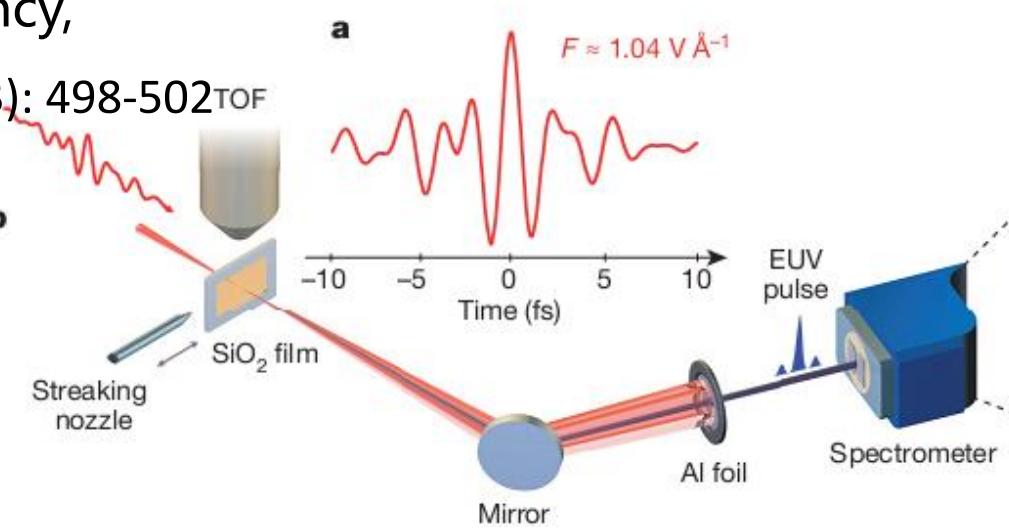
Attosecond high field physics

In future:

Higher Flux

Shorter Pulse

Shorter Wavelength



HHG and attosecond pulse driven by long wavelength laser

HHG cutoff photon energy

$$E_{\text{cutoff}} = I_p + 3.17U_p$$

$$U_p \propto I_L \lambda_L^2$$

Increase wavelength:

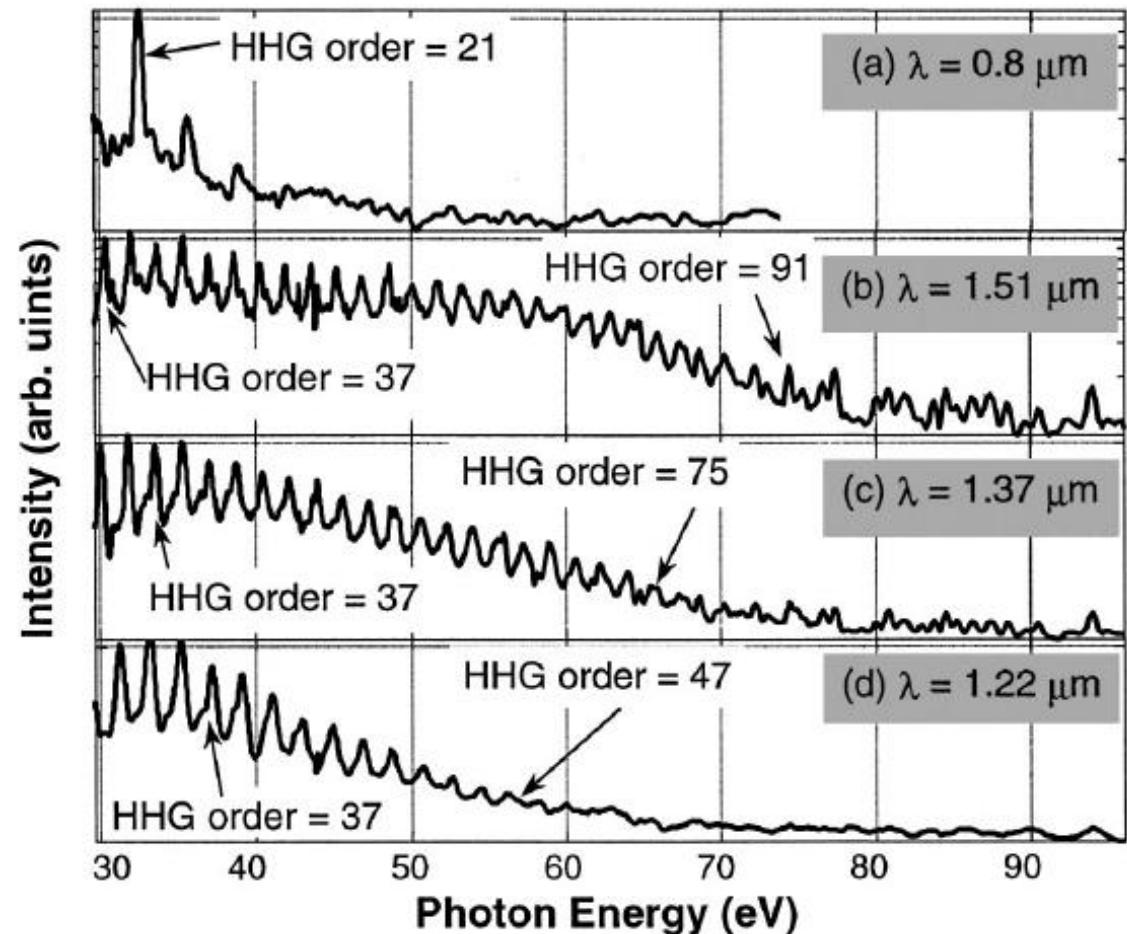
$$\lambda = 0.8 \mu\text{m} \rightarrow 1.7 \mu\text{m}$$

$$E_{\text{cutoff}} = 500 \text{ eV}$$

for

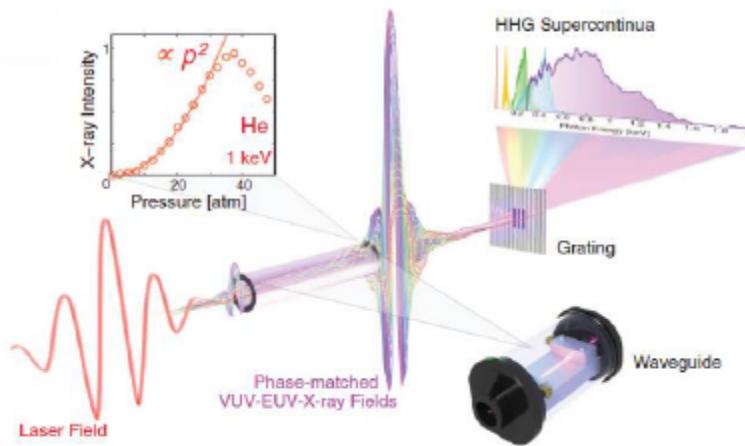
$$\lambda = 1.7 \mu\text{m}$$

$$I_L = 5 \times 10^{14} \text{ W/cm}^2$$



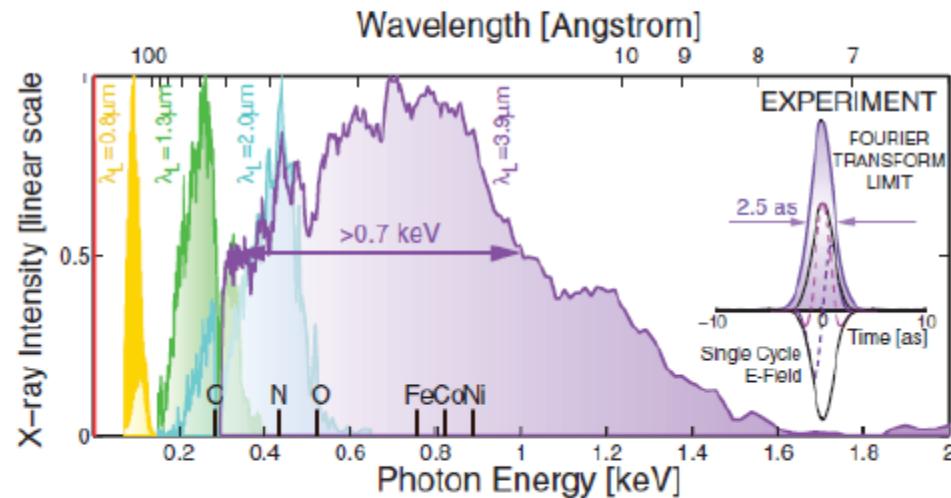
keV X-ray from mid-IR, fs pulses

- Phase-matched emission: mid-IR ($3.9\text{ }\mu\text{m}$) pulse focused into a high-pressure gas-filled waveguide



Right combination of laser wavelength, gas pressure-length product, laser intensity

- 1) HHG from non-isolated emitters: electron wave-function: $\sim 500\text{ \AA}$
He atom separation: $\sim 15\text{ \AA}$ at 10 atm
- 2) Laser beam self-confinement

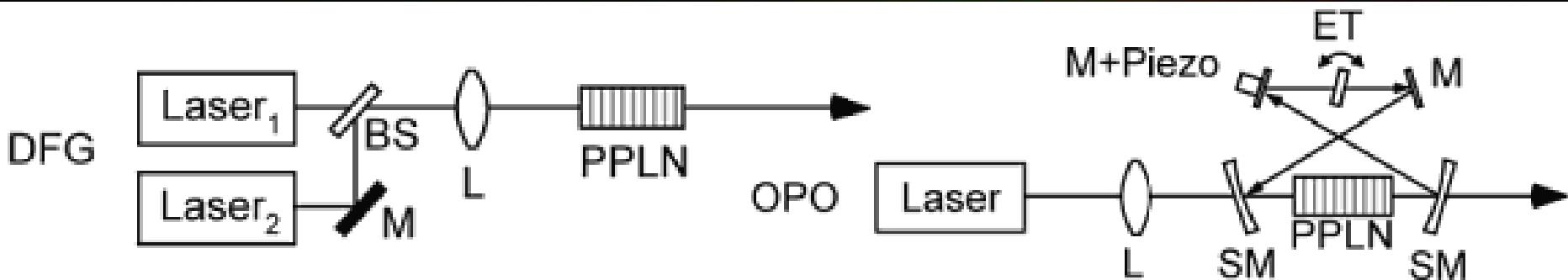


driving pulses: $3.9\text{ }\mu\text{m}$, 80 fs (six cycles), 10 mJ, 20 Hz from OPCPA

Outline

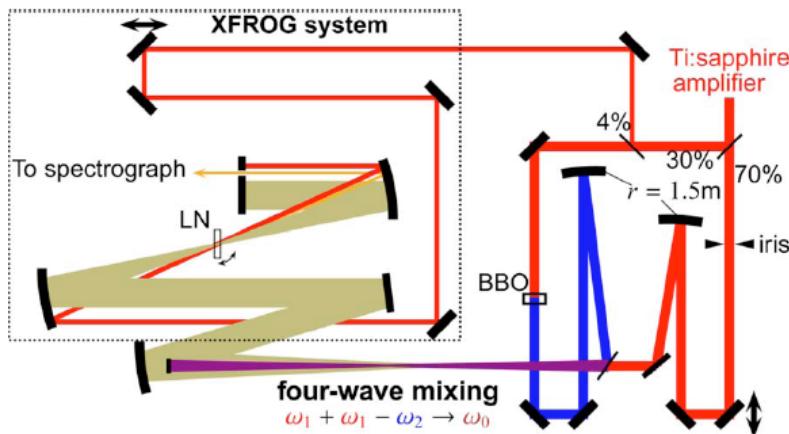
- General Introduction
- Ultrahigh Intensity Laser-Toward multi-PW power
 - ◆ Oscillator-Generation of femtosecond laser
 - ◆ Stretcher-Management of dispersion
 - ◆ Amplifier-Boost laser energy
 - ◆ Compressor-compensate dispersion for high peak power
 - ◆ Enhancement on contrast ratio
 - ◆ Typical PW laser facilities in the world
- Ultrafast Laser-Toward Few Cycles and Attosecond Pulse
- Optical Parametric Amplifier-Toward mid-infrared range
- High average power-Toward All-Solid State Amplifier
- Acknowledgement

Comparison for MIR generation scheme

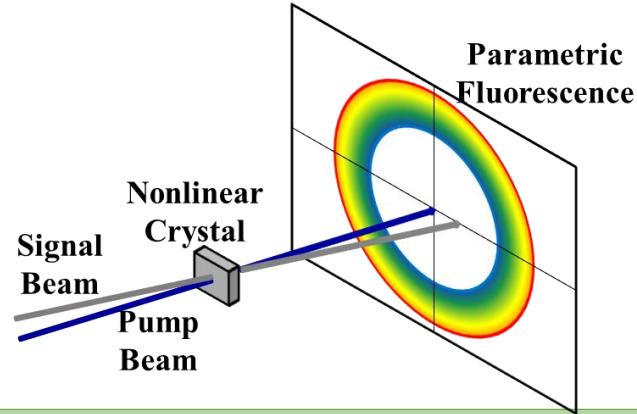


Difference Frequency Generation(DFG)
Complicated synchronization system

Optical Parametric Oscillation(OPO)
Limited by Group Velocity Mismatch

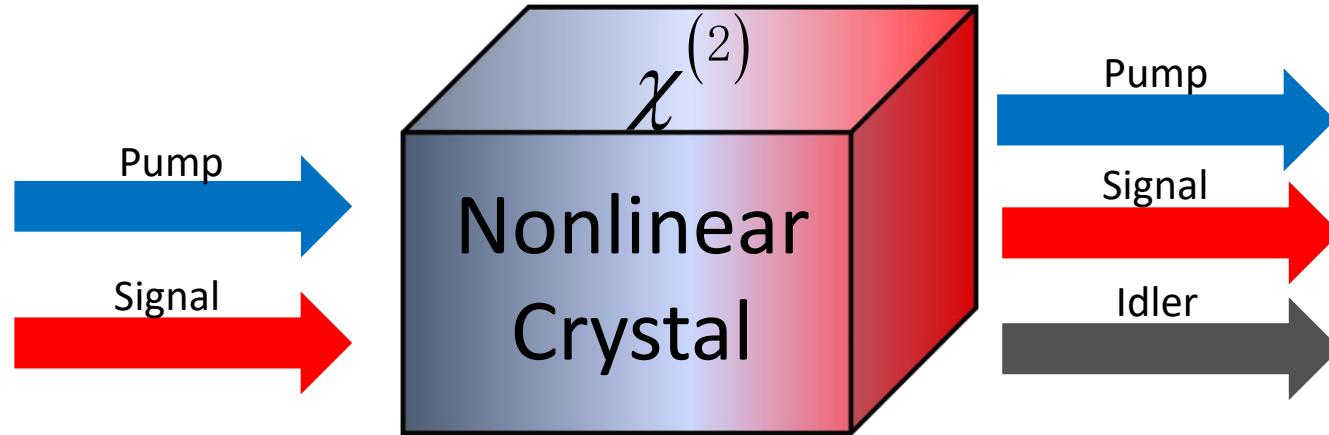


Four Wave-Mixing (FWM)
Low energy and efficiency

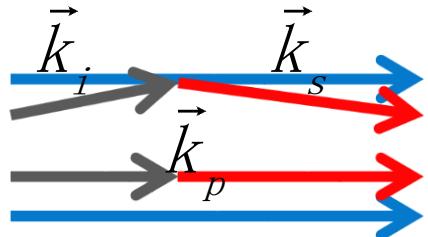


Optical Parametric Amplification(OPA)
High single pass gain $\sim 10^6$
Broad bandwidth NOPA/DOPA

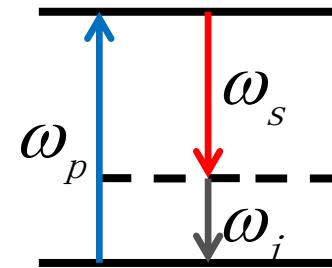
Principle of Optical Parametric Amplification

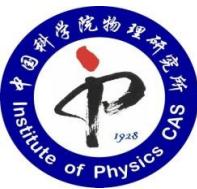


$$\hbar \vec{k}_p = \hbar \vec{k}_s + \hbar \vec{k}_i$$

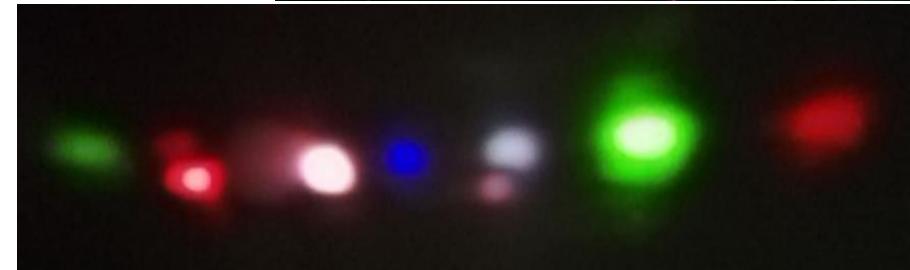
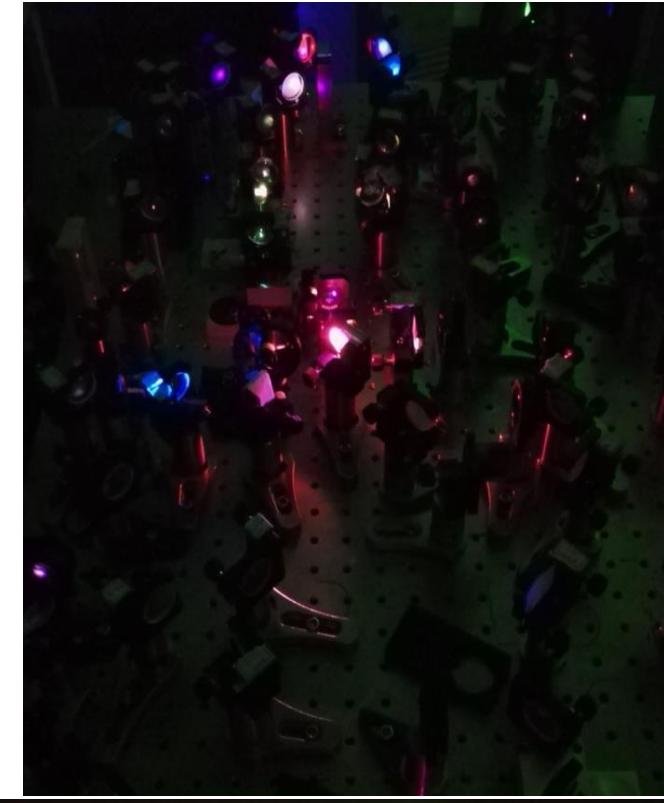
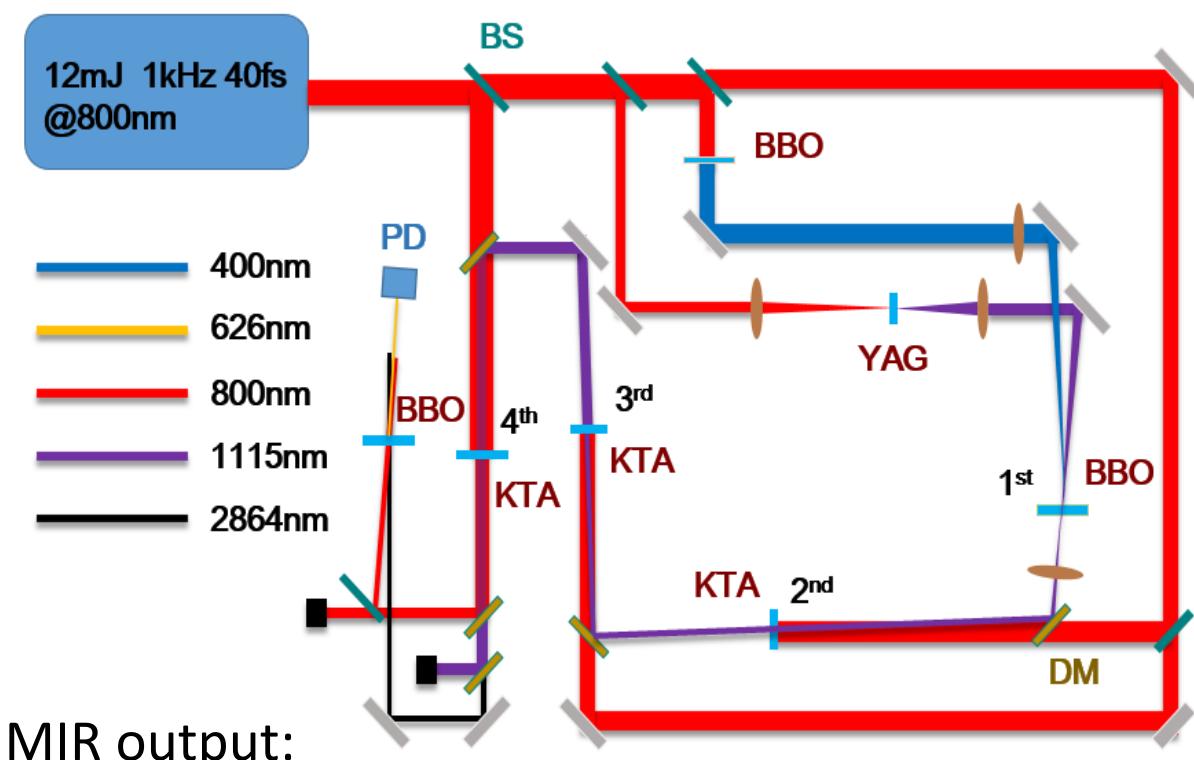


$$\hbar \omega_p = \hbar \omega_s + \hbar \omega_i$$





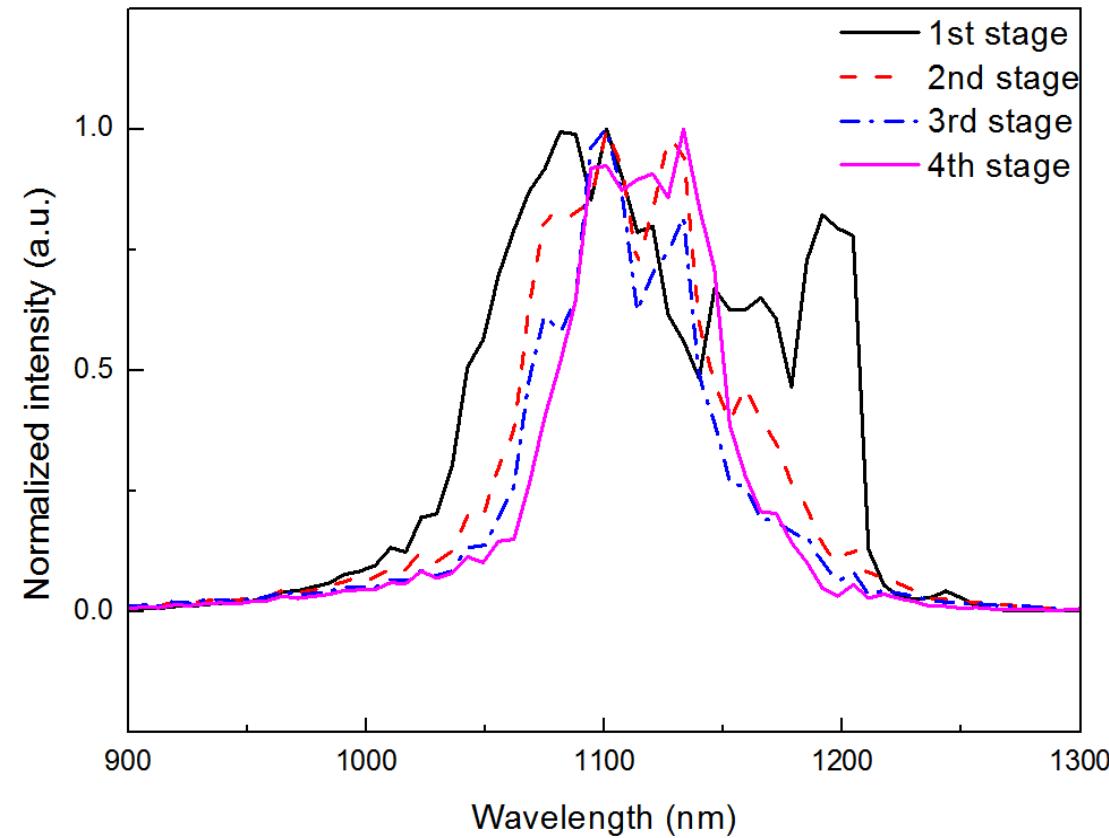
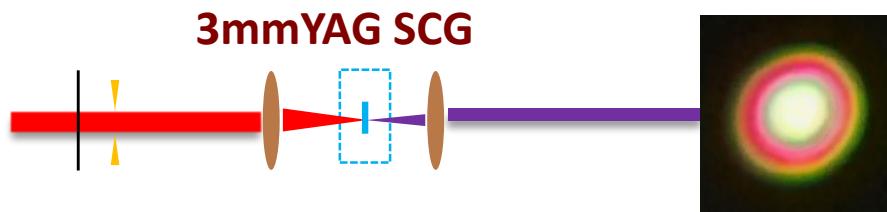
Schematic of Experimental Setup for KTA-OPA



- ◆ Center: 2864nm
- ◆ FWHM: 525nm
- ◆ Energy: 520μJ
- ◆ Stability(RMS) : 1.86%

Signal from 3mm YAG and amplification

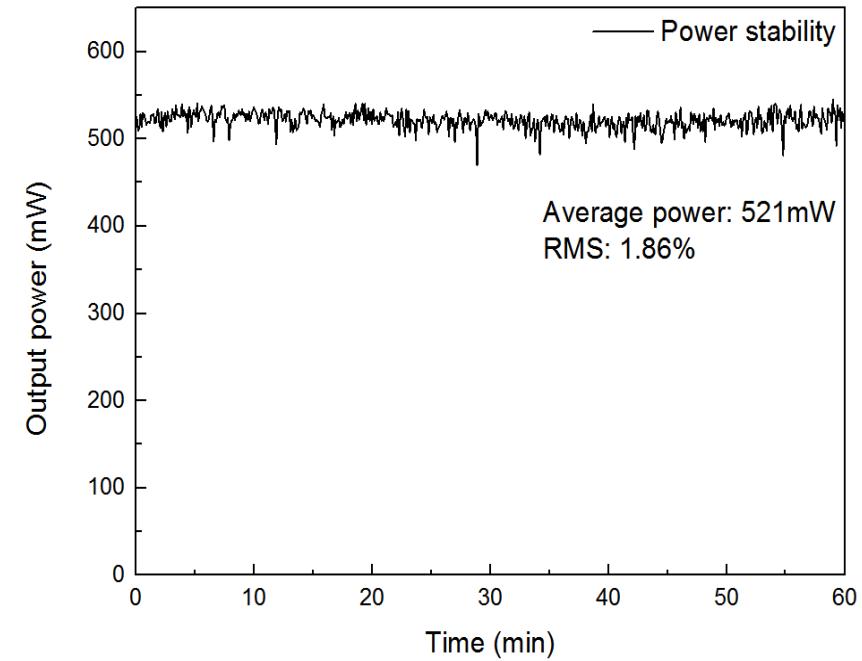
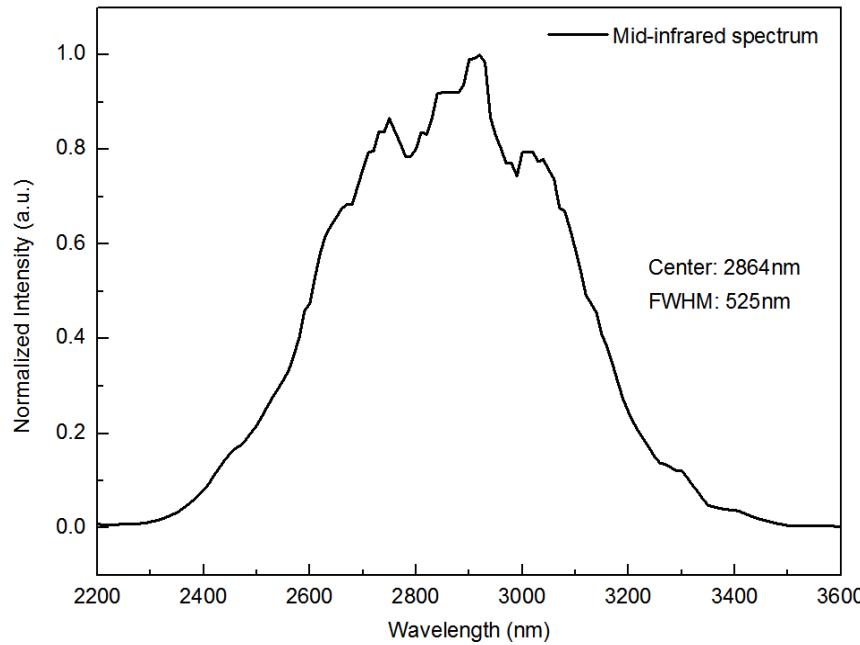
Signal from the super-continuum generation by focus the pump laser into the YAG crystal.



Signal output of the final stage:

- Center: 1115nm
- FWHM: 72nm
- Energy: 1.8mJ (1kHz)

Spectrum and Stability



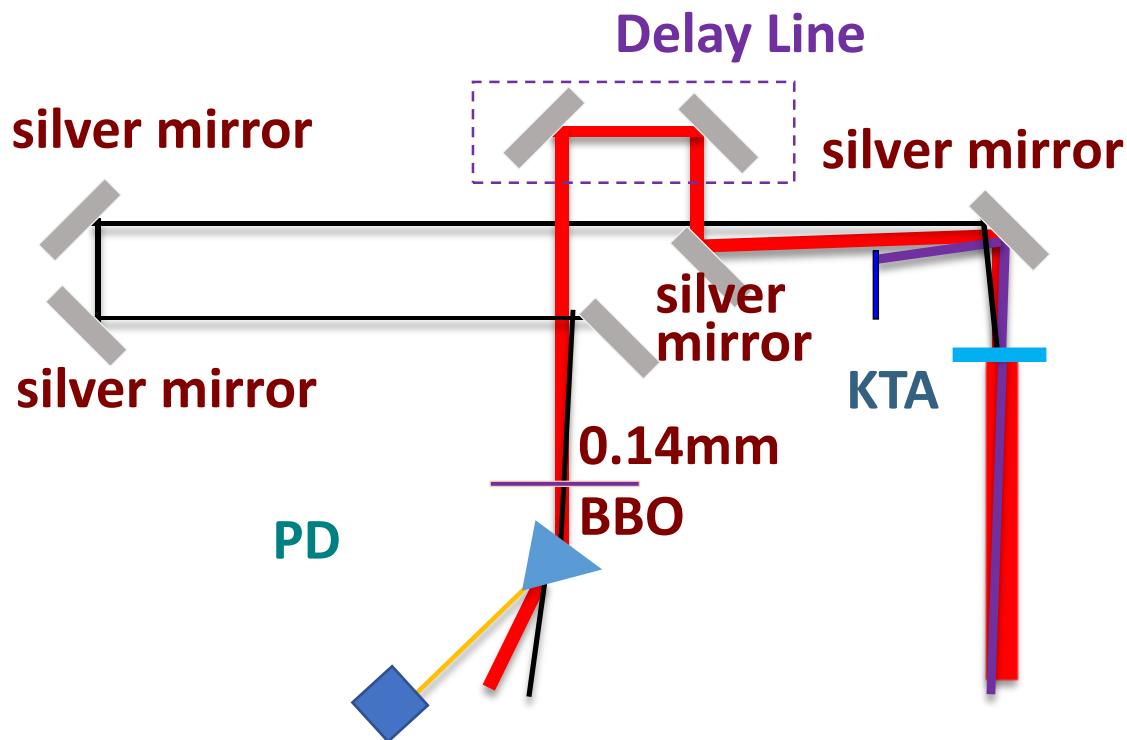
Characteristics

- Center: 2864nm
- FWHM: 525nm
- Energy: 520 μ J (1kHz)
- FTL: 27fs

Energy stability (over 1 hour)

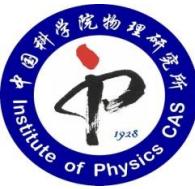
- Average power: 521mW (1kHz)
- RMS deviation : 1.86%

Measurement of laser pulse

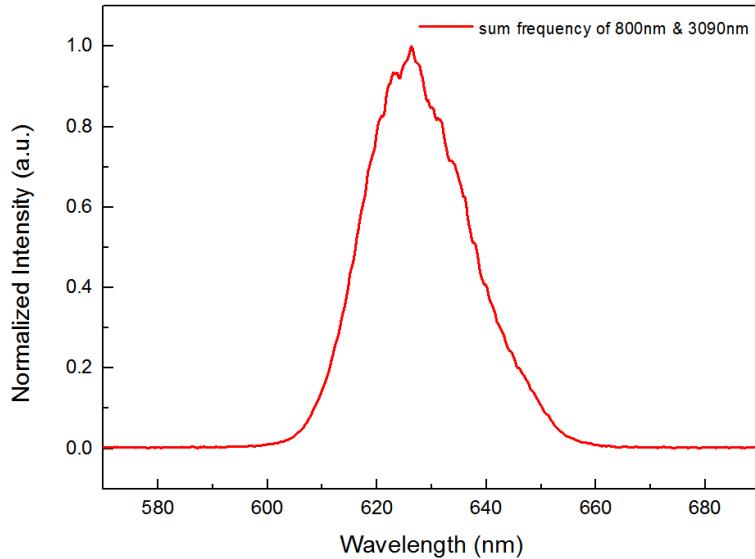


$$I_{626}(\tau) \propto \int_{-\infty}^{+\infty} \sec h^2\left(\frac{t}{\tau_{800}/1.763}\right) \times [\sec h\left(\frac{t-\tau}{\tau_{3090}/1.763}\right) \otimes \text{sqr}\left(\frac{t}{\delta_{\text{BBO}} \cdot l_c} + \frac{1}{2}\right)]^2 dt$$

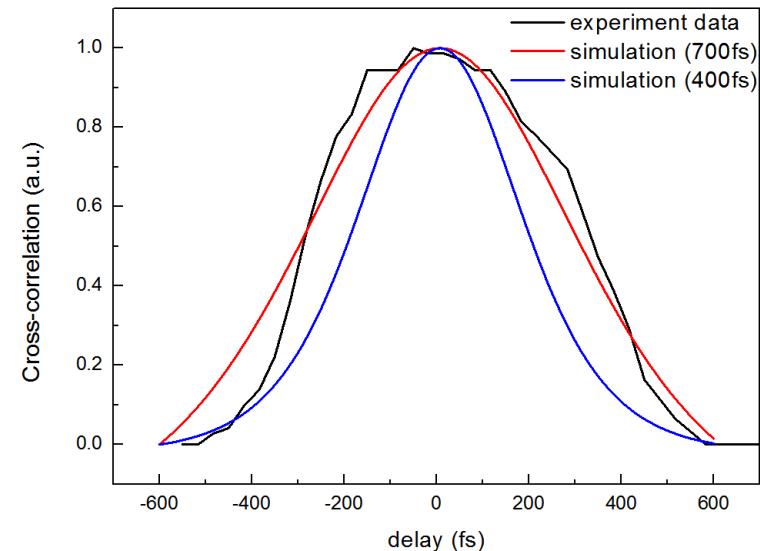
$$\text{sqr}(x) = \begin{cases} 1 & \text{if } |x| \leq \frac{1}{2} \\ 0 & \text{otherwise} \end{cases}$$



Measurement of laser pulse

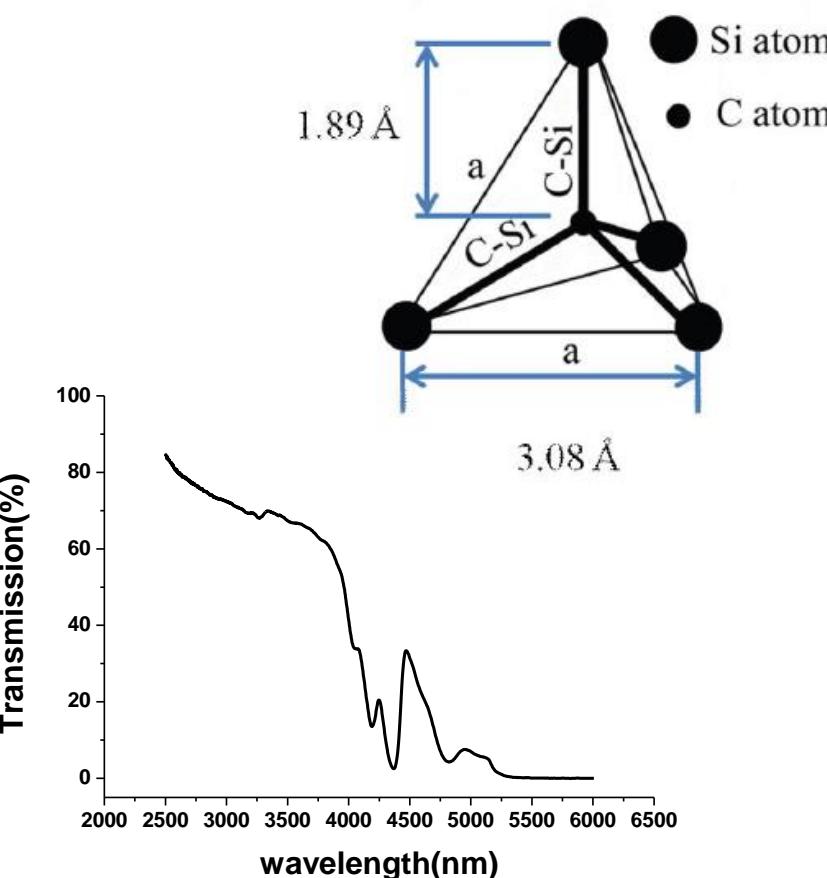


Spectrum of the SFG
(Sum frequency generation)



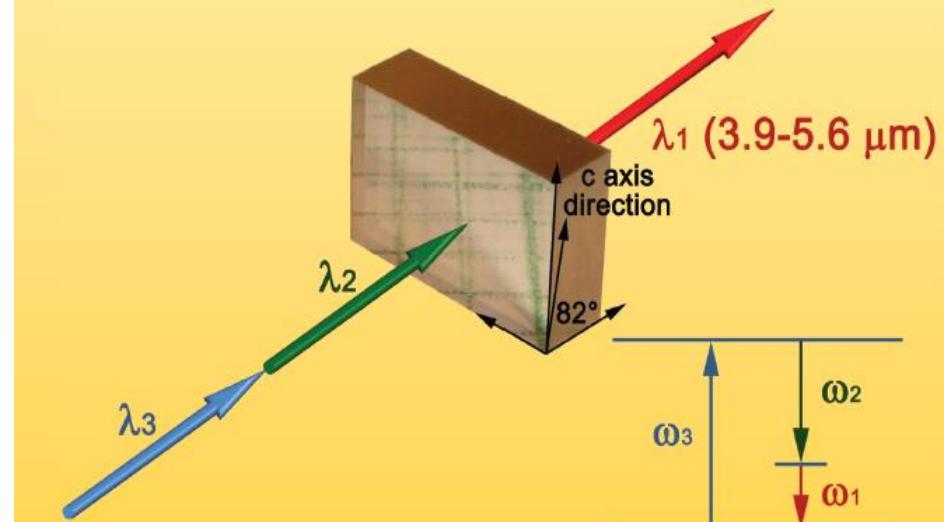
Cross-correlation trace
for pulse duration

SiC-a new crystal for MIR



LASER & PHOTONICS REVIEWS

4H-SiC crystal: frequency conversion ($\text{o} + \text{e} \rightarrow \text{o}$)

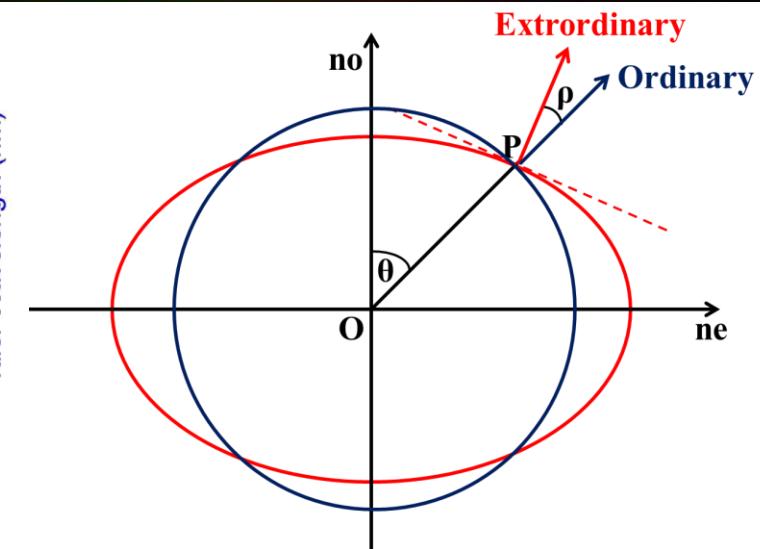
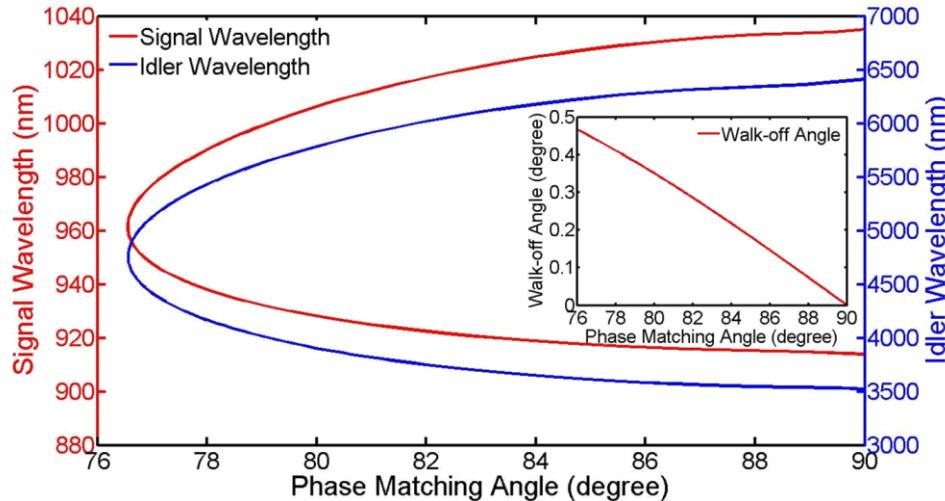


4H-SiC: a new nonlinear material for midinfrared lasers

- ◆ High nonlinear coefficient
- ◆ High damage threshold
- ◆ Good thermal conductivity

Shunchong Wang *et al.*, Laser Photonics Rev. Vol.7, 831 (2013)

Character of 4H-SiC Crystal



Sellmeier Equations

$$n_e^2(\lambda) = 6.79485 + \frac{0.15558}{\lambda^2 - 0.03535} - 0.02296\lambda^2$$

$$n_o^2(\lambda) = 1 + \frac{0.20075\lambda^2}{\lambda^2 + 12.07224} + \frac{5.54861\lambda^2}{\lambda^2 - 0.02641} + \frac{35.65066\lambda^2}{\lambda^2 - 1268.24708}$$

800nm(o) → 1017nm(e)+3750nm(o)

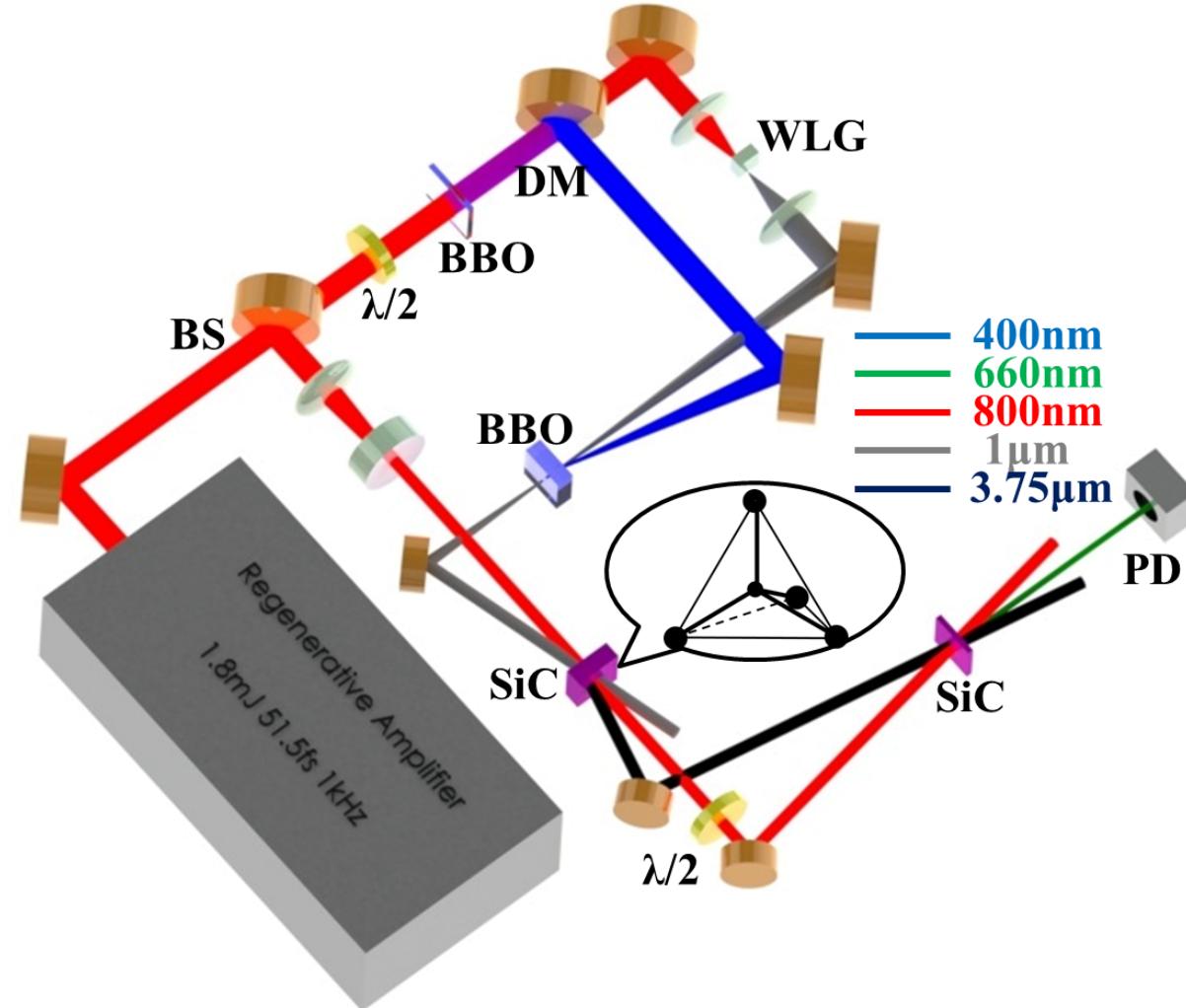
Schematic of Experimental Setup

BBO (SHG)
1mm 29.2°

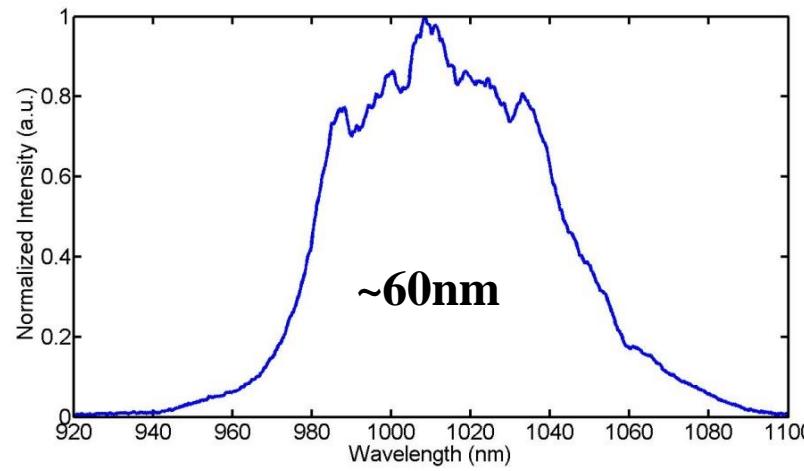
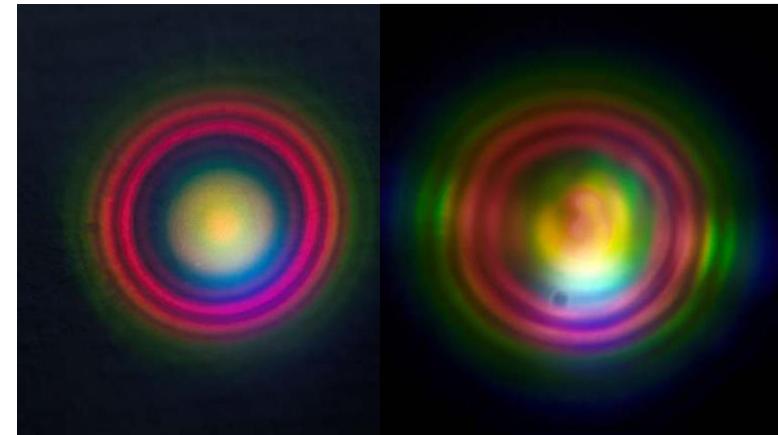
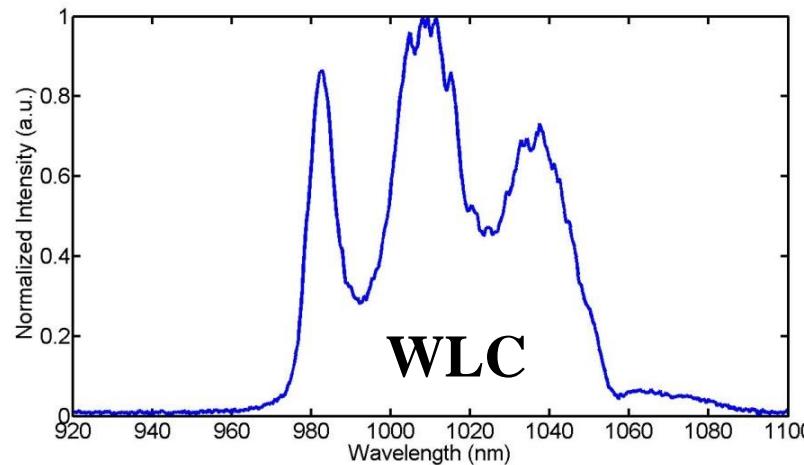
BBO (OPA)
3mm 28.6°

SiC (OPA)
3mm 90°

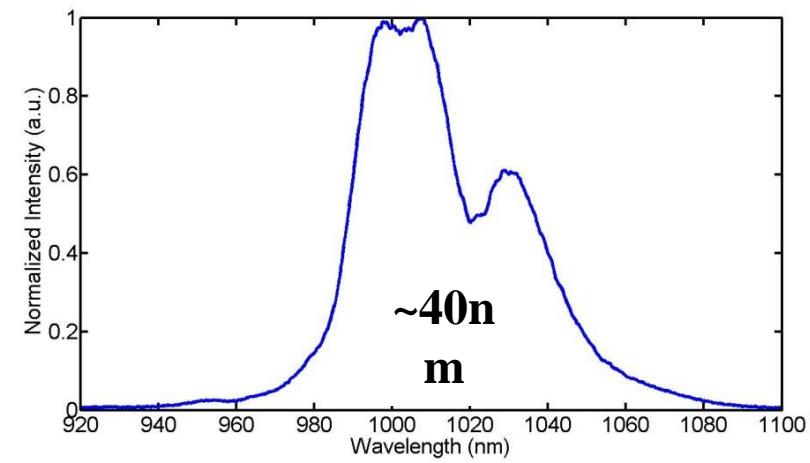
SiC (SFG)
1mm 90°



Results and Pulse Characterization

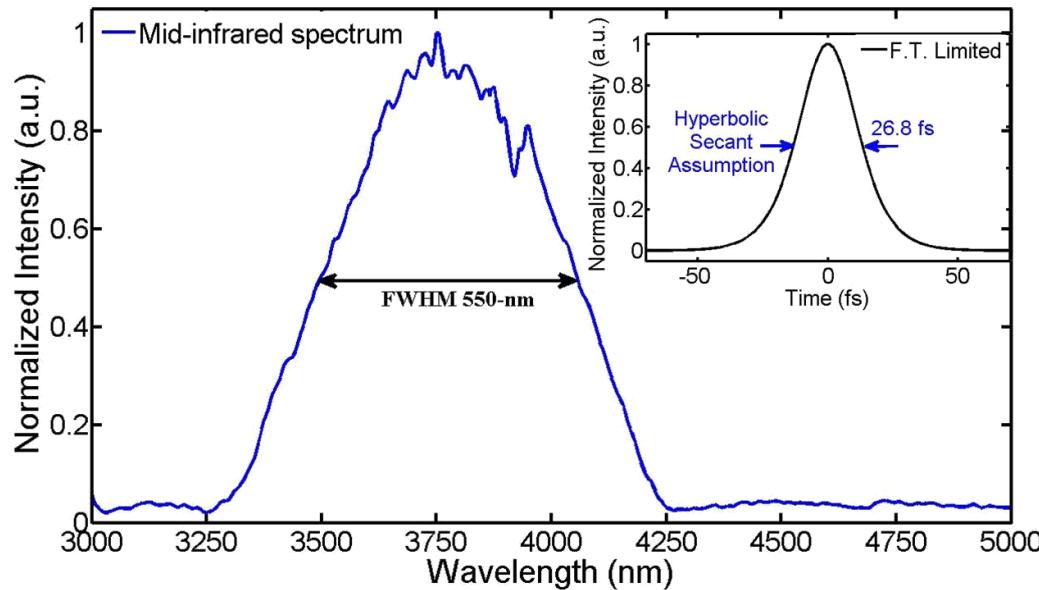


1st OPA



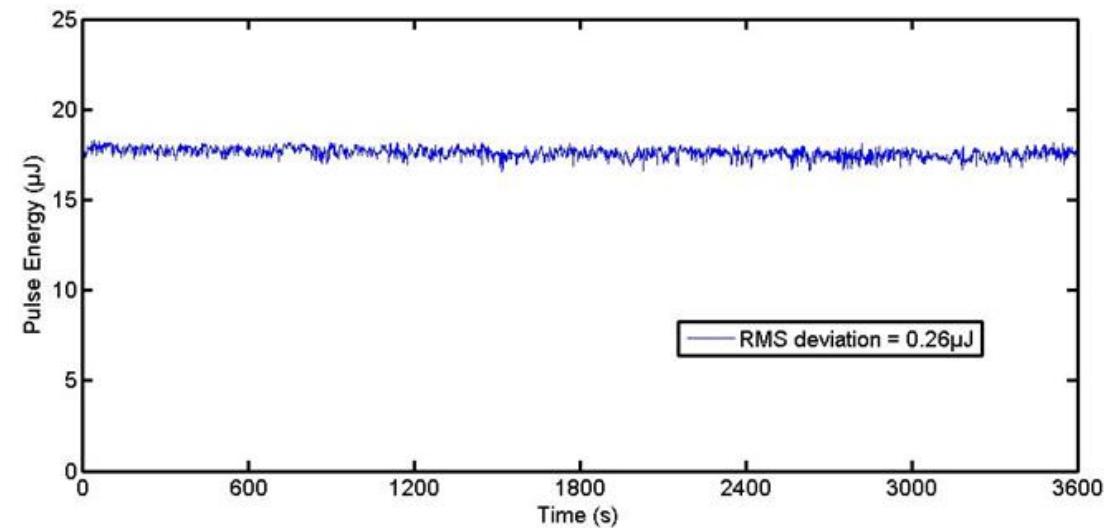
2nd OPA

Results and Pulse Characterization

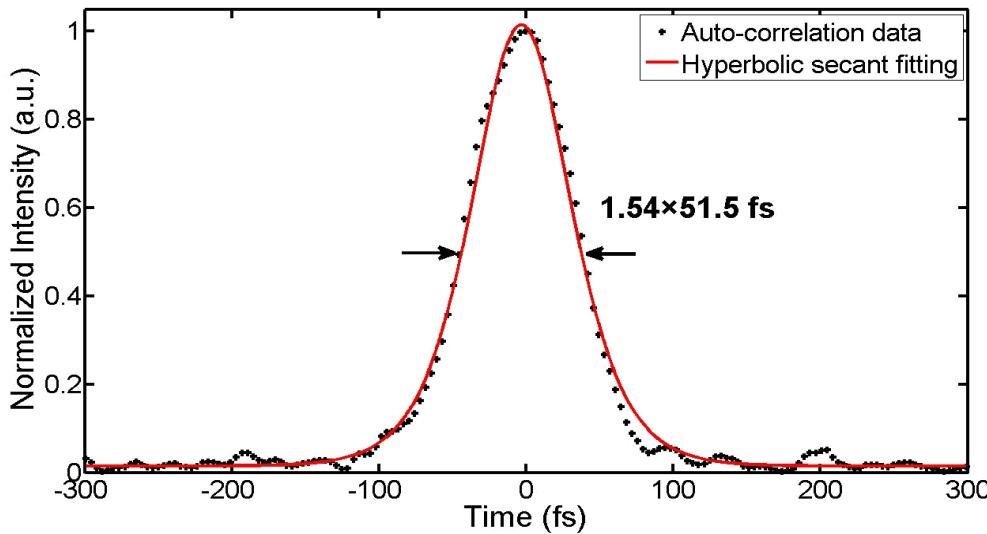


**Spectrum: 550nm
FT Limit: 26.8-fs**

**Energy 17 μ J
RMS = 1.48%**



Results and Pulse Characterization



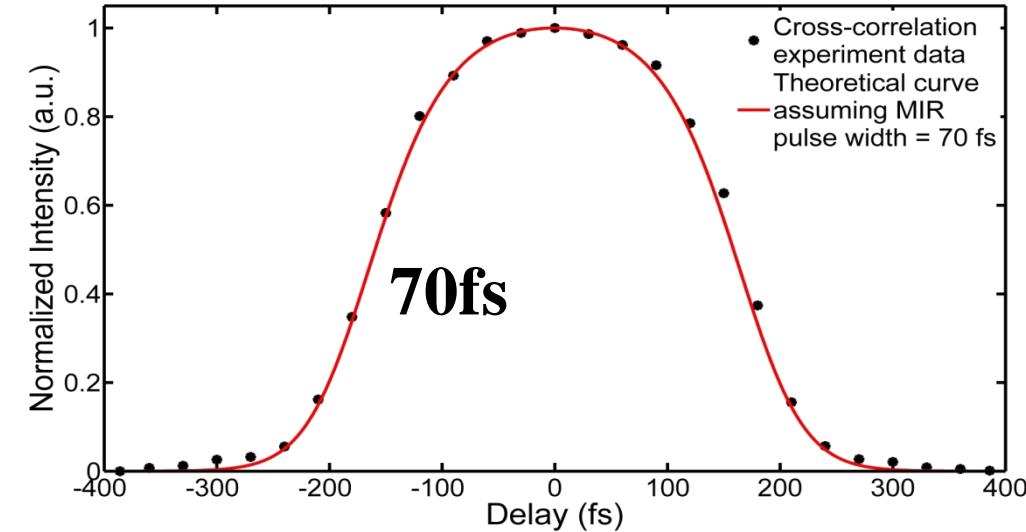
$$I_{660}(\tau) \propto \int_{-\infty}^{+\infty} \operatorname{sech}^2\left(\frac{t}{\tau_{800}/1.763}\right) \times \left[\operatorname{sech}\left(\frac{t-\tau}{\tau_{3750}/1.763}\right) \otimes \operatorname{sqr}\left(\frac{t}{\delta_{silc}} + \frac{1}{2}\right)\right]^2 dt$$

$$\operatorname{sqr}(x) = \begin{cases} 1 & \text{if } |x| \leq \frac{1}{2}, \\ 0 & \text{otherwise.} \end{cases}$$

Since the low energy, we measured the pulse duration by using cross-correlator

Cross-Correlation Curve assuming 70fs MIR and 50fs NIR

Hai-Tao Fan, et al *Opt Lett* 39 6249(2014)



Outline

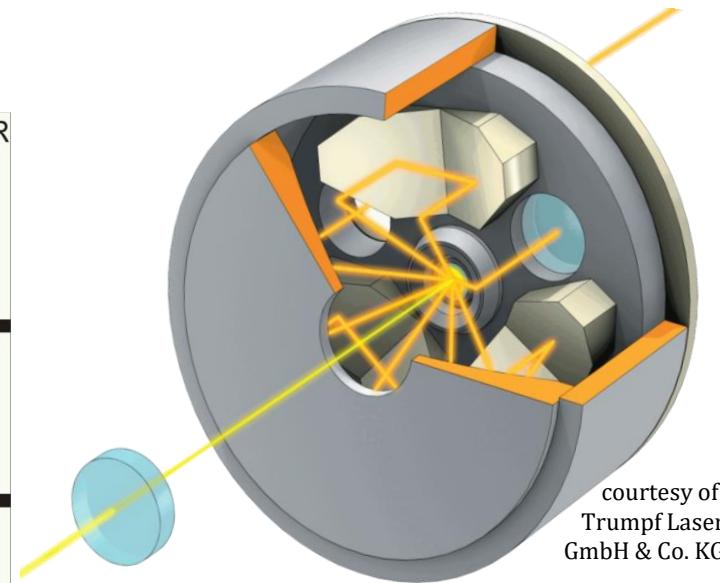
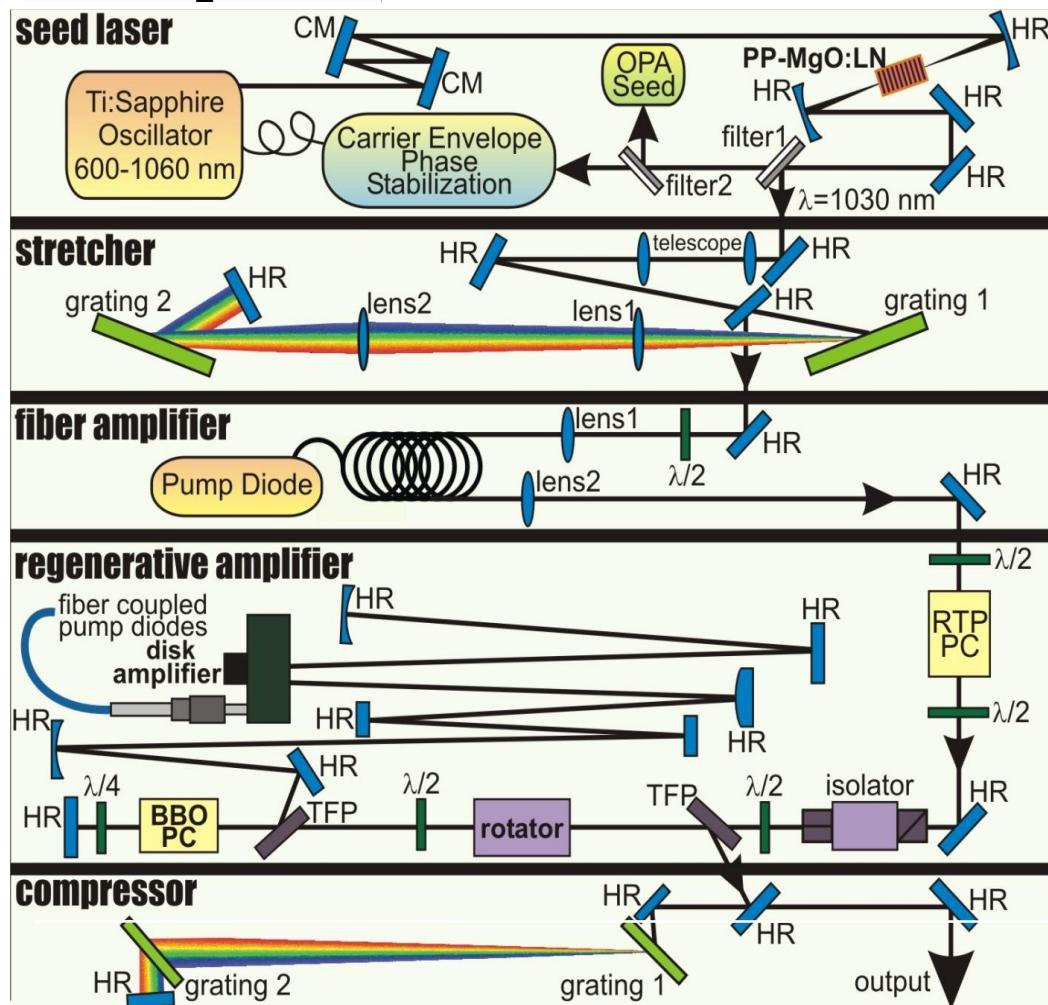
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- High average power-Toward All-Solid State Amplifier
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Next generation-thin disc femtosecond laser



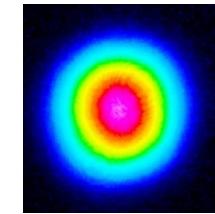
LUDWIG-
MAXIMILIANS-
UNIVERSITÄT
MÜNCHEN

Lasersystem – Yb:YAG thin-disc regenerative amplifier



courtesy of:
Trumpf Laser
GmbH & Co. KG

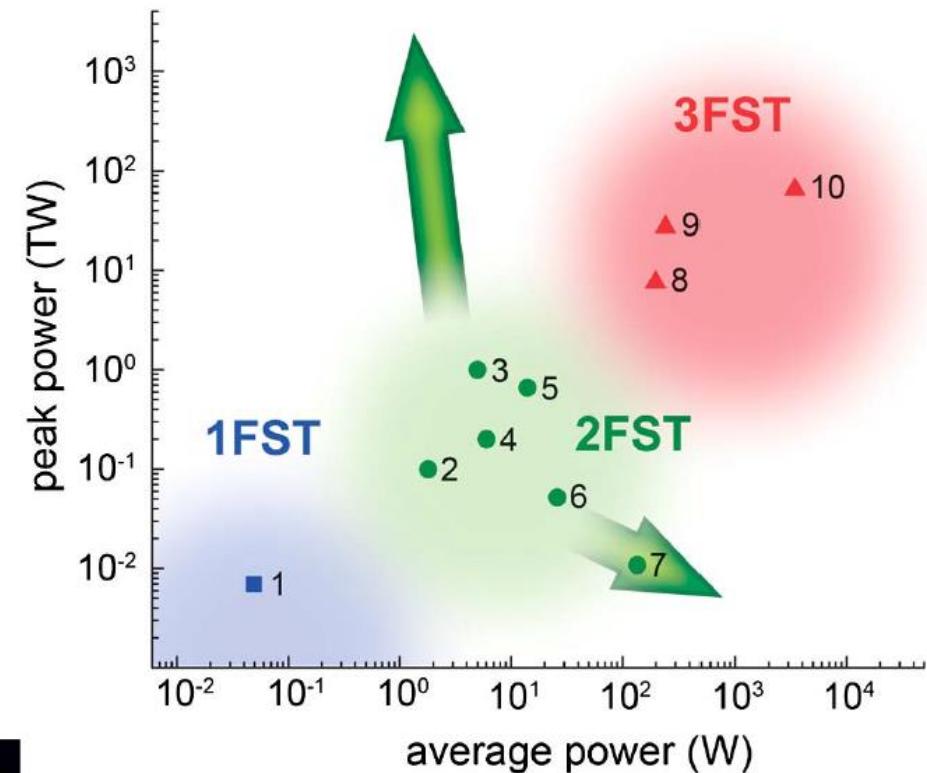
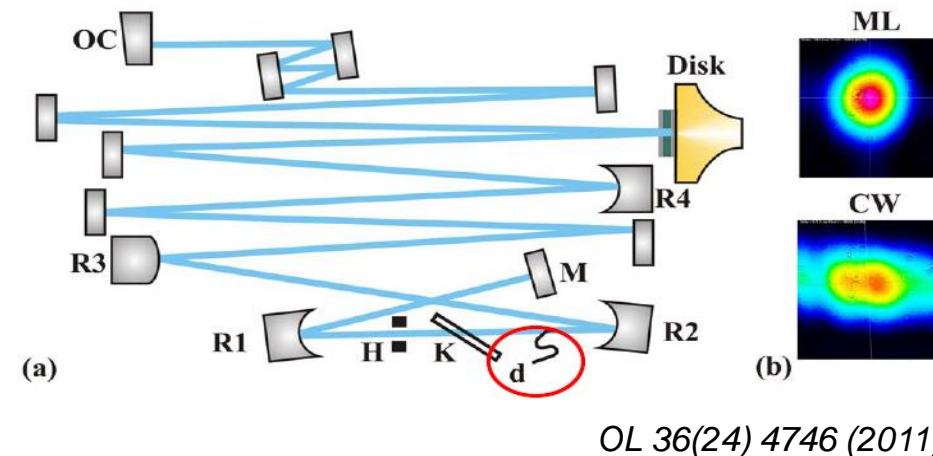
Regenerative amplifier:
(Laserhead Trumpf Laser)



Number of round trips	150
Repetition rate	1-10 kHz
Pulse energy	25 mJ
Average power	75W
Pulse duration	1.6 ps
Bandwidth	$\sim 1 \text{ nm}$

Status and trend of mode-locking disk laser

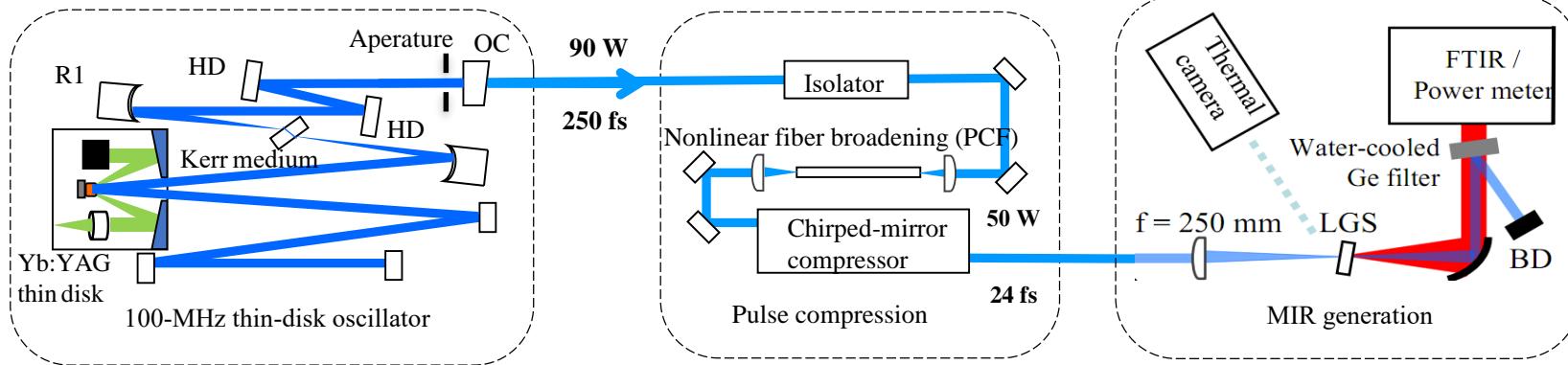
	Power & Energy
SESAM (ETH, 2012)	275 W, 25.6 MW, 583 fs, 16.9 μ J, 16 MHz (Vacuum)
SESAM (ETH, 2014)	242 W, 66 MW, 1.07ps, 80 μ J, 3 MHz (Vacuum)
KLM (MPQ, 2011)	17 W, 1.7 MW, 200fs 0.43 μ J, 40 MHz (air)
KLM (MPQ, 2014)	270 W, 38 MW, 330fs 14.4 μ J, 19 MHz (air)



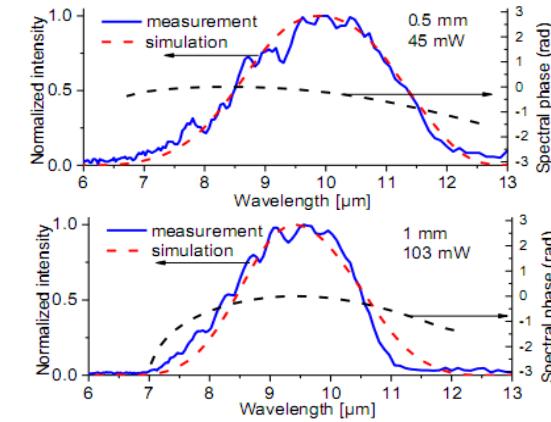
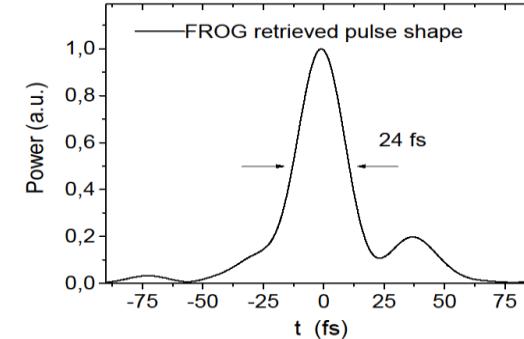
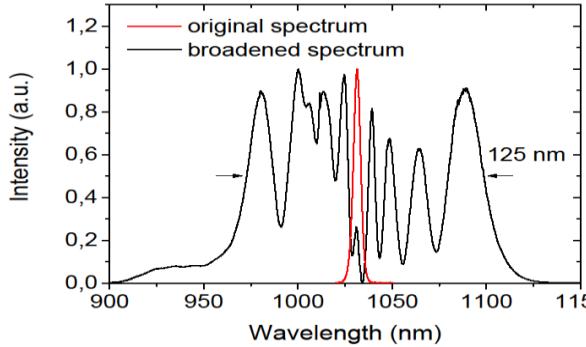
	τ_{pulse}	E_{pulse}	P_{peak}	$P_{average}$
system 8	5 fs	40 mJ	7.5 TW	200 W
system 9	1.7 fs	49 mJ	27 TW	245 W
system 10	5 fs	345 mJ	65 TW	3450 W

H.Fattahi et al, Optica, 1.45(2014)

Thin disc Yb:YAG laser at 100MHz



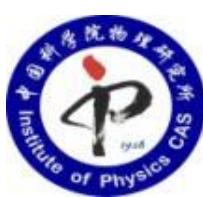
- ◆ 100 MHz KLM oscillator--90 W, 250 fs/50W, 24 fs
- ◆ 200 MHz KLM oscillator--75 W, 260 fs



J Wei et al, Opt Express, Vol. 21: 29867 (2013)

J Wei et al, Opt Lett. Vol.40:1627 (2015)

I. Pupeza, et al.,
CLEO Postdeadline, STh5C, 2014



Innoslab femtosecond amplifier

OPTICS EXPRESS 2009 / Vol. 17, No. 15 12230

400 W Yb:YAG Innoslab fs-amplifier

P. Russbueldt^{1,*}, T. Mans¹, G. Rotarius¹, J. Weitenberg²,
H.D. Hoffmann¹ and R. Poprawe^{1,2}

¹*Fraunhofer Institute for Laser Technology, Steinbachstr. 15, 52074 Aachen, Germany*

OPTICS LETTERS 2010 / Vol. 35, No. 24 4169

Compact diode-pumped 1.1 kW Yb:YAG Innoslab femtosecond amplifier

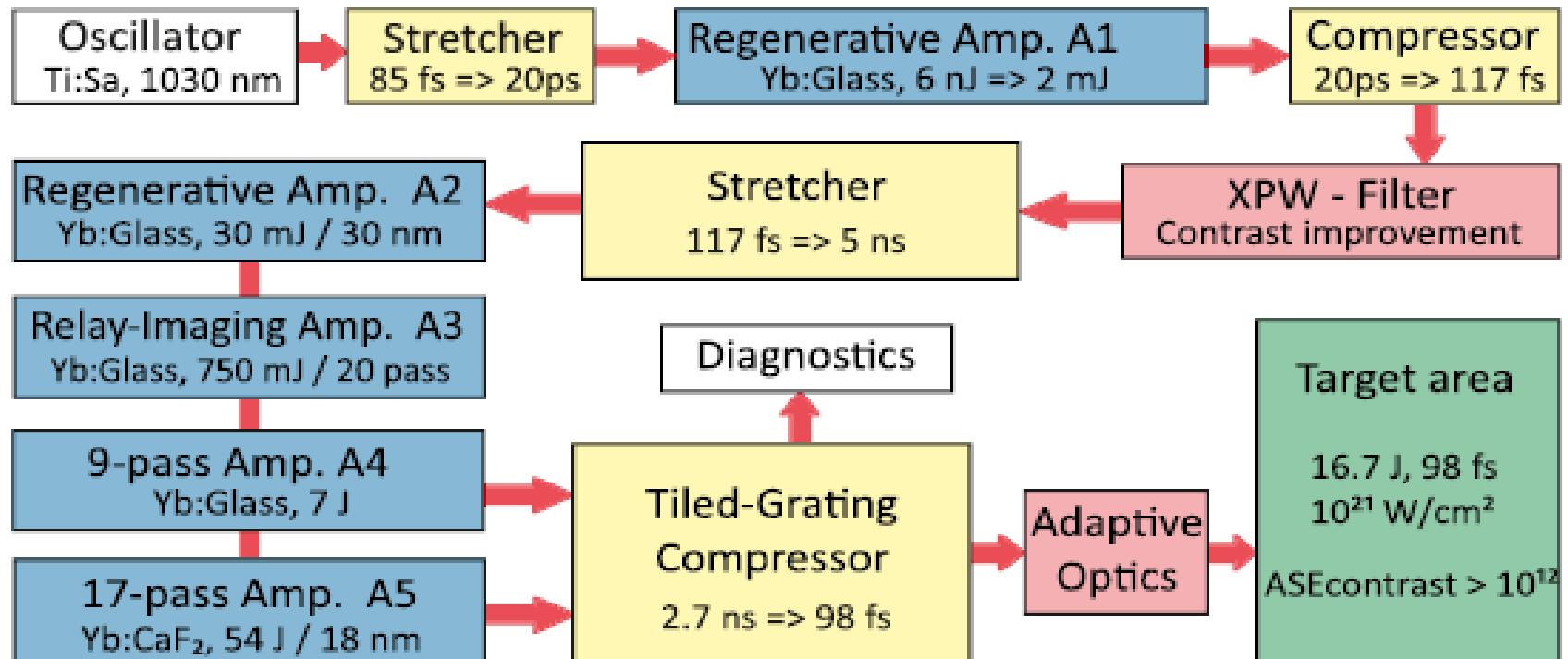
P. Russbueldt,^{1,*} T. Mans,² J. Weitenberg,² H. D. Hoffmann,¹ and R. Poprawe^{1,2}

¹*Fraunhofer Institute for Laser Technology, Steinbachstrasse 15, 52074 Aachen, Germany*



POLARIS laser system

Petawatt Optical Laser Amplifier for Radiation Intensive Experiments



- ◆ Institute for Optics and Quantum Electronics Jena
- ◆ Helmholtz-Institute Jena

DCPA design (ps, ns)

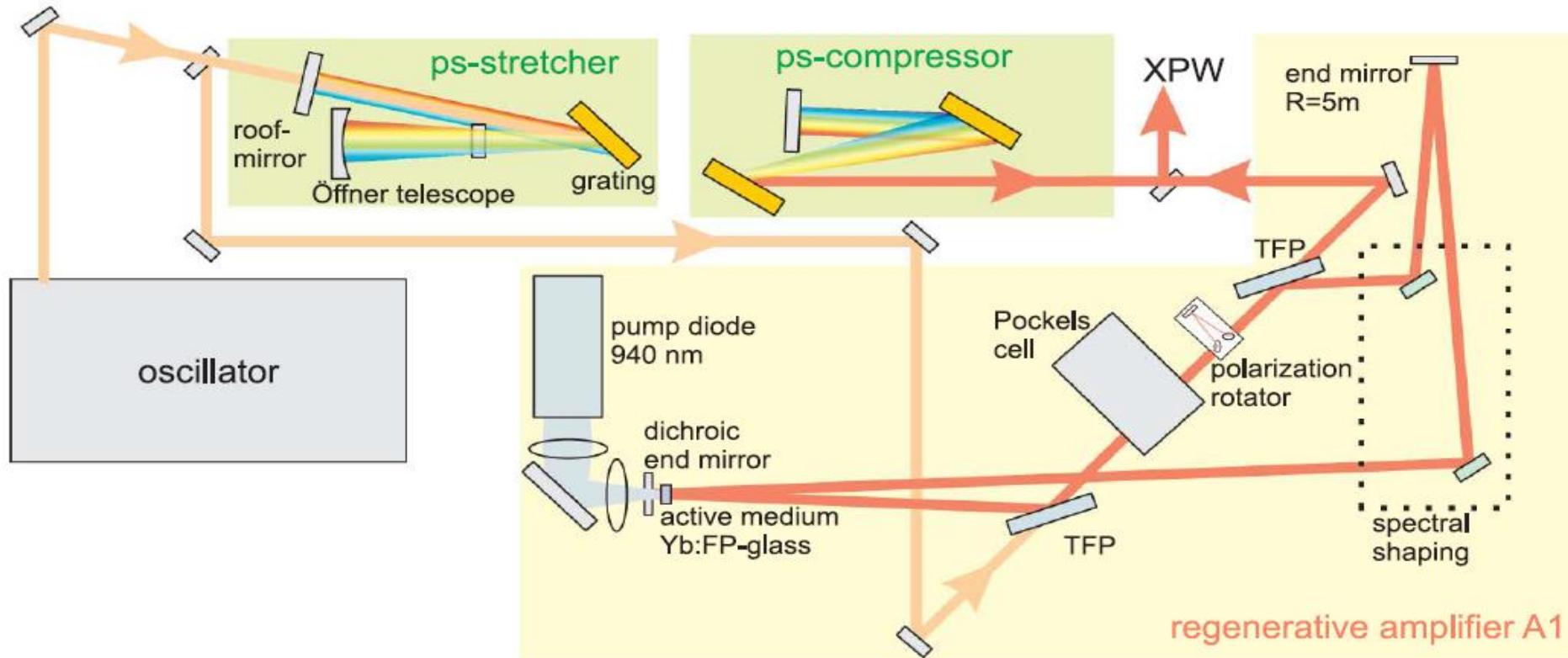
A1-A2: Regenerative amp

A3: image relay multi-pass amp (20pass)

A4: 9 pass amp

A5: 17 pass amp (54J/26.6.J)

POLARIS laser system



A1 (output: 2mJ, 1Hz)

- ◆ Seeding: 75MHz ,85fs (Ti:Sa)@1030nm
- ◆ Pump laser: laser diode@940nm
- ◆ Gain crystal: Yb:Glass
- ◆ Cavity configuration: Ring regenerative amp with function to control gain narrowing effect (from 12nm to 16nm)

A2 (output: 30mJ)
Same design with A1

Optics Letters

54 J pulses with 18 nm bandwidth from a diode-pumped chirped-pulse amplification laser system

MARCO HORNUNG,^{1,2,*} HARTMUT LIEBETRAU,² SEBASTIAN KEPPLER,² ALEXANDER KESSLER,¹
MARCO HELLWING,² FRANK SCHORCHT,¹ GEORG A. BECKER,² MARIA REUTER,² JENS POLZ,²
JÖRG KÖRNER,² JOACHIM HEIN,^{1,2} AND MALTE C. KALUZA^{1,2}

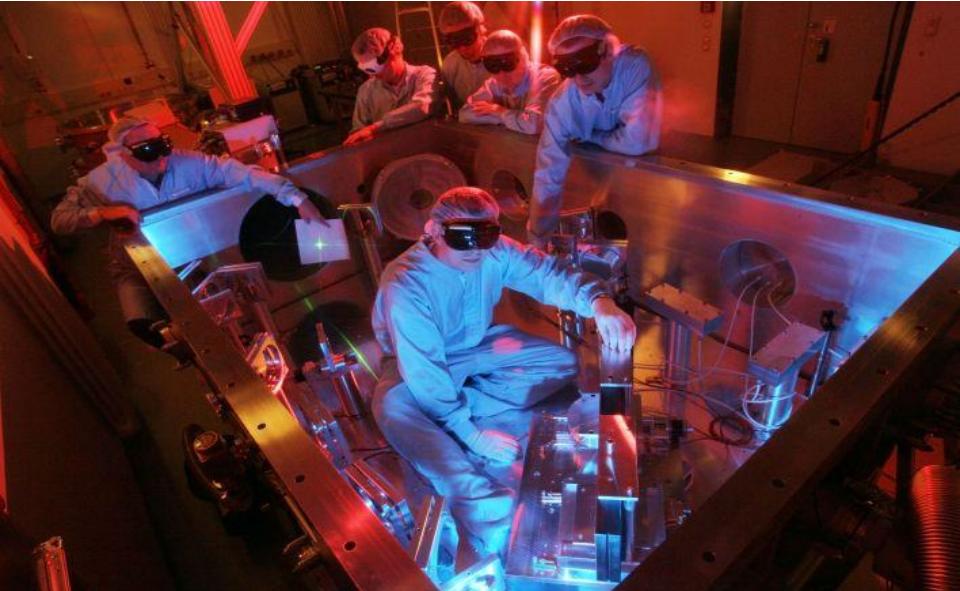
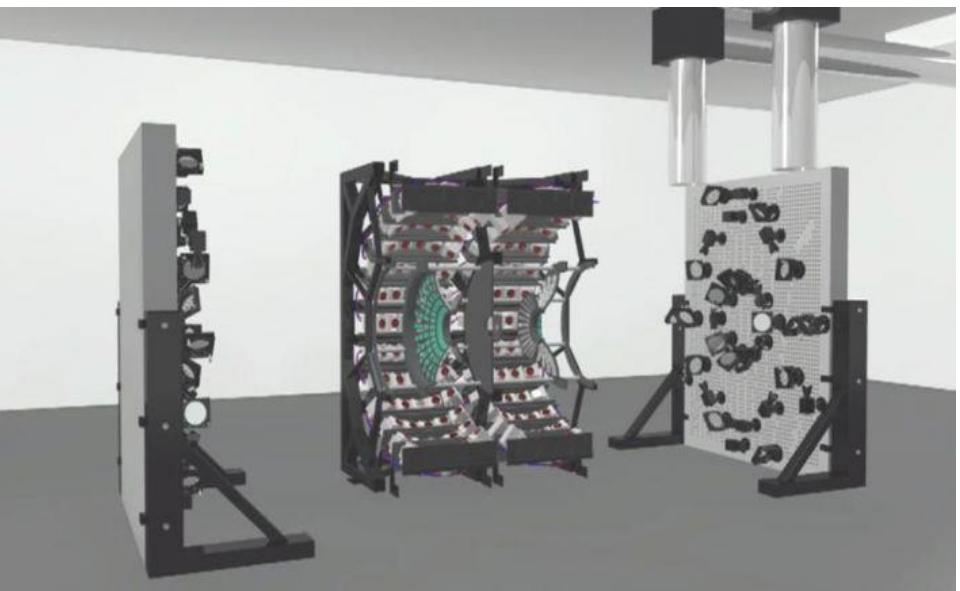
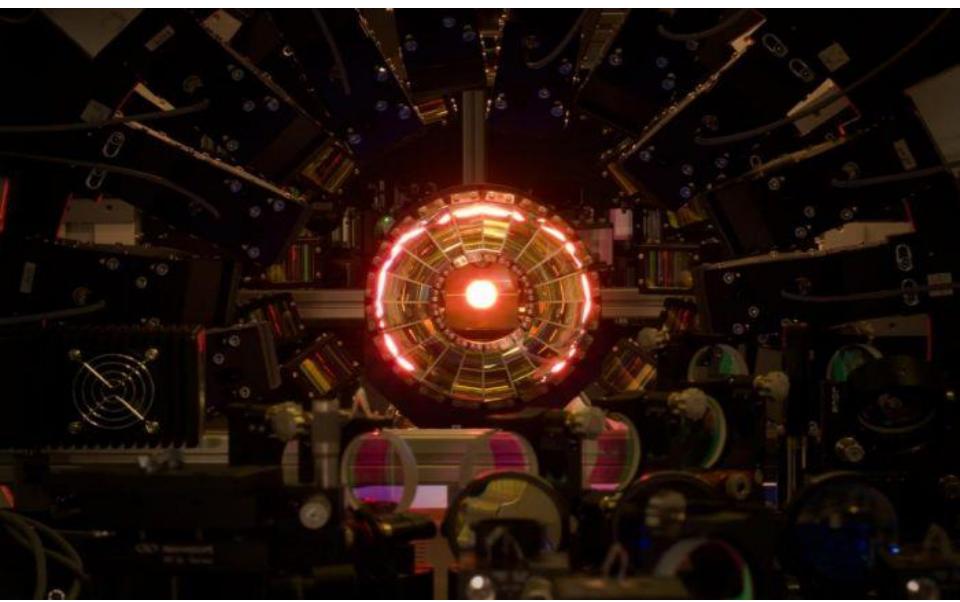
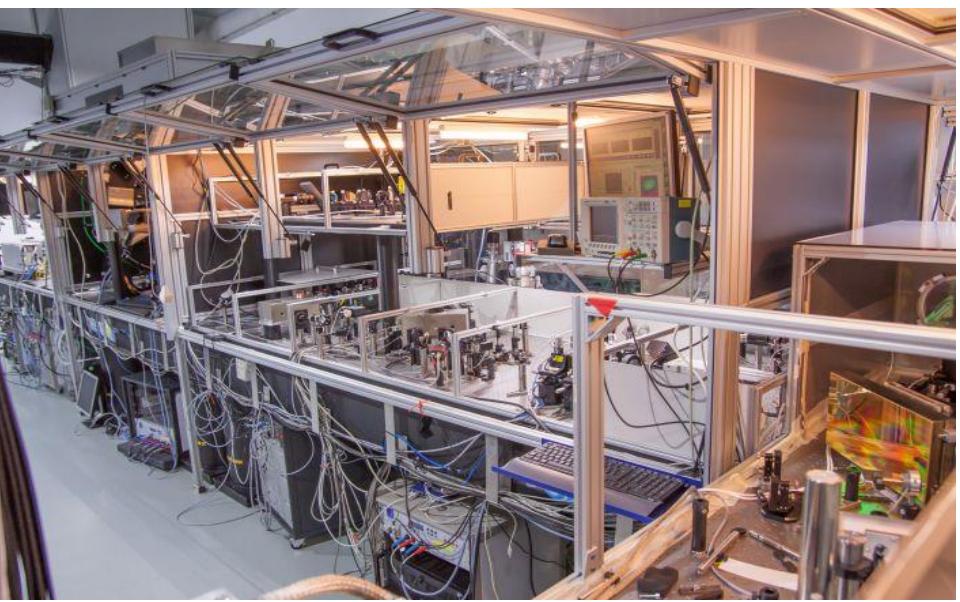
¹Helmholtz-Institute Jena, Fröbelstieg 3, 07743 Jena, Germany

²Institute of Optics and Quantum Electronics, Max-Wien Platz 1, 07743 Jena, Germany

*Corresponding author: Marco.Hornung@uni-jena.de

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Repetition rate: 1/50 Hz
Energy: 54J (before compressor)
16.7J(after compressor)
Pulse duration: 98fs
Peak power: ~200TW
 10^{12} contrast



Summary

- General Introduction
- Ultrahigh Intensity Laser-Toward multi-PW power
 - ◆ Oscillator-Generation of femtosecond laser
 - ◆ Stretcher-Management of dispersion
 - ◆ Amplifier-Boost laser energy
 - ◆ Compressor-compensate dispersion for high peak power
 - ◆ Enhancement on contrast ratio
 - ◆ Typical PW laser facilities in the world
- Ultrafast Laser-Toward Few Cycles and Attosecond Pulse
- Optical Parametric Amplifier-Toward mid-infrared range
- High average power-Toward All-Solid State Amplifier
- Acknowledgement

Acknowledgement

My Colleagues and Students at IoP/CAS, Xidian U



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- Ultrafast photonics
- Laser applications in medicine & biology
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- Terahertz generation and applications
- Photo-chemistry
- Nonlinear optics and quantum optics
- Laser metrology
- Ultra-high intensity lasers
- Nano-photonics
- Laser material processing
- Fiber Lasers
- Advanced laser materials

Thank you for your attention!

